



# PRINCIPLES OF KELVIN PROBE FORCE MICROSCOPY AND APPLICATIONS

Laurent Nony

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# PRINCIPLES OF KELVIN PROBE FORCE MICROSCOPY AND APPLICATIONS

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2<sup>nd</sup> German-French summer school on noncontact-AFM  
Osnabrück, 12<sup>th</sup>-16<sup>th</sup> of September 2016, Germany



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UMR CNRS 7334, Universités Aix-Marseille et Sud Toulon-Var



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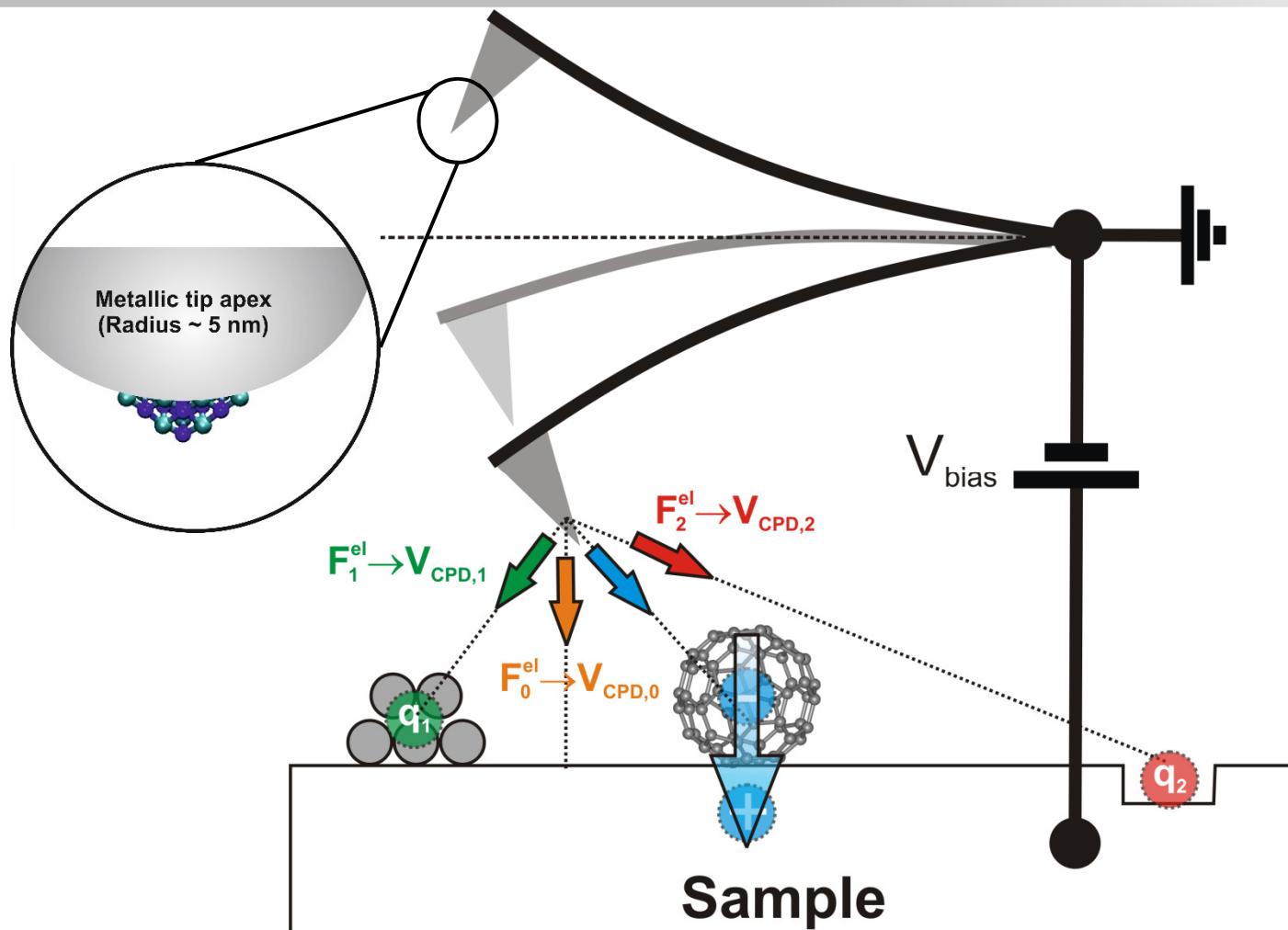


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# Motivation



- Forces:
  - VdW
  - Chemical
  - Magnetostatic
  - Electrostatic

KPFM → Electrostatic force compensation →  $V_{\text{bias}}$  → **Models** to get quantitative estimates (CPD, charges, dipoles...)

# Outline

## I. INTRODUCTION

- ❑ Electrostatic forces & Contact Potential Difference (CPD)

## II. PRINCIPLES OF KPFM

- ❑ Concepts
- ❑ FM-KPFM operational mode

## III. ELECTROSTATIC MODELS

- ❑ Generic approach to  $F^{el}$
- ❑ Examples of models

## IV. EXAMPLES OF APPLICATIONS

- ❑ Long-range regime
- ❑ Short-range regime

## CONCLUSION

# Before starting...

## ❑ There will be color...

- ✓ Slides marked with  are to be understood
- ✓ Slides marked with  can conceptually be accepted and be understood later
- ✓ Slides marked with  address more complex concepts. Use the related references to get into them and take your time

## ❑ Slides including the symbol won't be addressed during that

### lecture (section IV)

- ✓ They may contain relevant information for you, though
- ✓ They remain included in the flow of slides as they are thematically relevant

# I. Introduction



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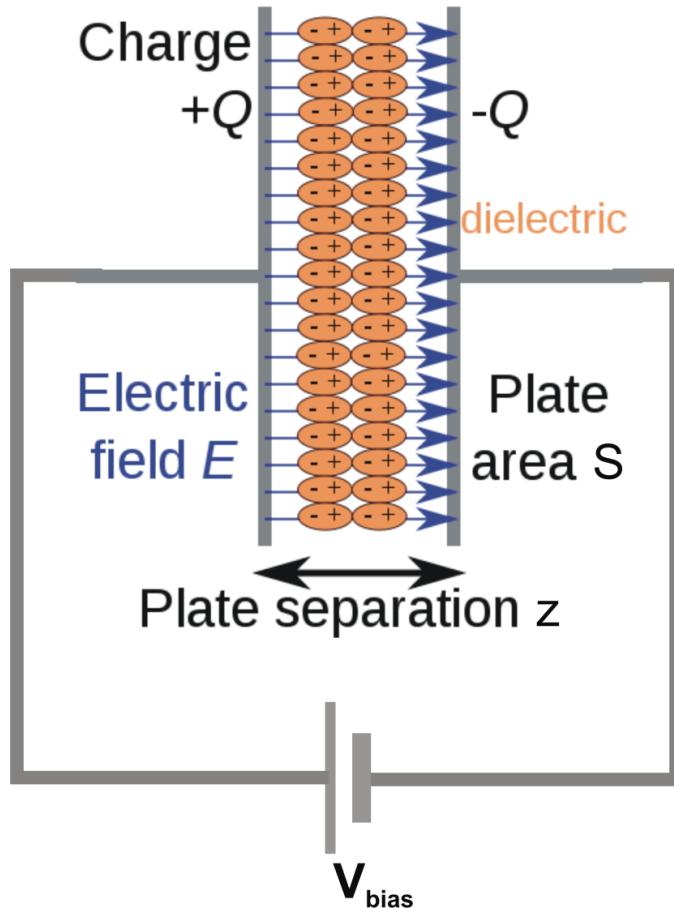


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# Electrostatic force: macroscopic concept

□ Parallel-plate capacitor:



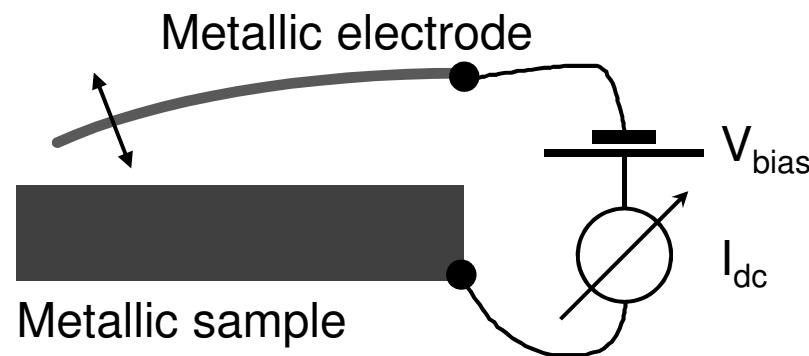
□ Capacitance C:

$$C = \frac{\epsilon_0 \epsilon_r S}{z} = \frac{Q}{V_{\text{bias}}} \quad (\text{Eq.1})$$

# Electrostatic force: macroscopic concept



William Thomson (later Lord Kelvin of Largs):  
1824 (Belfast, Ireland) - 1907 (Largs, UK)

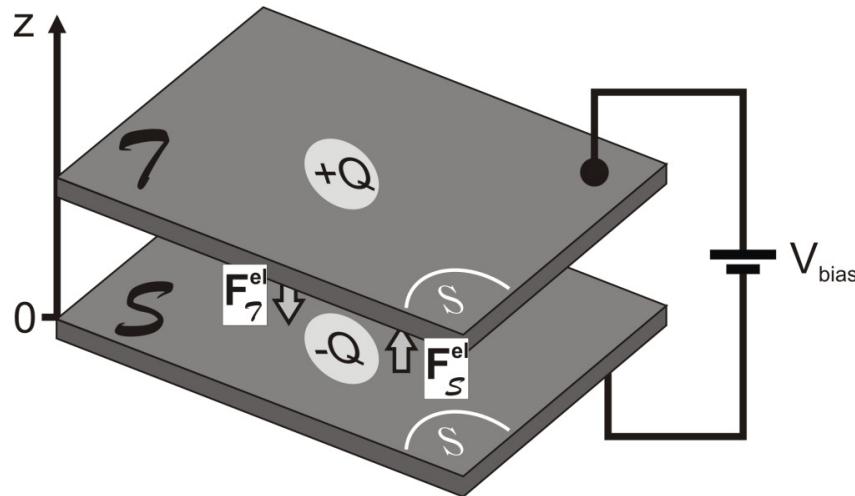


$$I_{\text{dc}} = \frac{dC}{dt} (V_{\text{bias}} - V_{\text{offs}})$$

\*Lord Kelvin, *Phil. Mag.* **46**, 82 (1898)

# Electrostatic force: macroscopic concept

- Electrostatic force acting on the plates of a charged parallel-plate capacitor (no inner charges or dipoles):



Electrostatic energy supplied to the capacitor:

$$W^{\text{el}} = -\frac{1}{2}QV_{\text{bias}} = -\frac{1}{2}CV_{\text{bias}}^2 \quad (\text{Eq.2})$$

$$\mathbf{F}_{\mathcal{T}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z} \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V_{\text{bias}}^2 \hat{\mathbf{z}} \quad (\text{Eq.3})$$

Attractive!

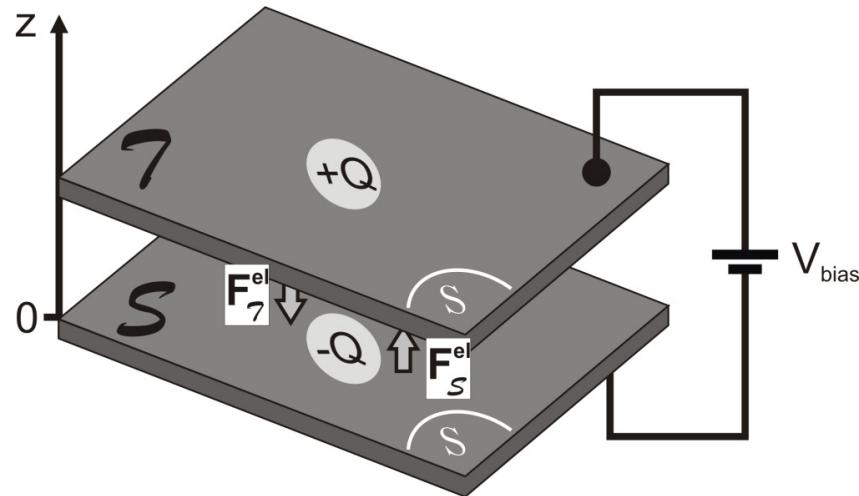
Here:  $\mathbf{F}_{\mathcal{T}}^{\text{el}} = -\frac{1}{2} \frac{\epsilon_0 \epsilon_r S}{z^2} V_{\text{bias}}^2 \hat{\mathbf{z}}$

$$\epsilon_r = 1, S = 1 \mu\text{m}^2, z \sim 2 \text{ nm}; V_{\text{bias}} = 0.1 \text{ V} \Rightarrow |\mathbf{F}^{\text{el}}| \sim 10 \text{ nN} !$$

Electrostatic forces are conditionnally large!

# Electrostatic force: macroscopic concept

- Electrostatic force acting on the plates of a charged parallel-plate capacitor (no inner charges or dipoles):

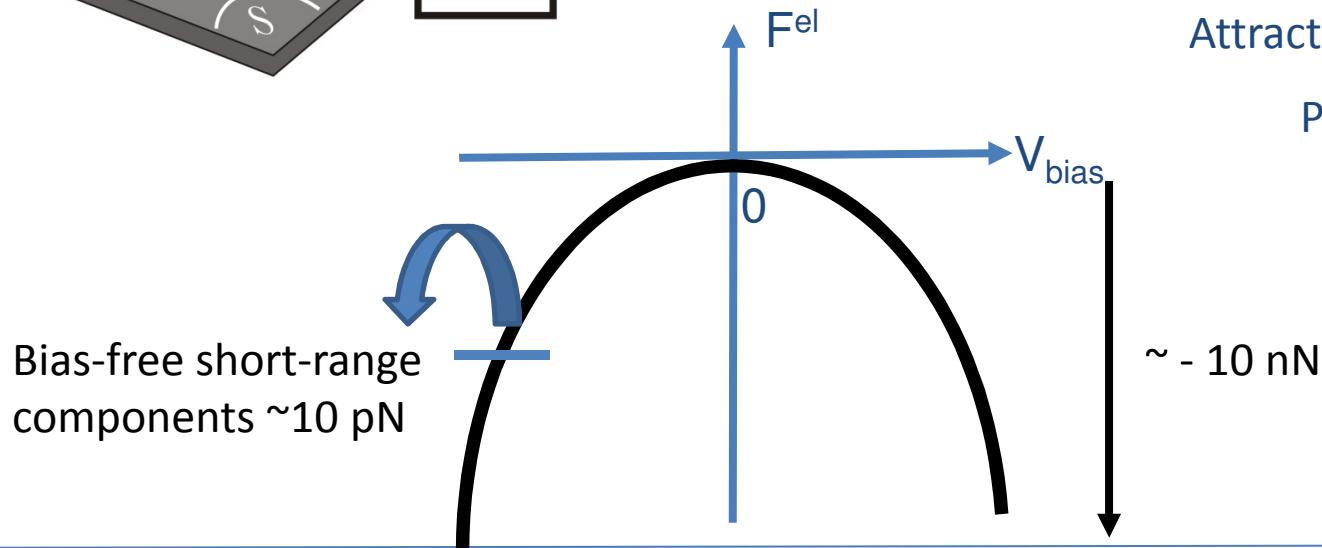


Electrostatic energy supplied to the capacitor:

$$W^{\text{el}} = -\frac{1}{2}QV_{\text{bias}} = -\frac{1}{2}CV_{\text{bias}}^2 \quad (\text{Eq.2})$$

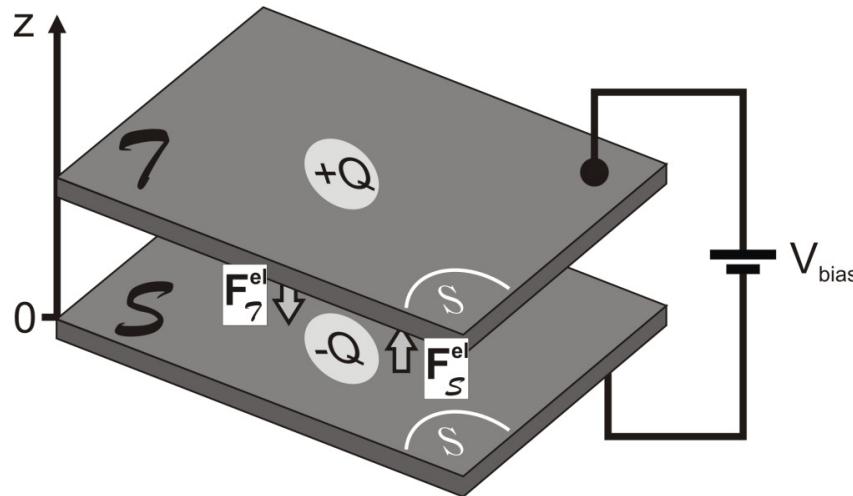
$$\mathbf{F}_{\tau}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z}\hat{\mathbf{z}} = -\frac{1}{2}\left|\frac{\partial C}{\partial z}\right|V_{\text{bias}}^2\hat{\mathbf{z}} \quad (\text{Eq.3})$$

Attractive!  
Parabola-like behavior



# Electrostatic force: macroscopic concept

- Electrostatic force acting on the plates of a charged parallel-plate capacitor (no inner charges or dipoles):

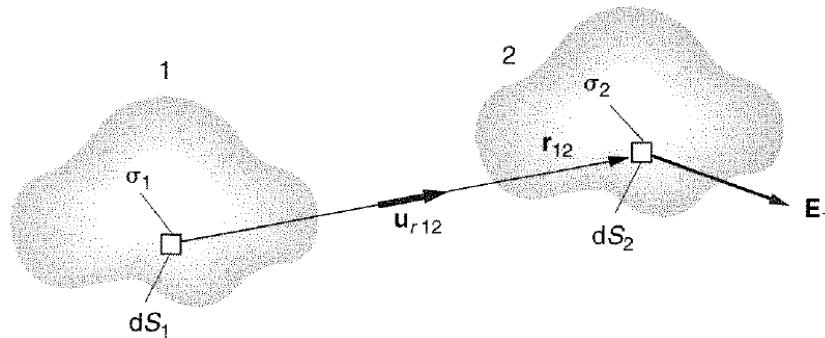


Electrostatic energy supplied to the capacitor:

$$W^{\text{el}} = -\frac{1}{2}QV_{\text{bias}} = -\frac{1}{2}CV_{\text{bias}}^2 \quad (\text{Eq.2})$$

$$\mathbf{F}_{\mathcal{T}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z}\hat{\mathbf{z}} = -\frac{1}{2}\left|\frac{\partial C}{\partial z}\right|V_{\text{bias}}^2\hat{\mathbf{z}} \quad (\text{Eq.3})$$

- Electrostatic force acting on an electrode of any kind:

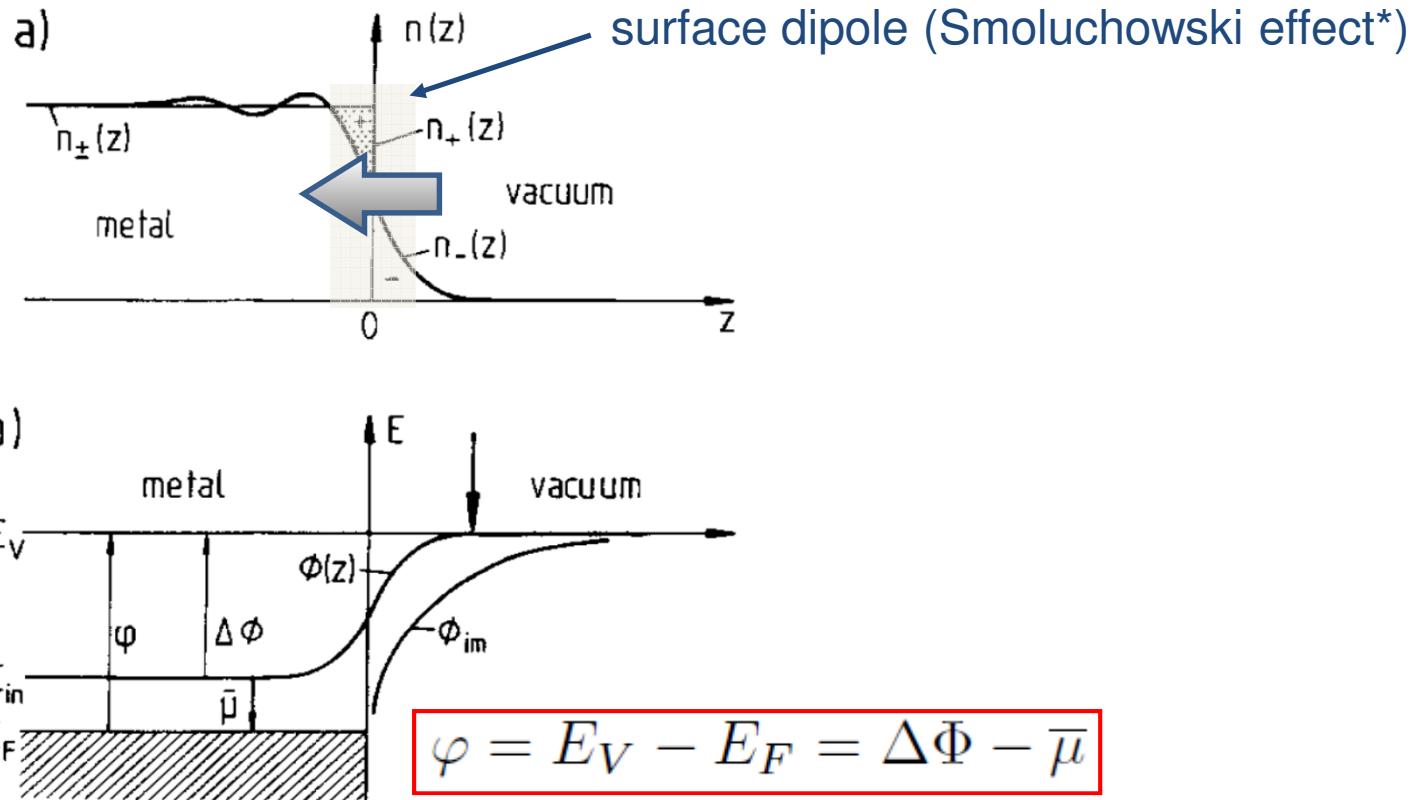


$$\boxed{\mathbf{F}_{1 \rightarrow 2}^{\text{el}} = - \oint_{S_2} \sigma_2 dS_2 \mathbf{E}_1}$$

# Work function in metals

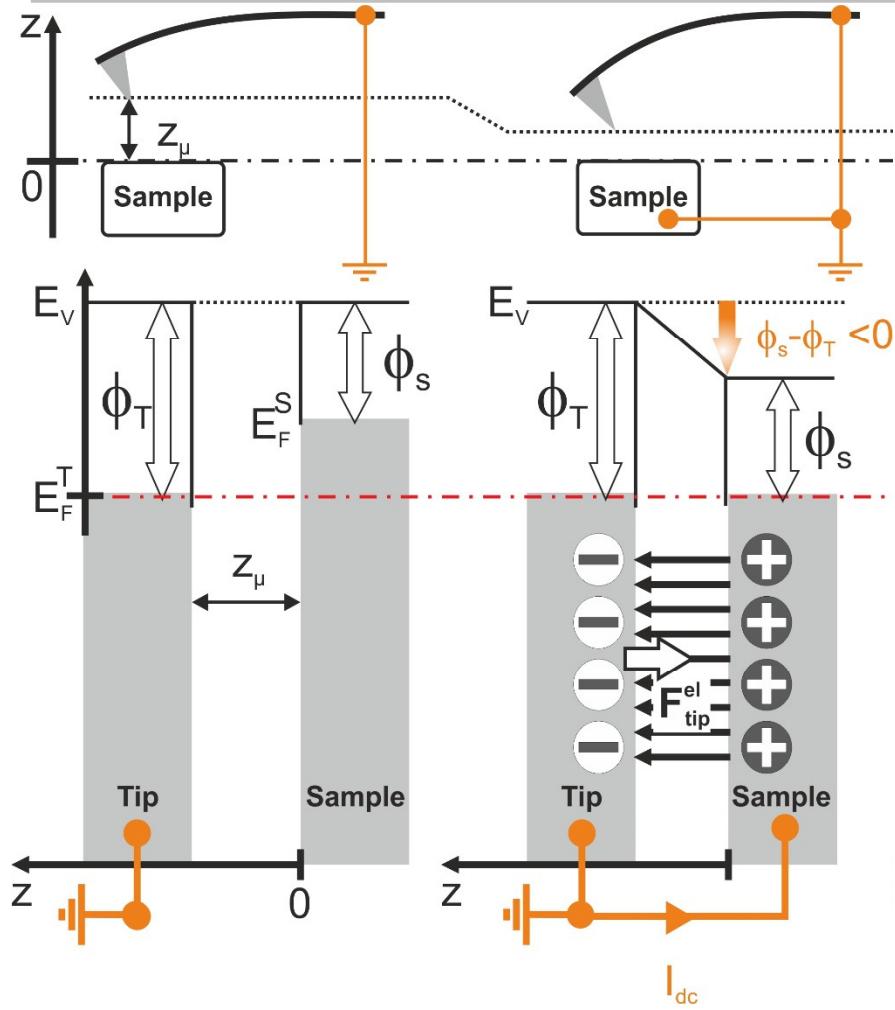
K. Wandelt, Appl. Surf. Sci. 111, 1 (1997)

"The work function  $\varphi$  of an **infinite homogeneous metal** surface is defined as the energy difference between... the Fermi level... and a final state... the so called vacuum level."



\* Physics of surfaces and interfaces, H. Ibach, Springer 2006.

# Electrostatic force and Contact Potential Difference (CPD)

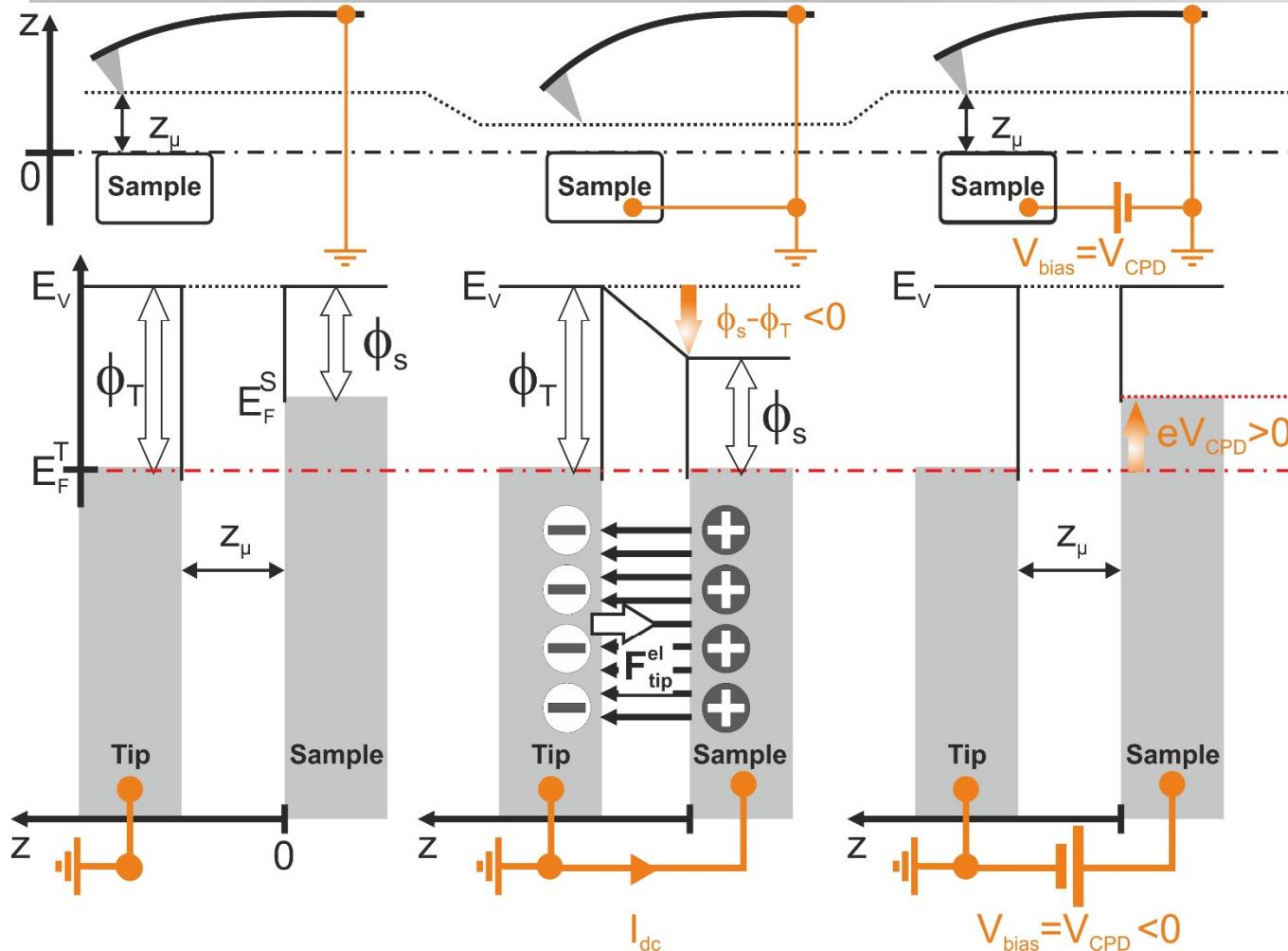


NB: here,  $V_{CPD} < 0$

$$V_{CPD} = \frac{\Delta\Phi}{|e|} = \frac{\Phi_{sample} - \Phi_{tip}}{|e|}$$

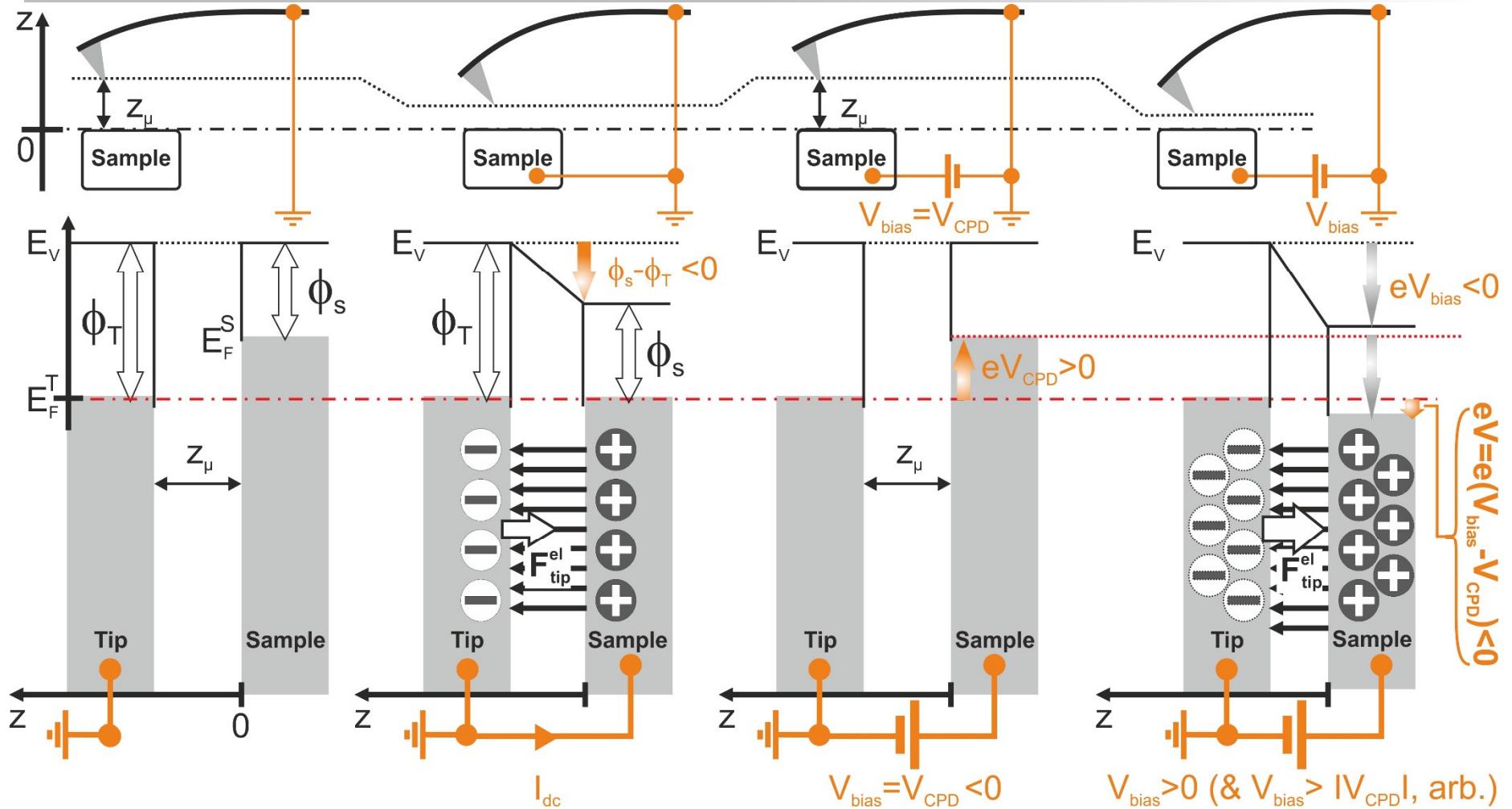
(Eq.5)

# Electrostatic force and Contact Potential Difference (CPD)



$V_{bias} = V_{CPD} \rightarrow$  electrostatic force compensation

# Electrostatic force and Contact Potential Difference (CPD)



$$F_{tip}^{el} = -\frac{\partial W^{el}}{\partial z} \hat{z} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V^2 \hat{z} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| (V_{bias} - V_{CPD})^2 \hat{z} \quad (Eq.6)$$

# Electrostatic force and Contact Potential Difference (CPD)

$$\mathbf{F}_{\text{tip}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z} \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V^2 \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| (V_{\text{bias}} - V_{\text{CPD}})^2 \hat{\mathbf{z}} \quad (\text{Eq.6})$$

*Void capacitor (=inner charge free)*

- KPFM = detecting tip-surface **electrostatic forces** and compensate them with the proper dc bias on the sample while scanning\* :

$$F_{\text{tip}}^{\text{el}} = 0 \Leftrightarrow V_{\text{bias}} = V_{\text{CPD}} \quad (\text{Eq.7})$$

- This is why KPFM may be used on **any kind of surfaces**: metals, semiconductors & insulators, despite with the former, the concept of CPD is ambiguous...

\* only if the tip is grounded and  $V$  is applied to the sample,  $V_{\text{bias}} = -V_{\text{CPD}}$  otherwise

# Electrostatic force and Contact Potential Difference (CPD)

$$\mathbf{F}_{\text{tip}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z} \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V^2 \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| (V_{\text{bias}} - V_{\text{CPD}})^2 \hat{\mathbf{z}} \quad (\text{Eq.6})$$

Void capacitor (=inner charge free)

- Therefore, KPFM was conceptually extended to a mean of measuring samples' CPD\*:

$$F_{\text{tip}}^{\text{el}} = 0 \Leftrightarrow V_{\text{bias}} = V_{\text{CPD}} \quad (\text{Eq.7})$$

- BUT** equations 6 & 7 are valid for a void capacitor, only:

- $F_{\text{tip}}^{\text{el}} \propto V^2$
- $V \rightarrow V(\cancel{x})$ : no charges and/or dipole present inside the capacitor, unless otherwise  $F_{\text{tip}}^{\text{el}} = 0 \Rightarrow V_{\text{bias}} \neq V_{\text{CPD}}$

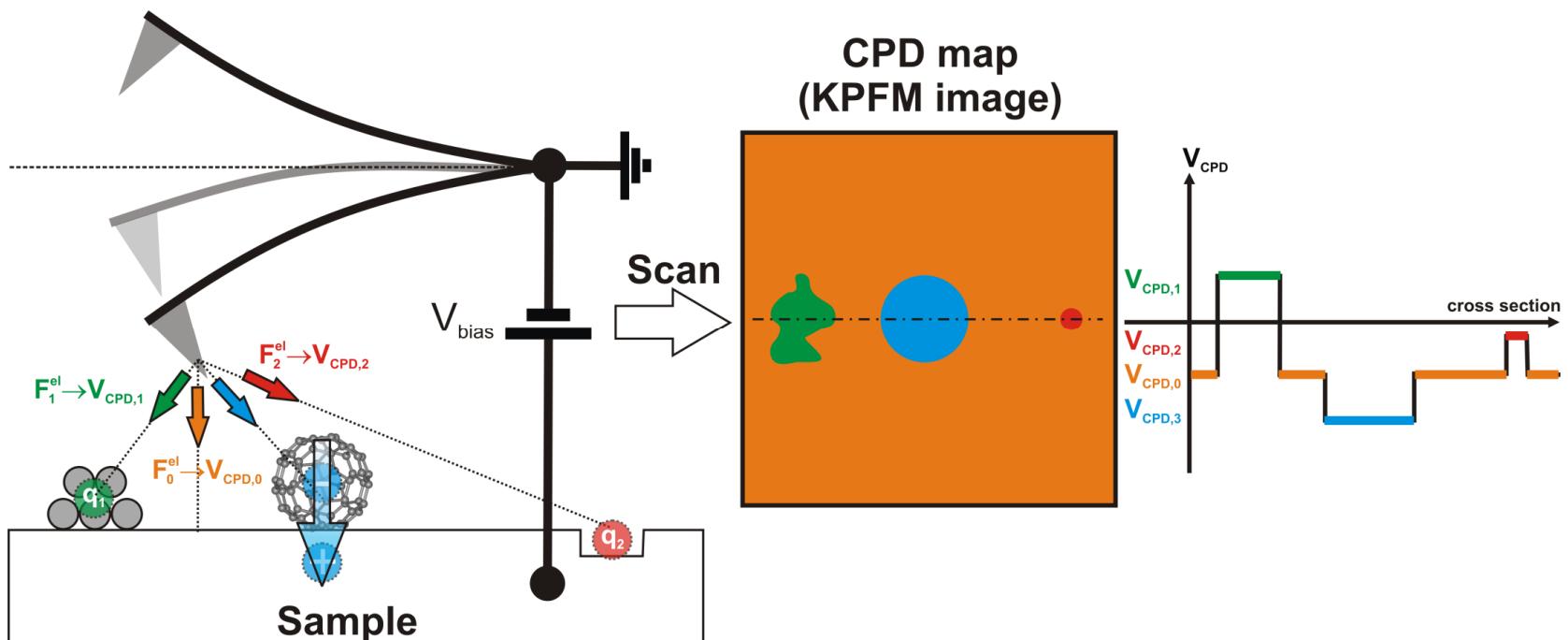
\* only if the tip is grounded and  $V$  is applied to the sample,  $V_{\text{bias}} = -V_{\text{CPD}}$  otherwise

# Electrostatic force and Contact Potential Difference (CPD)

$$\mathbf{F}_{\text{tip}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z} \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V^2 \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| (V_{\text{bias}} - V_{\text{CPD}})^2 \hat{\mathbf{z}} \quad (\text{Eq.6})$$

*Void capacitor (=inner charge free)*

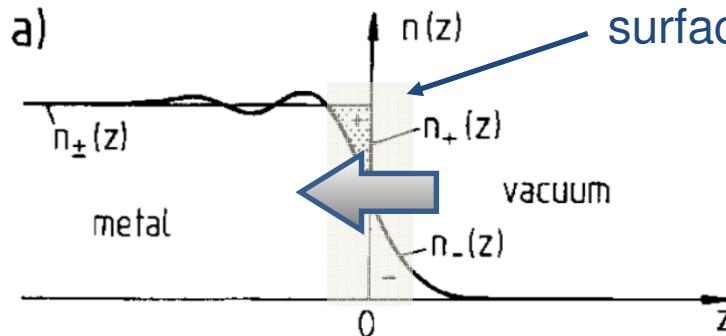
- Charges or dipoles (ions, vacancies, clusters, charge transfer effects, polarization effects...) systematically occur at the tip-surface interface: **models required to interpret  $F^{\text{el}}$  and hence, the KPFM signal (« CPD »)**



# Work function in metals

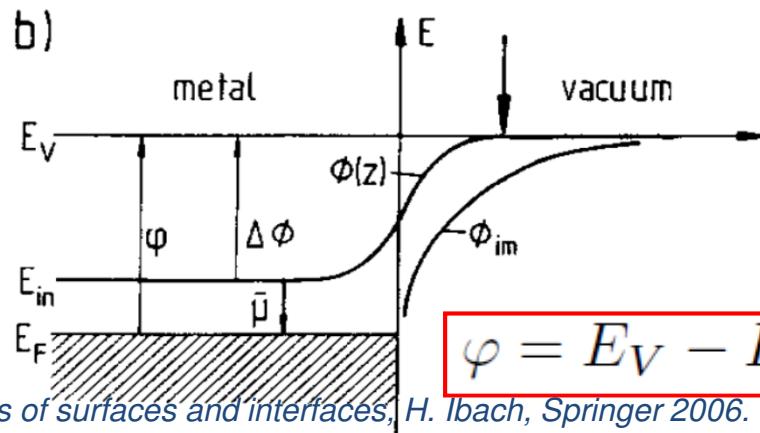
K. Wandelt, Appl. Surf. Sci. 111, 1 (1997)

"The work function  $\varphi$  of an **infinite homogeneous metal** surface is defined as the energy difference between... the Fermi level... and a final state... the so called vacuum level."



surface dipole (Smoluchowski effect\*)

"...Real (metallic) surfaces are (a) of limited size, (b) made up by discrete atoms, (c) mostly include chemical and structural defects... Consequently  $\Phi(z)$  ... vary parallel to the surface. A few Å away from the surface, the energy difference  $\varphi_{loc} = \Delta\Phi(x,y,z) - \mu$  acquires the character of a **local work function**"



Local Contact Potential Difference (LCPD)  
= Short-Range Electrostatic forces

KPFM  
↓

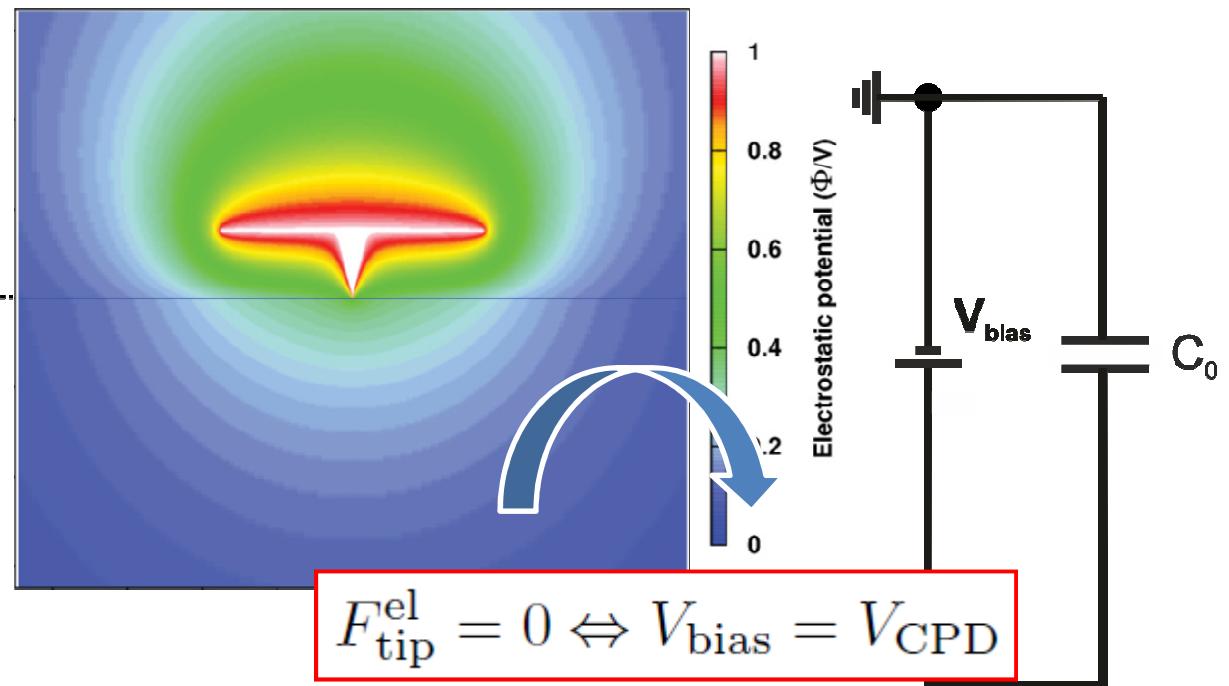
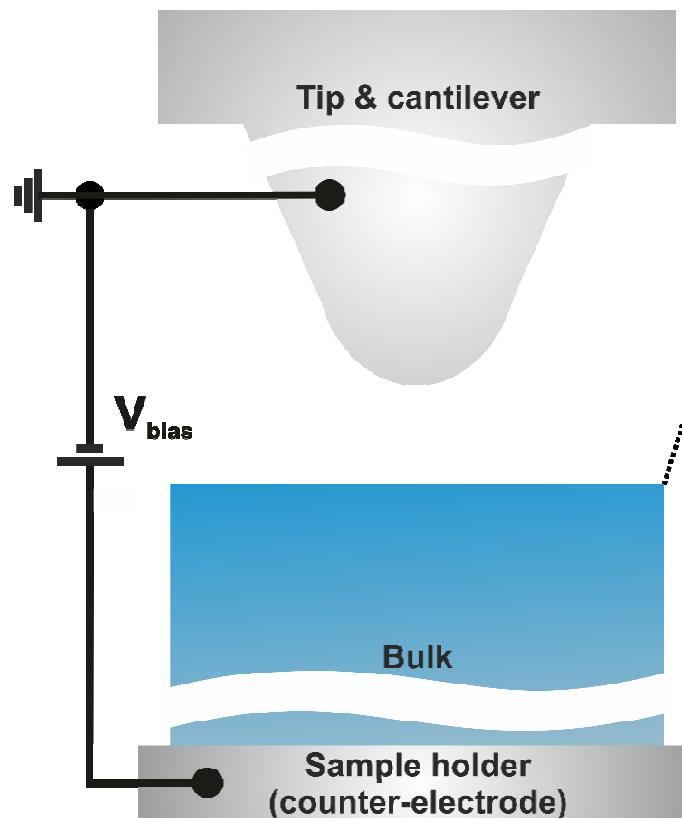
$$\varphi = E_V - E_F = \Delta\Phi - \bar{\mu}$$

\* Physics of surfaces and interfaces, H. Ibach, Springer 2006.

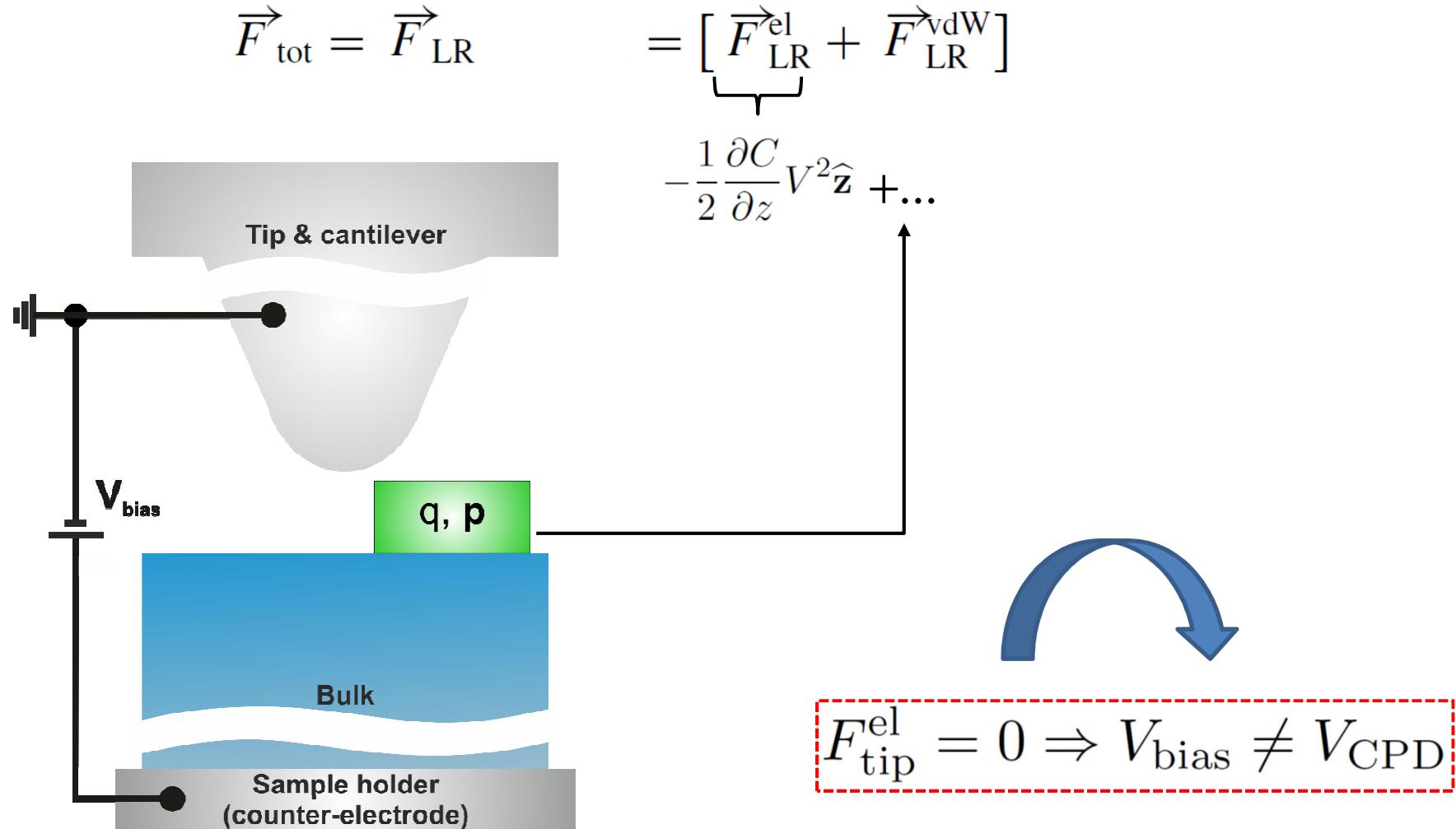
# Long- and short-range electrostatic forces in KPFM

$$\vec{F}_{\text{tot}} = \vec{F}_{\text{LR}}$$

$$= \underbrace{\left[ \vec{F}_{\text{LR}}^{\text{el}} + \vec{F}_{\text{LR}}^{\text{vdW}} \right]}_{- \frac{1}{2} \frac{\partial C}{\partial z} V^2 \hat{\mathbf{z}}}$$



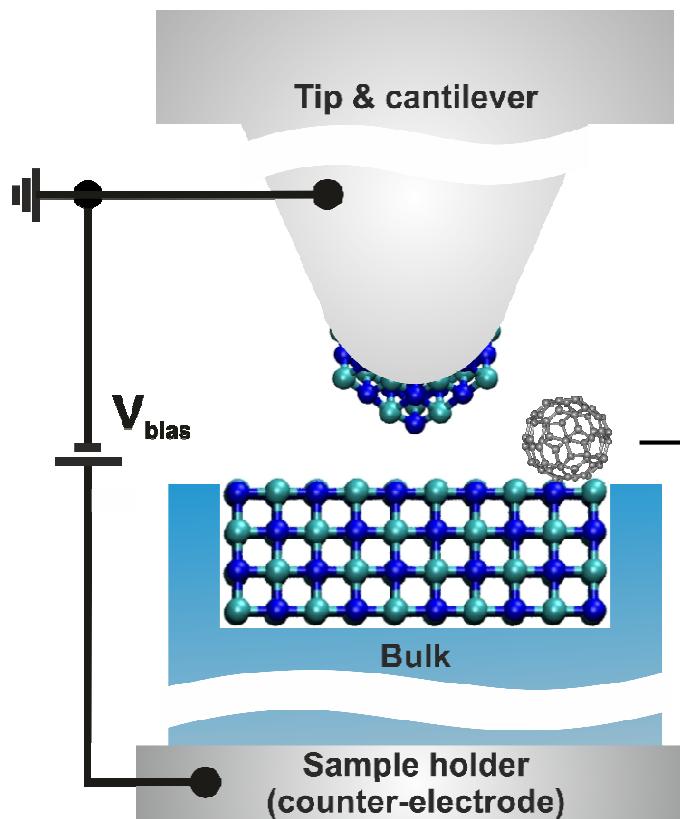
# Long- and short-range electrostatic forces in KPFM



Mesoscopic objects (whose size is comparable or larger than the tip)

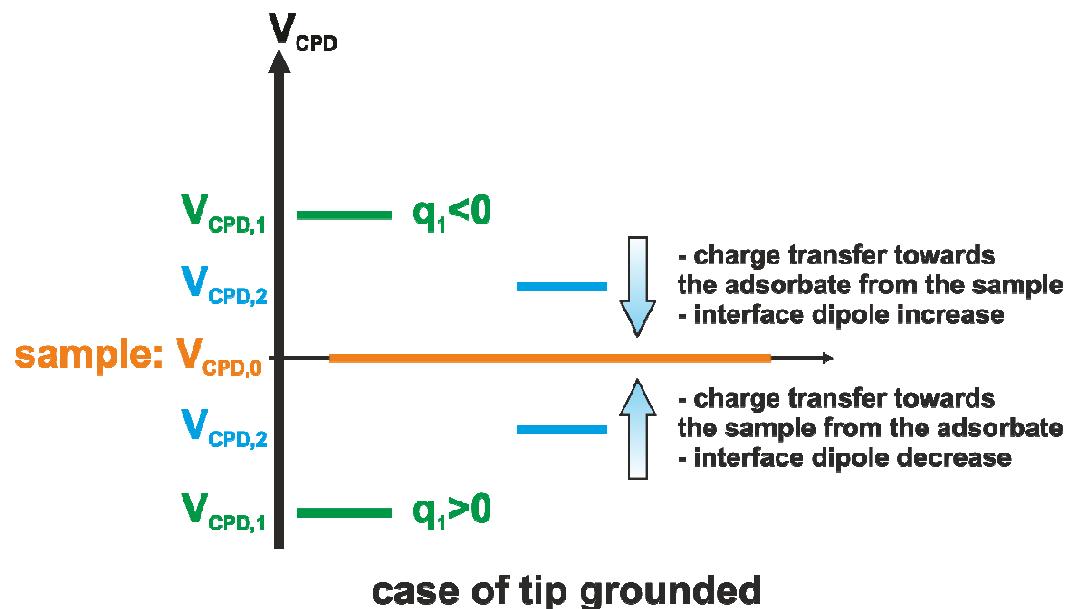
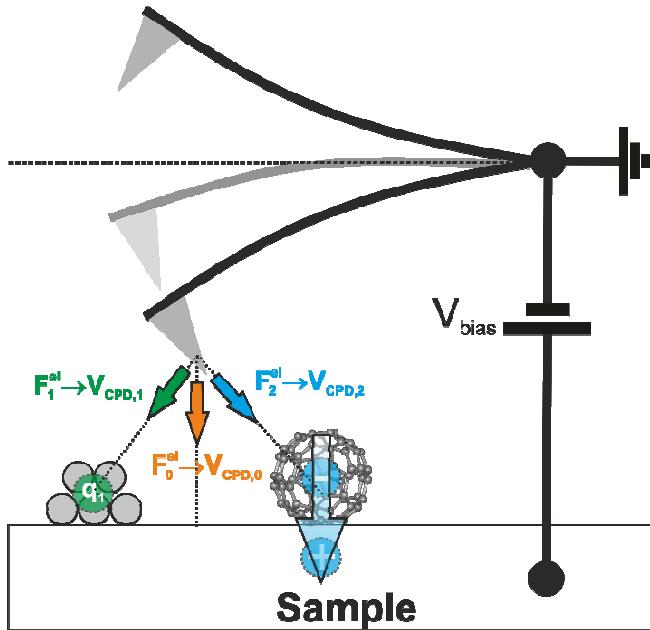
# Long- and short-range electrostatic forces in KPFM

$$\vec{F}_{\text{tot}} = \vec{F}_{\text{LR}} + \vec{F}_{\text{SR}} = \left[ \underbrace{\vec{F}_{\text{LR}}^{\text{el}} + \vec{F}_{\text{LR}}^{\text{vdW}}}_{-\frac{1}{2} \frac{\partial C}{\partial z} V^2 \hat{\mathbf{z}}} \right] + \left[ \underbrace{\vec{F}_{\text{SR}}^{\text{el}} + \vec{F}_{\text{SR}}^{\text{vdW}}}_{\dots} \right] \quad (\text{Eq.8})$$



$$F_{\text{tip}}^{\text{el}} = 0 \Rightarrow V_{\text{bias}} \neq V_{\text{CPD}}$$

# Sign of the charge & dipole orientation (tip grounded)\*

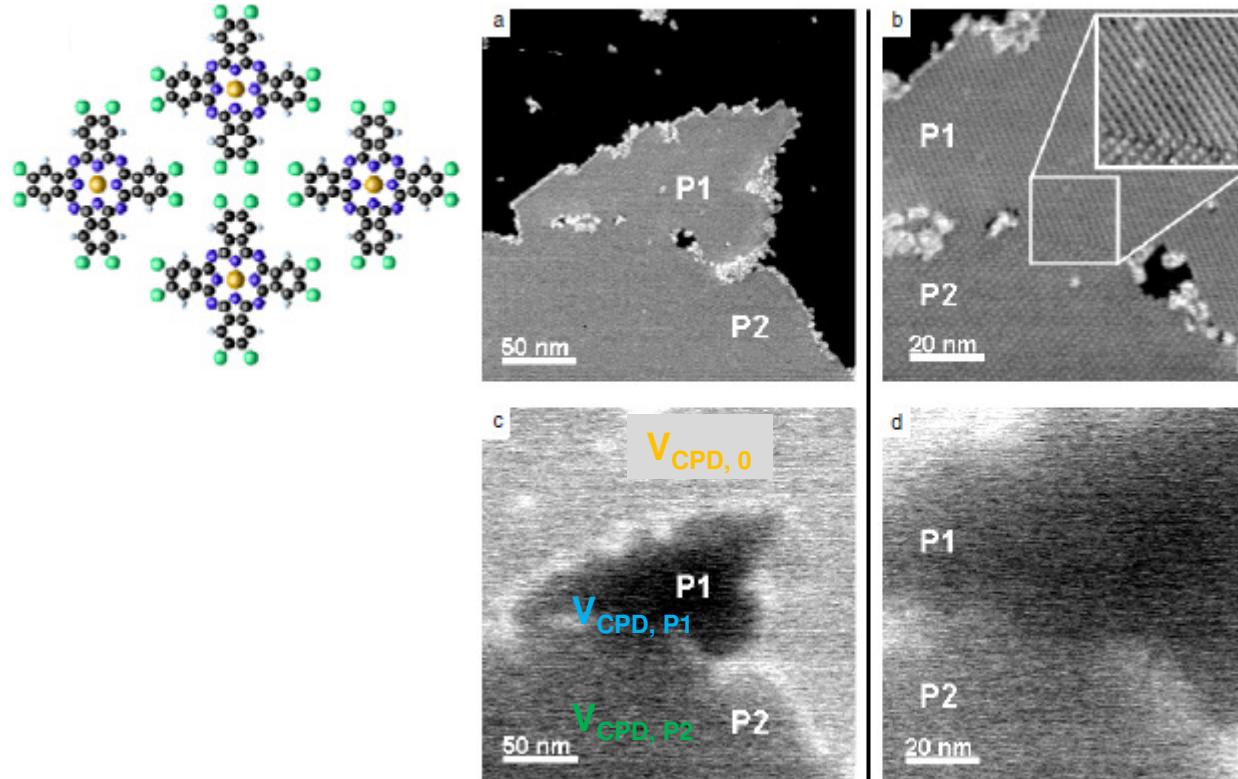


Local quantity $\alpha$	Sign, orientation	CPD shift: $V_{CPD,\alpha} - V_{CPD,0}$	« Local WF interpretation » $\Phi_{sample,\alpha} - \Phi_{sample,0}$
Charge $q$	+	$< 0$	$< 0$ : decrease
	-	$> 0$	$> 0$ : increase
Dipole $p$	$\uparrow$	$< 0$	$< 0$ : decrease
	$\downarrow$	$> 0$	$> 0$ : increase

\*consistent with most frequently reported results (see « References » section at the end of the slides)

# Example

## □ ZnPcCl<sub>8</sub> on Ag(111)\*:



- $V_{CPD, 0} = 4.73 \text{ V}$
- $V_{CPD, P1} = V_{CPD, \text{ref}} - 103 \text{ mV} \rightarrow \text{negative shift} \rightarrow \text{layer gets } \ll + \gg \text{ charged} \rightarrow \text{interf. dip. decreased}$
- $V_{CPD, P2} = V_{CPD, \text{ref}} - 54 \text{ mV} \rightarrow \text{idem, but less than with P1}$

\*P. Milde et al. Nanotechnology 19, 305501 (2008)

## Summary of that section...

- KPFM = compensation of the electrostatic force(s) that occur between the tip and the surface forming a capacitor.
- For a « void capacitor », the electrostatic force writes:

$$\mathbf{F}_{\text{tip}}^{\text{el}} = -\frac{\partial W^{\text{el}}}{\partial z} \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| V^2 \hat{\mathbf{z}} = -\frac{1}{2} \left| \frac{\partial C}{\partial z} \right| (V_{\text{bias}} - V_{\text{CPD}})^2 \hat{\mathbf{z}}$$

- Therefore:

$$F_{\text{tip}}^{\text{el}} = 0 \Leftrightarrow V_{\text{bias}} = V_{\text{CPD}}$$

- But this is an insufficient approach with real samples as charges and/or dipoles are always present therein. Hence, the  $V_{\text{bias}}$  and  $z$  dependence of the total electrostatic force is to be quantified first to interpret the **KPFM signal, i.e. the « CPD »**
- The sign of the CPD shift tells us about the sign of the charge and/or of the surface dipole present on the surface

## II. Principles of KPFM



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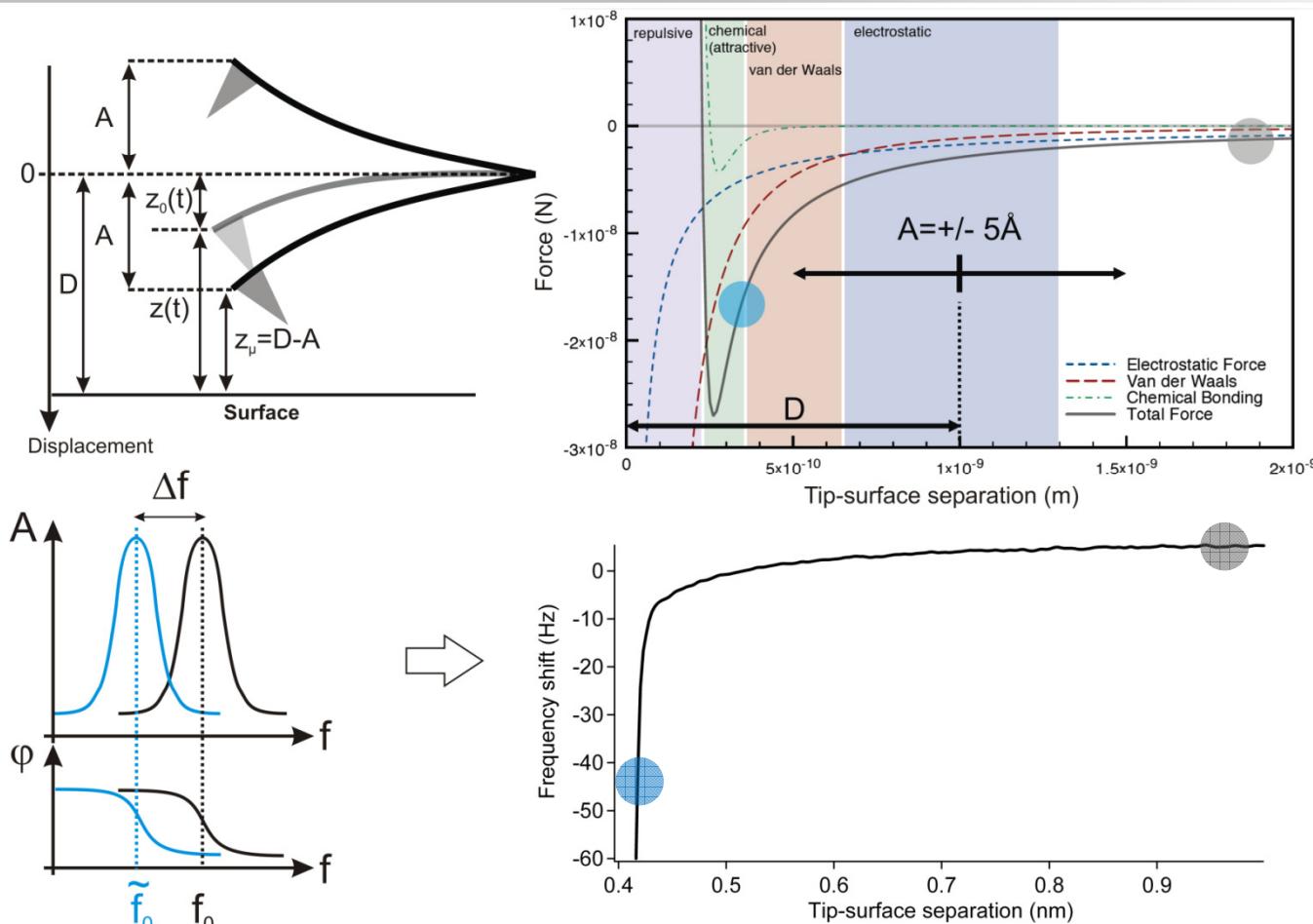
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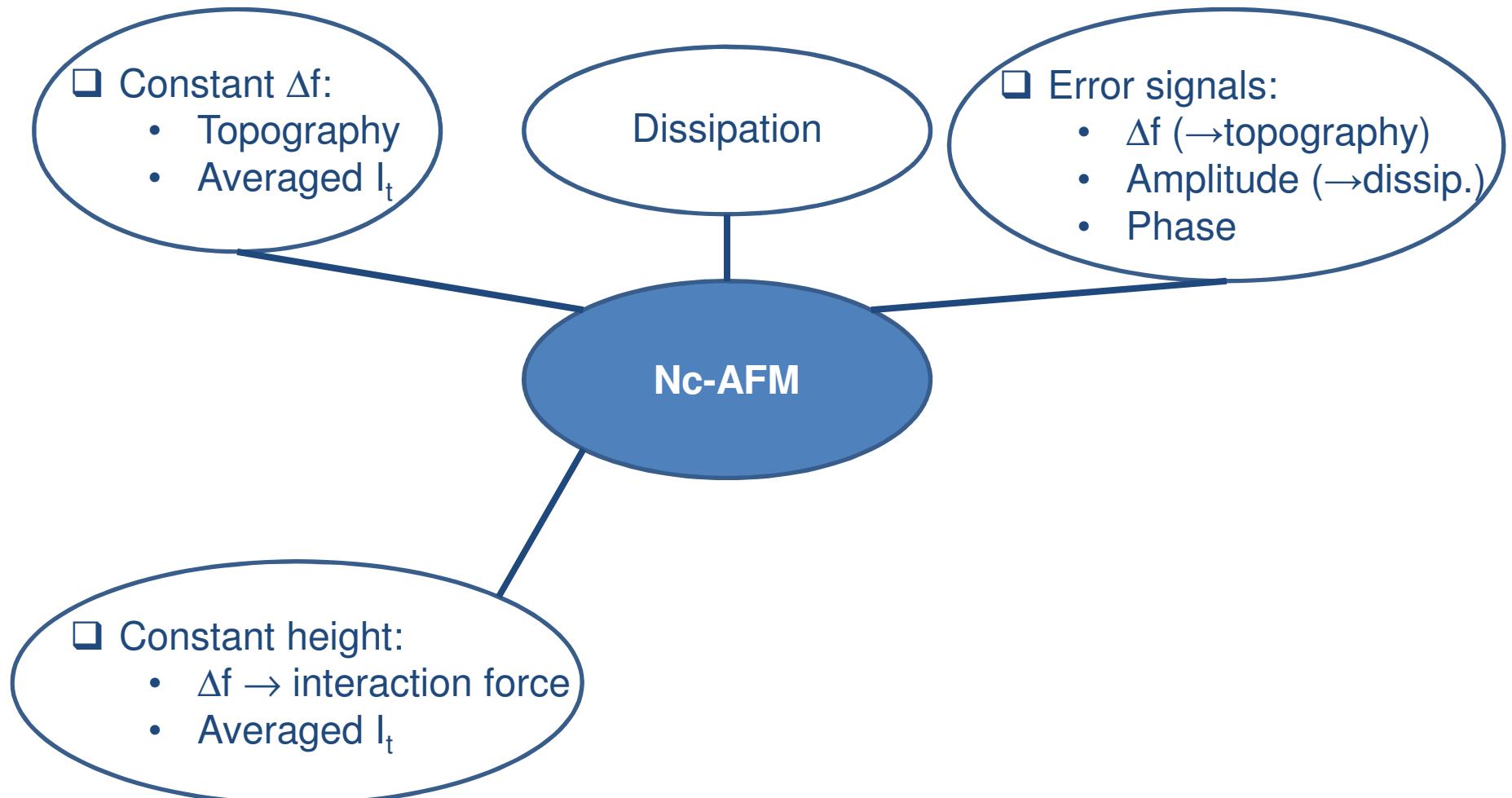
# Frequency shift in non contact-AFM



$$\frac{\Delta f(z_\mu)}{f_0} = \frac{\langle F_{\text{int}}^c \rangle}{k_0 A_0} = \frac{1}{2\pi k_0 A_0} \int_0^{2\pi} F_{\text{int}}^c(z_\mu + A_0 - A_0 \cos(u)) \cos(u) du \quad (\text{Eq.9})$$

<sup>1</sup>F.Giessibl, Phys Rev. B 56, 16010 (1997); Phys. Rev.B 61, 9968 (2000)

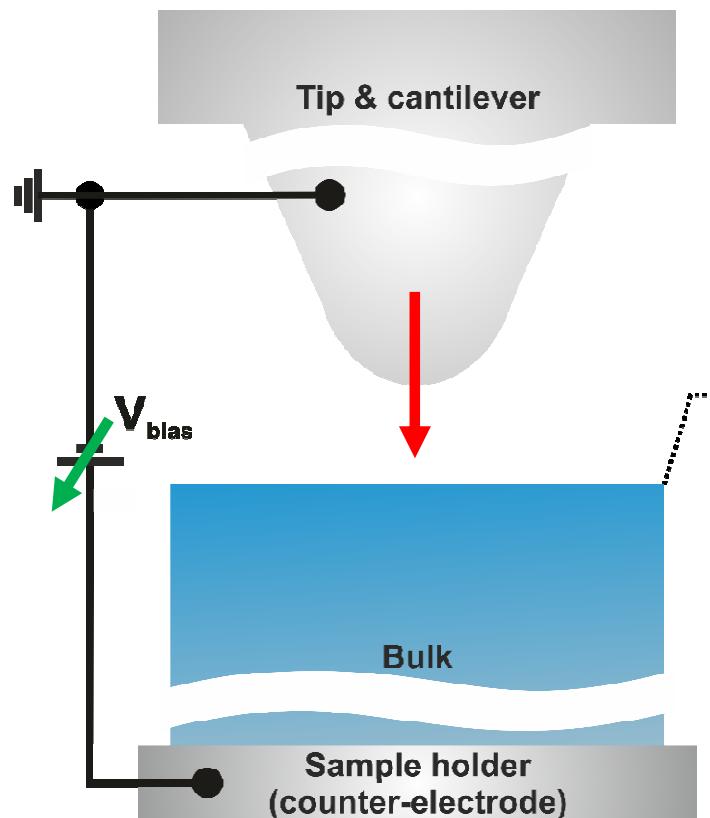
# Non contact-AFM



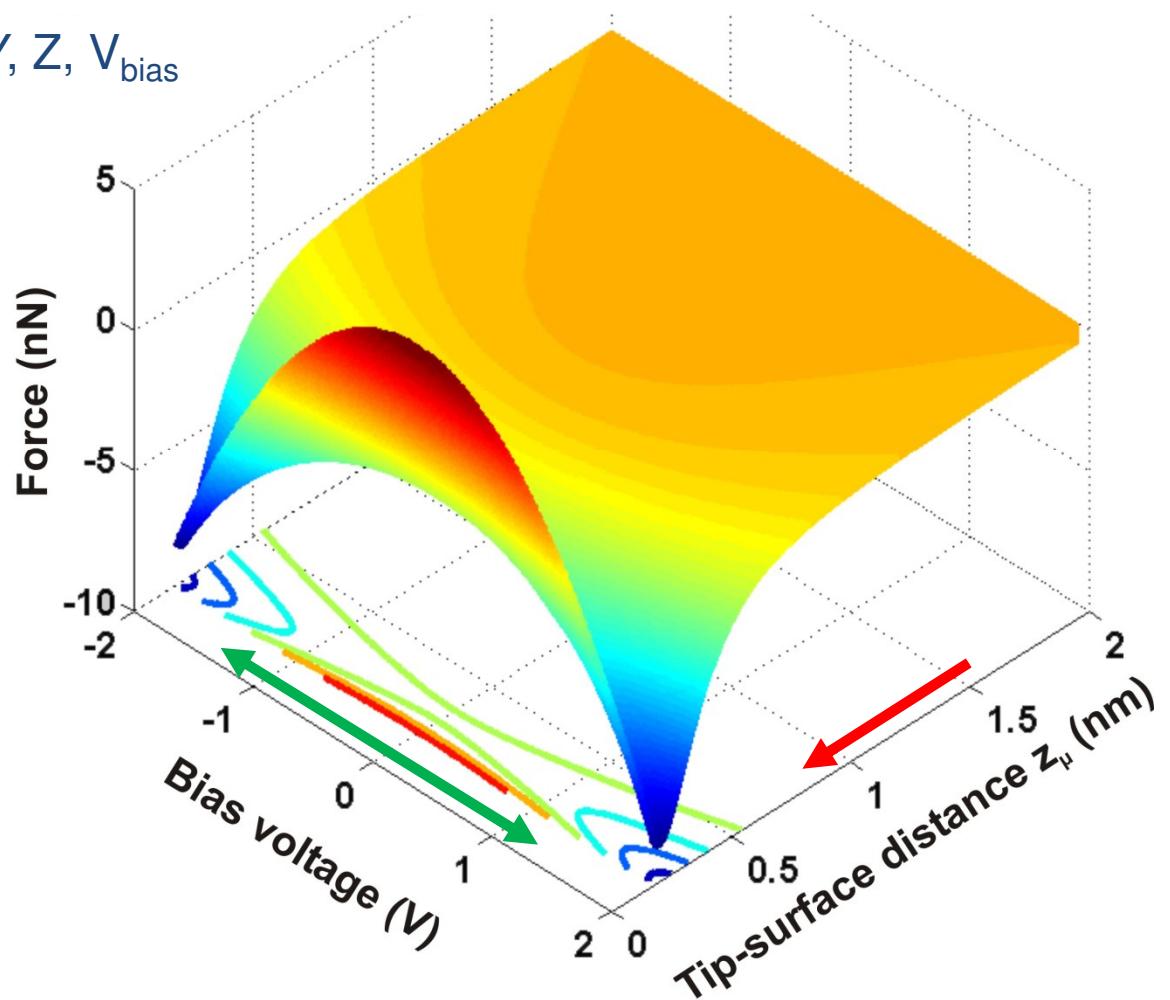
# KPFM (in connection with nc-AFM)

$$\vec{F}_{\text{tot}} = \vec{F}_{\text{LR}} + \vec{F}_{\text{SR}} = [\vec{F}_{\text{LR}}^{\text{el}} + \vec{F}_{\text{LR}}^{\text{vdW}}] + [\vec{F}_{\text{SR}}^{\text{el}} + \vec{F}_{\text{SR}}^{\text{vdW}}]$$

4D vectorial field: X, Y, Z,  $V_{\text{bias}}$

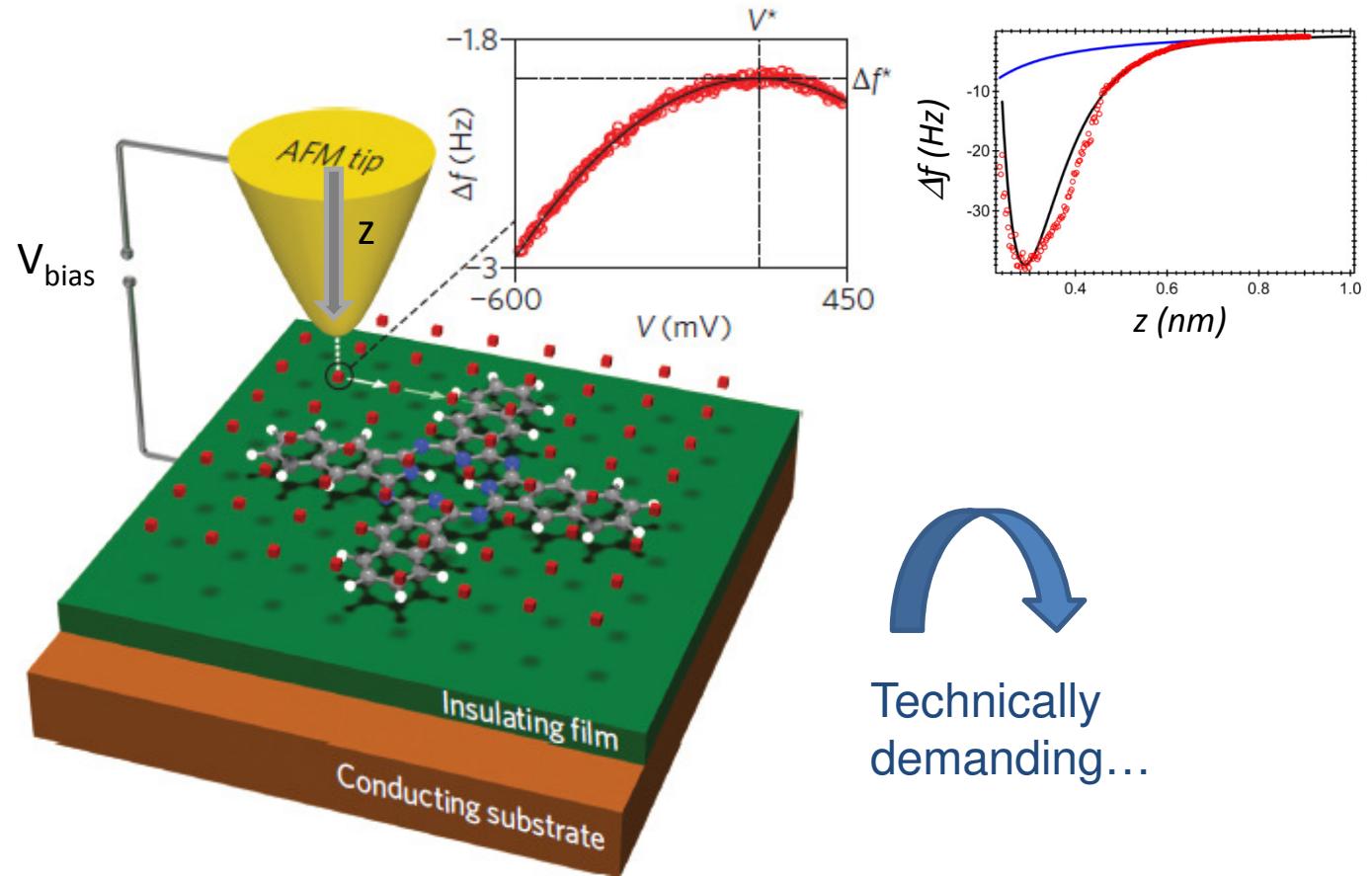


Constant X & Y, here



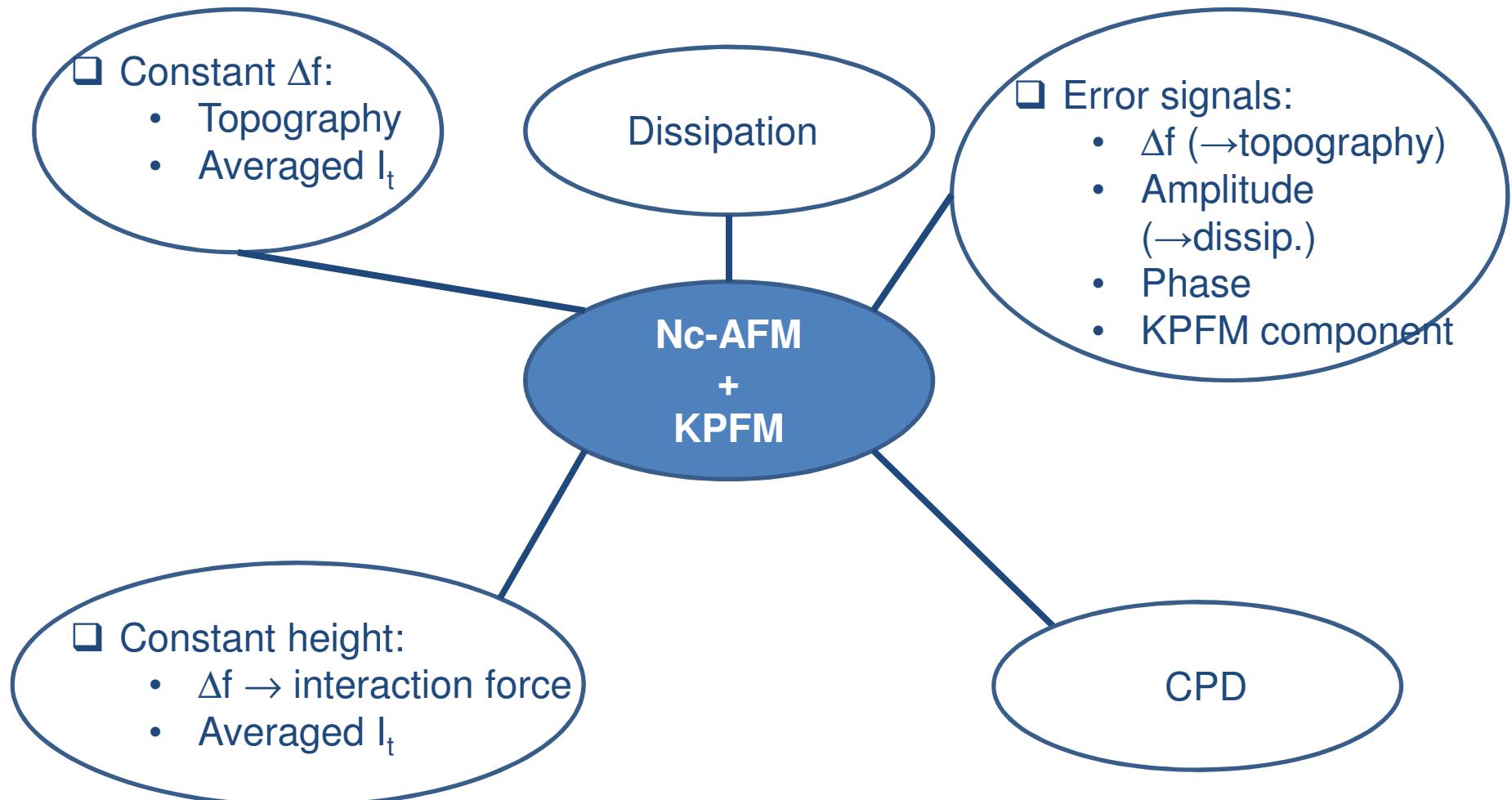
# KPFM (in connection with nc-AFM)

The ideal way to get accurate forces & CPD measurements is to perform 4D force fields measurements\*:



\*scheme adapted from F.Mohn *et al.* Nature Nanotechnology 7(4), 227–231 (2012)

# Non contact-AFM

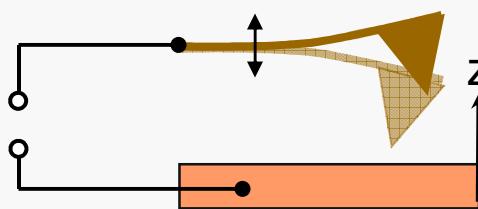


# KPFM (in connection with nc-AFM)

Idea<sup>\*</sup> : bias modulation  $\longrightarrow$  discrimination of the electrostatic force w.r.t. other interaction forces

Bias voltage applied between the tip and the surface :

$$V_{bias} = V_{dc} + V_{ac} \sin(2\pi f_{mod} t)$$



Noncontact-AFM:  
Oscillation at  $f_0$   
(Force  $\rightarrow \Delta f(z)$ )

Attractive electrostatic force (tip, void capacitor):

$$F_{tip}^{\text{el}} = +\frac{1}{2} \frac{\partial C(z)}{\partial z} [V_{dc} - V_{CPD} + V_{ac} \sin(2\pi f_{mod} t)]^2 \quad (\text{Eq. 10})$$

\*M. Nonnenmacher et al., APL **58**, 2921 (1991); J. Weaver et al. JVSTB **9**, 1559 (1991)

# KPFM (in connection with nc-AFM)

Spectral components:

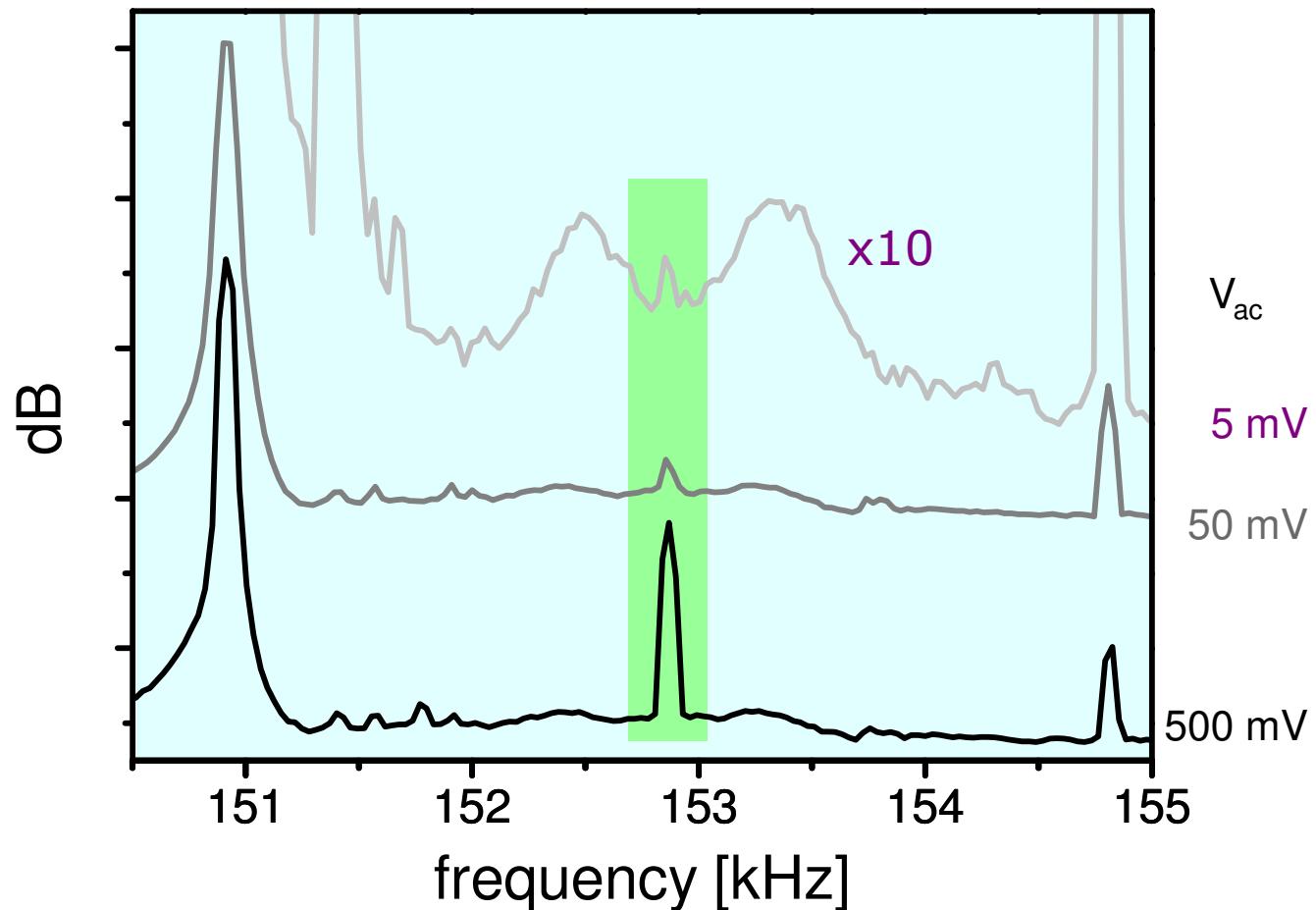
$$\left\{ \begin{array}{l} F_{\text{tip}}^{\text{el,0}} = \frac{\partial C(z)}{\partial z} \left[ \frac{1}{2} (V_{\text{dc}} - V_{\text{CPD}})^2 + \frac{V_{\text{ac}}^2}{4} \right] \\ F_{\text{tip}}^{\text{el},f_{\text{mod}}} = \frac{\partial C(z)}{\partial z} (V_{\text{dc}} - V_{\text{CPD}}) V_{\text{ac}} \sin(2\pi f_{\text{mod}} t) \\ F_{\text{tip}}^{\text{el},2f_{\text{mod}}} = \frac{\partial C(z)}{\partial z} \frac{V_{\text{ac}}^2}{4} \cos(2f_{\text{mod}} t) \end{array} \right. \quad \begin{array}{l} (\text{Eq. 11a}) \\ (\text{Eq. 11b}) \\ (\text{Eq. 11c}) \end{array}$$

- These superimpose to the interaction force between the cantilever and the surface
- Static deflection & induced vibrations of the cantilever at  $f_0 + f_{\text{mod}}$  and  $f_0 + 2f_{\text{mod}}$
- Detection and cancellation of the  $f_{\text{mod}}$  component by applying a proper dc voltage which matches the CPD



# KPFM (in connection with nc-AFM)

Deflection power spectrum\*,  $f_{\text{mod}} = 2 \text{ kHz}$



\*U.Zerweck et al., Phys. Rev. B 71, 125424 (2005)

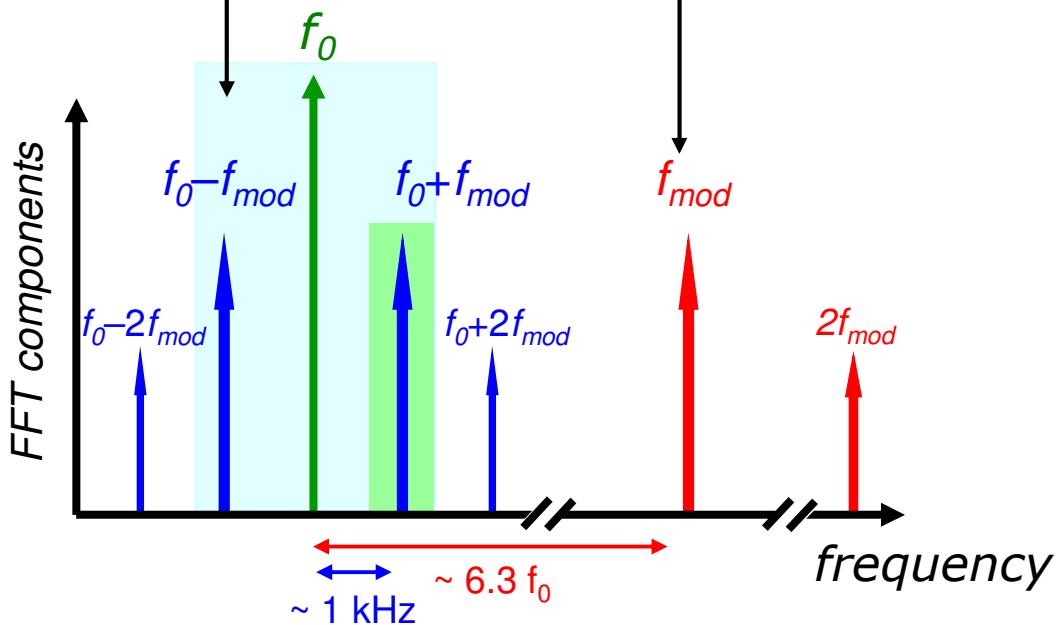
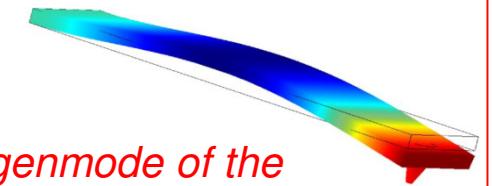
# FM- & AM-KPFM

Frequency modulation (FM-KPFM) :  $f_{mod} \sim 1 \text{ kHz}$

Amplitude modulation (AM-KPFM) :

$$f_{mod} = f_1 \sim 6.3f_0$$

$\rightarrow f_{mod}$  matches the first bending eigenmode of the cantilever above the fundamental one



# AM- vs. FM-KPFM

PHYSICAL REVIEW B 86, 075407 (2012)

## Multiscale approach for simulations of Kelvin probe force microscopy with atomic resolution

Ali Sadeghi, Alexis Baratoff, S. Alireza Ghasemi, Stefan Goedecker, Thilo Glatzel, Shigeki Kawai, and Ernst Meyer

*Department of Physics, University of Basel, Klingelbergstrasse 82, CH-4056 Basel, Switzerland*

(Received 23 March 2012; revised manuscript received 21 June 2012; published 2 August 2012)

The distance dependence and atomic-scale contrast recently observed in nominal contact potential difference (CPD) signals simultaneously recorded by Kelvin probe force microscopy (KPFM) using noncontact atomic force microscopy (NCAFM) on defect-free surfaces of insulating as well as semiconducting samples have stimulated theoretical attempts to explain such effects. Especially in the case of insulators, it is not quite clear how the applied bias voltage affects electrostatic forces acting on the atomic scale. We attack this problem in two steps. First, the electrostatics of the macroscopic tip-cantilever-sample system is treated by a finite-difference method on an adjustable nonuniform mesh. Then the resulting electric field under the tip apex is inserted into a series of atomistic wavelet-based density functional theory (DFT) calculations. Results are shown for a realistic neutral but reactive silicon nanoscale tip interacting with a NaCl(001) sample. Bias-dependent forces and resulting atomic displacements are computed to within an unprecedented accuracy. Theoretical expressions for amplitude modulation (AM) and frequency modulation (FM) KPFM signals and for the corresponding local contact potential differences (LCPD) are obtained by combining the macroscopic and atomistic contributions to the electrostatic force component generated at the voltage modulation frequency, and evaluated for several tip oscillation amplitudes  $A$  up to 10 nm. For  $A = 0.1 \text{ \AA}$ , the computed LCPD contrast is proportional to the slope of the atomistic force versus bias in the AM mode and to its derivative with respect to the tip-sample separation in the FM mode. Being essentially constant over a few volts, this slope is the basic quantity that determines variations of the atomic-scale LCPD contrast. Already above  $A = 1 \text{ \AA}$ , the LCPD contrasts in both modes exhibit almost the same spatial dependence as the slope. In the AM mode, this contrast is approximately proportional to  $A^{-1/2}$ , but remains much weaker than the contrast in the FM mode, which drops somewhat faster as  $A$  is increased. These trends are a consequence of the macroscopic contributions to the KPFM signal, which are stronger in the AM-mode and especially important if the sample is an insulator even at subnanometer separations where atomic-scale contrast appears.



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# Frequency-Modulation KPFM

Electrostatic force  $\longrightarrow$  shift of the resonance:

1<sup>st</sup> order :

$$f'_0 = \frac{1}{2\pi} \sqrt{\frac{k - \partial F / \partial z}{m^*}} \approx f_0 \left( 1 - \frac{1}{2k} \frac{\partial F}{\partial z} \right)$$

(Eq. 12)

Bias modulation ( $f_{\text{mod}}$ )  $\longrightarrow$  Electr. force modulation ( $f_{\text{mod}}$ )  $\longrightarrow$   $\Delta f$  modulation ( $f_{\text{mod}}$ )

« FM-KPFM is sensitive to the electrostatic force gradient... »

# Frequency-Modulation KPFM

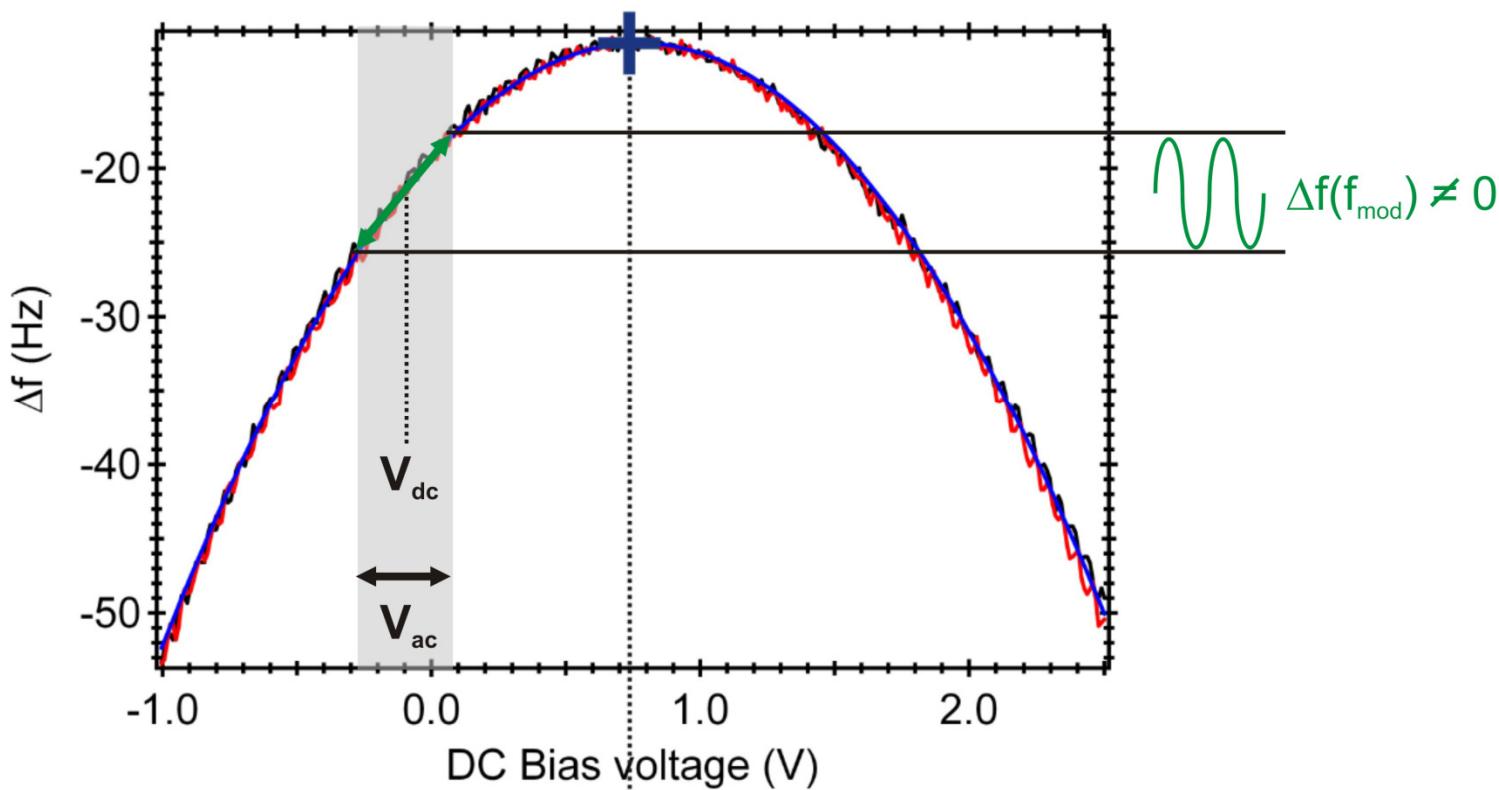
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# Frequency-Modulation KPFM

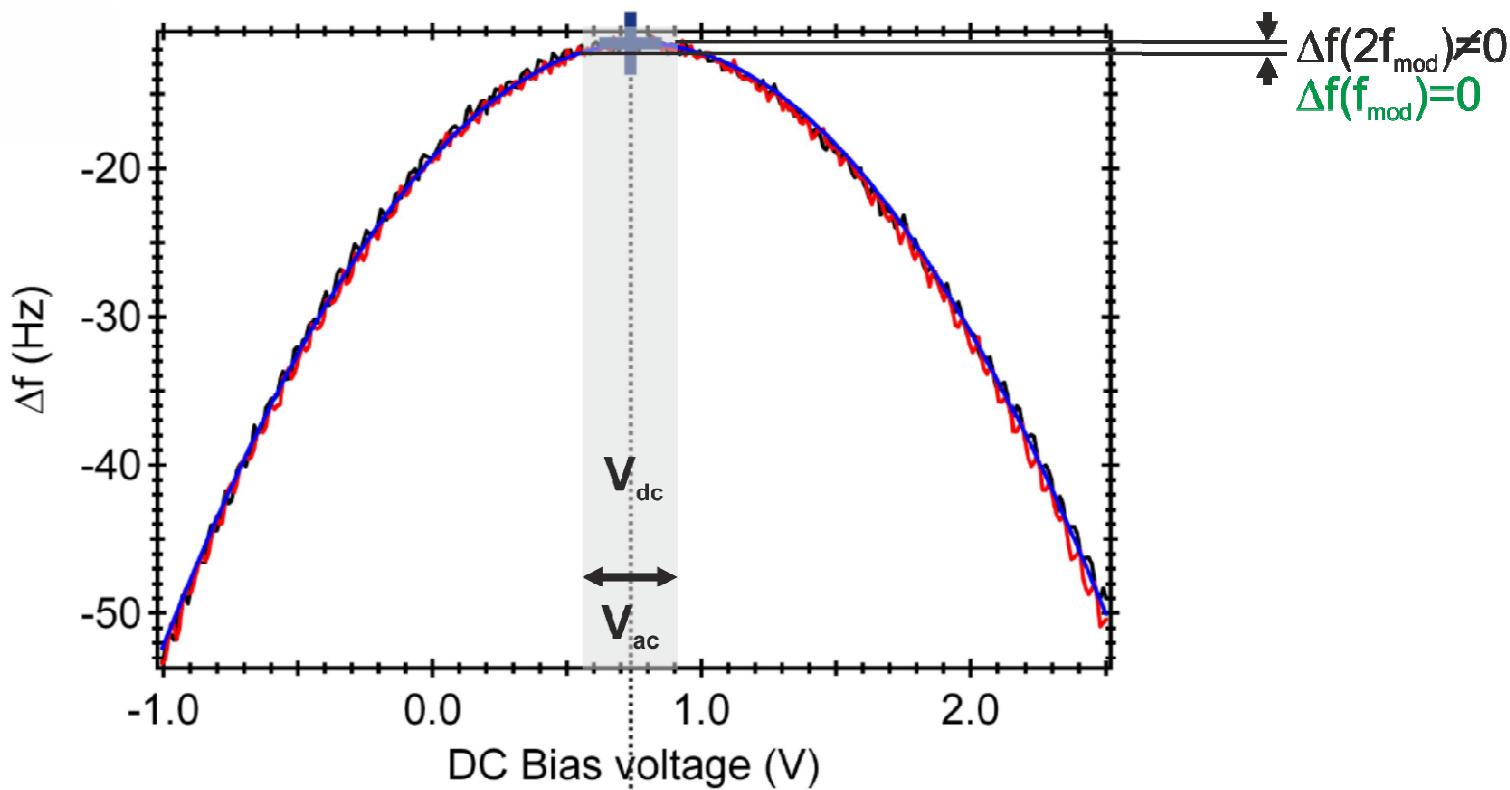
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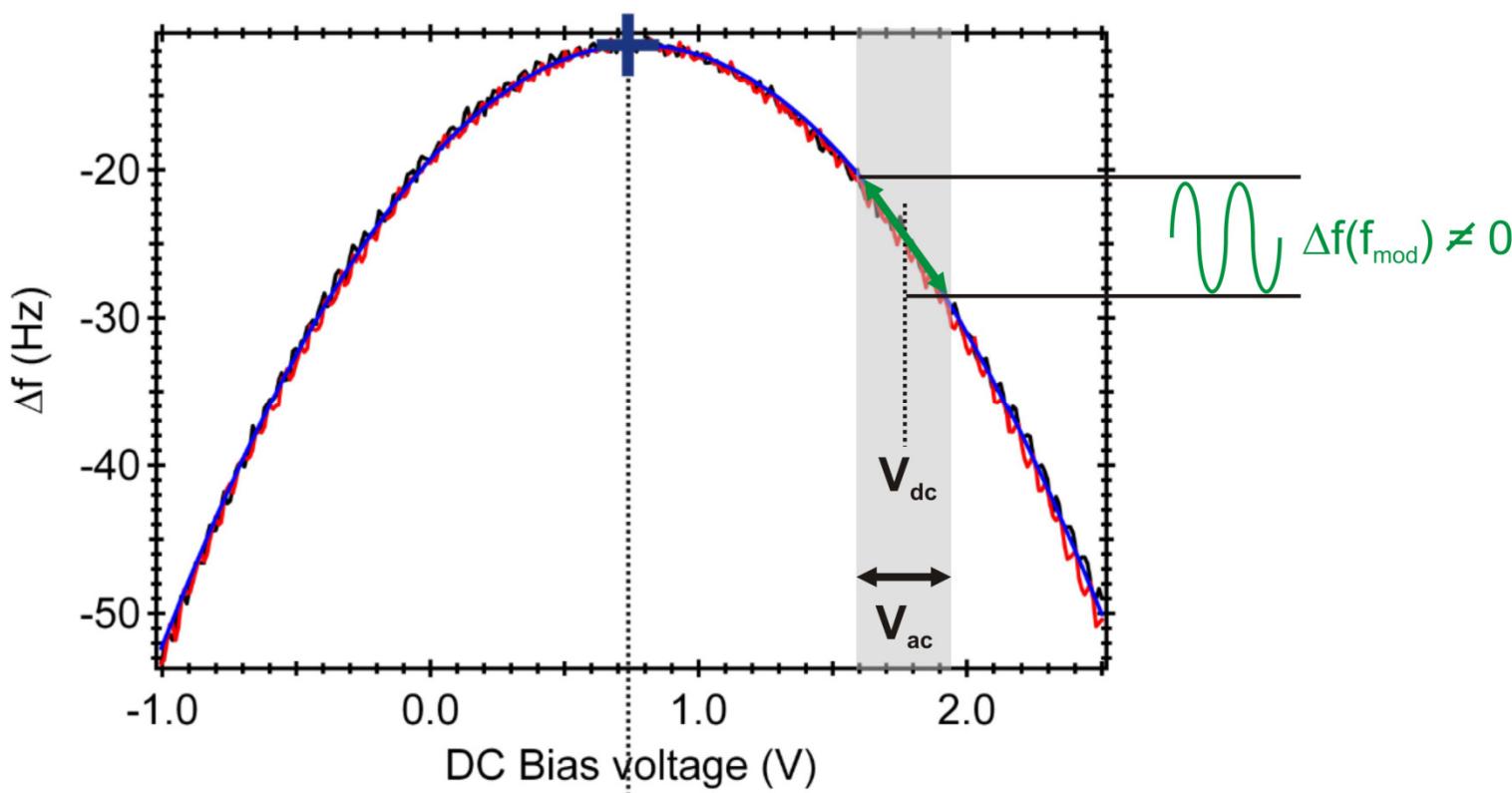
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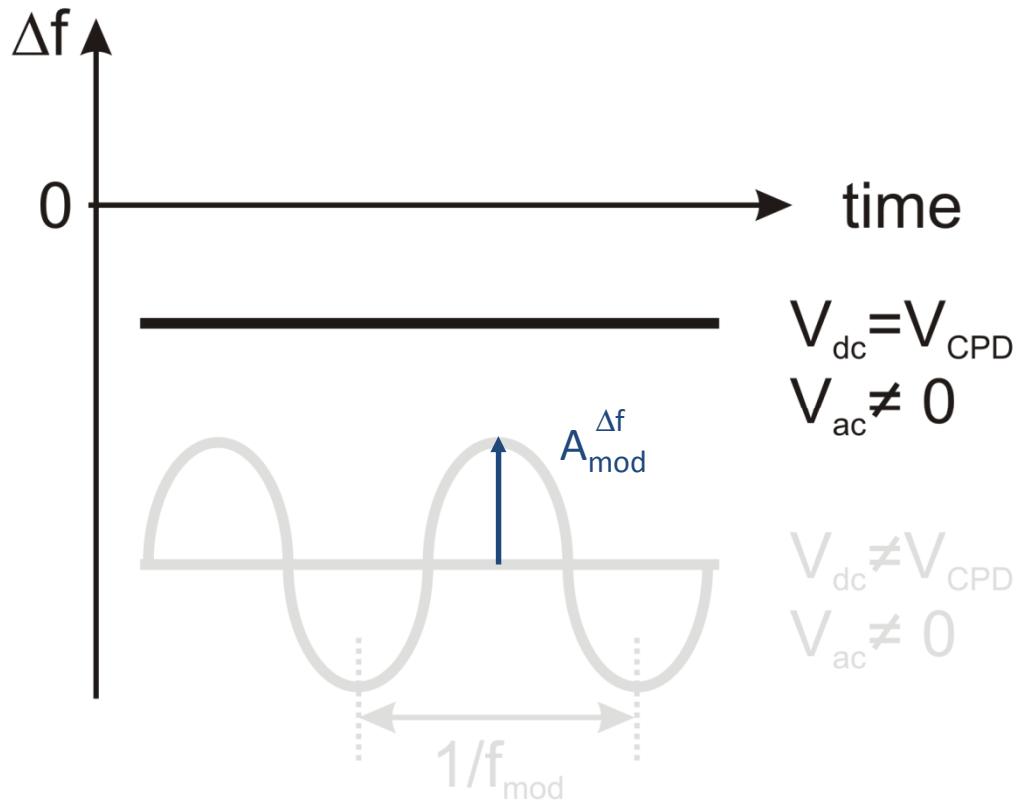
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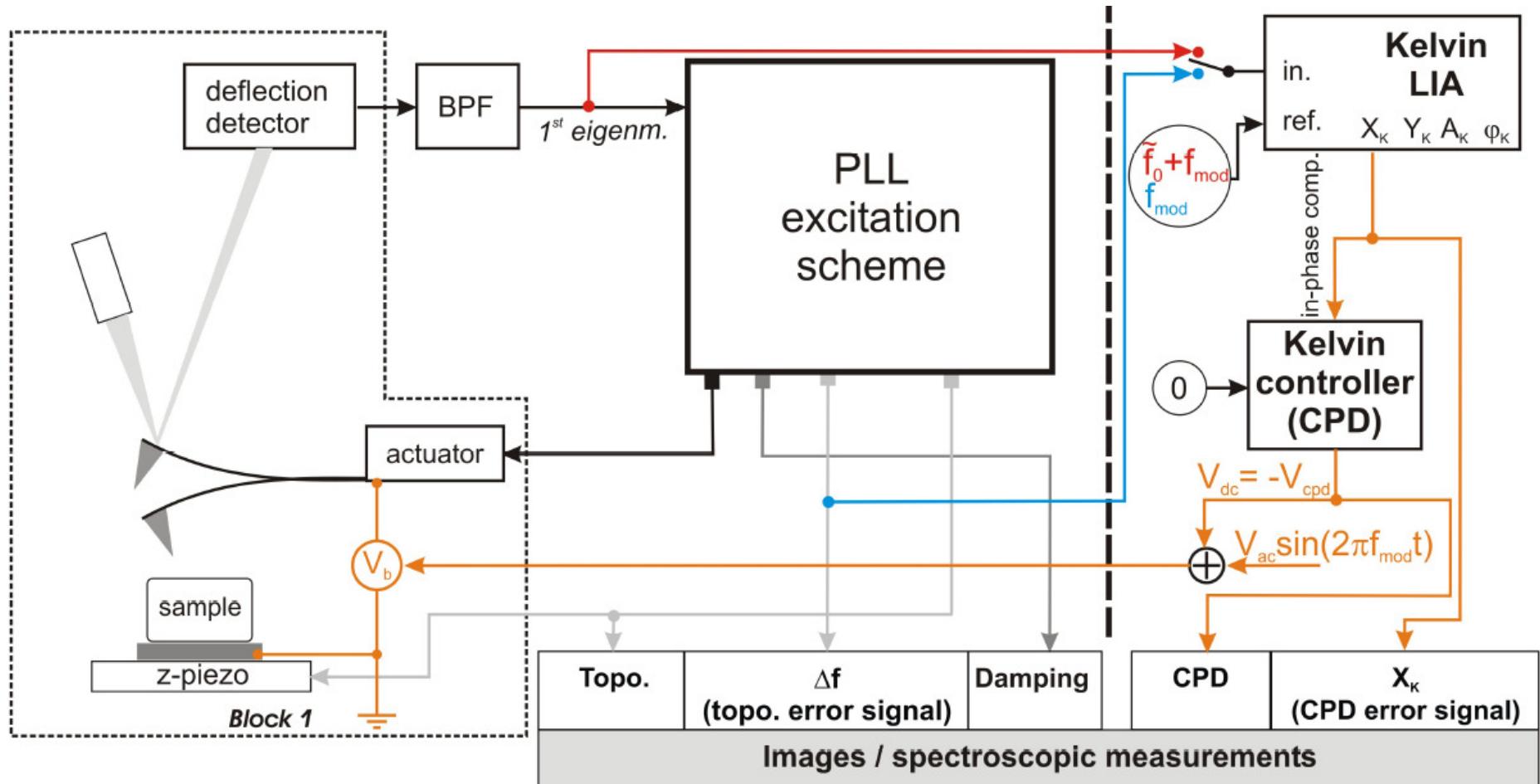


# Frequency-Modulation KPFM

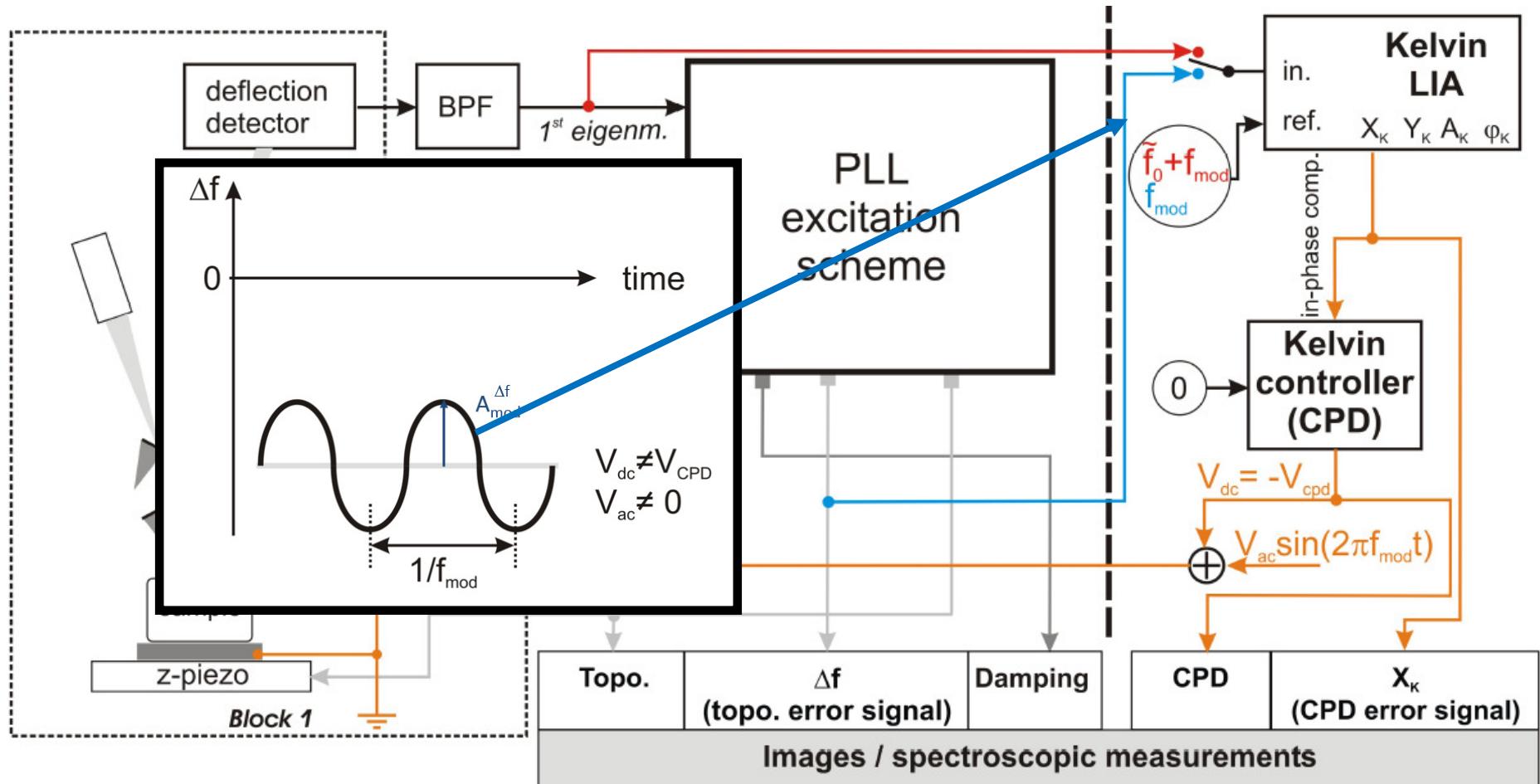


➡ Detecting & compensating  $A_{\text{mod}}^{\Delta f}$  by setting  
 $V_{\text{dc}} = V_{\text{CPD}}$  continuously while scanning

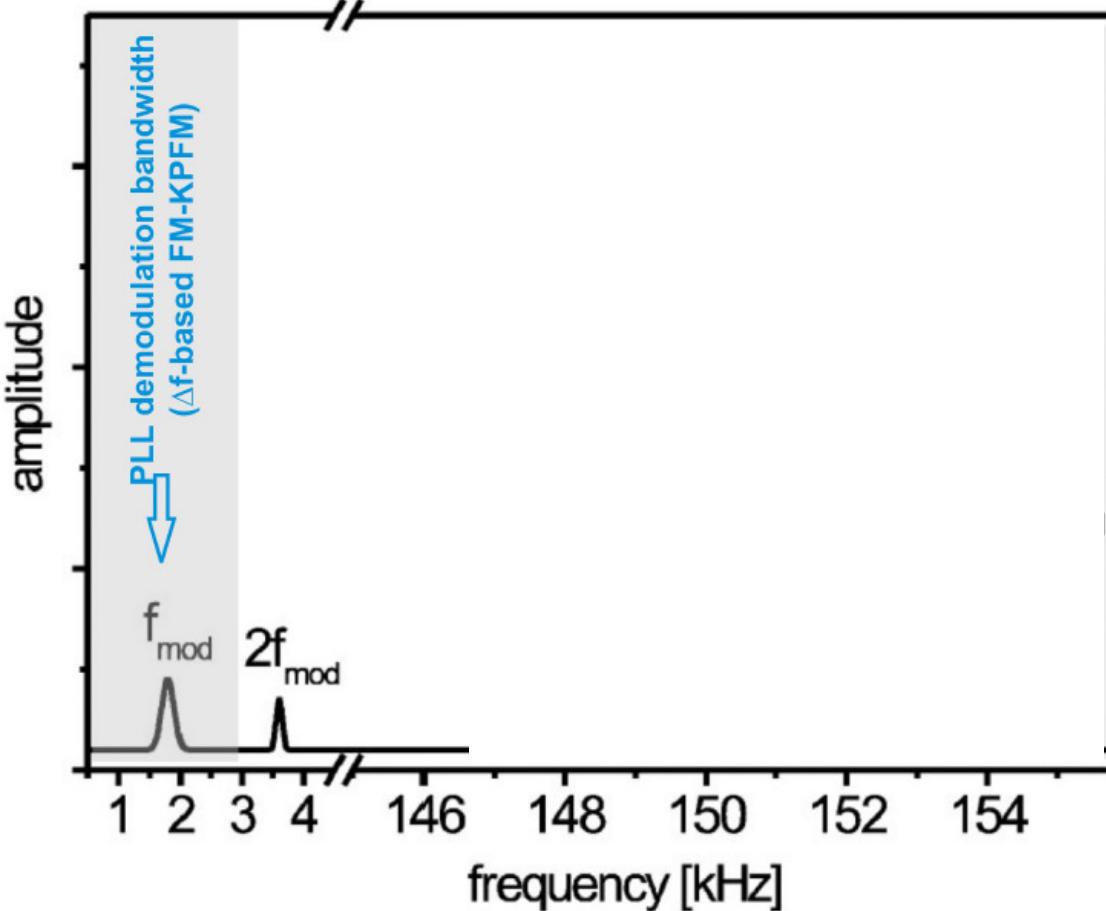
# Frequency-Modulation KPFM: experimental setup



# Frequency-Modulation KPFM: experimental setup

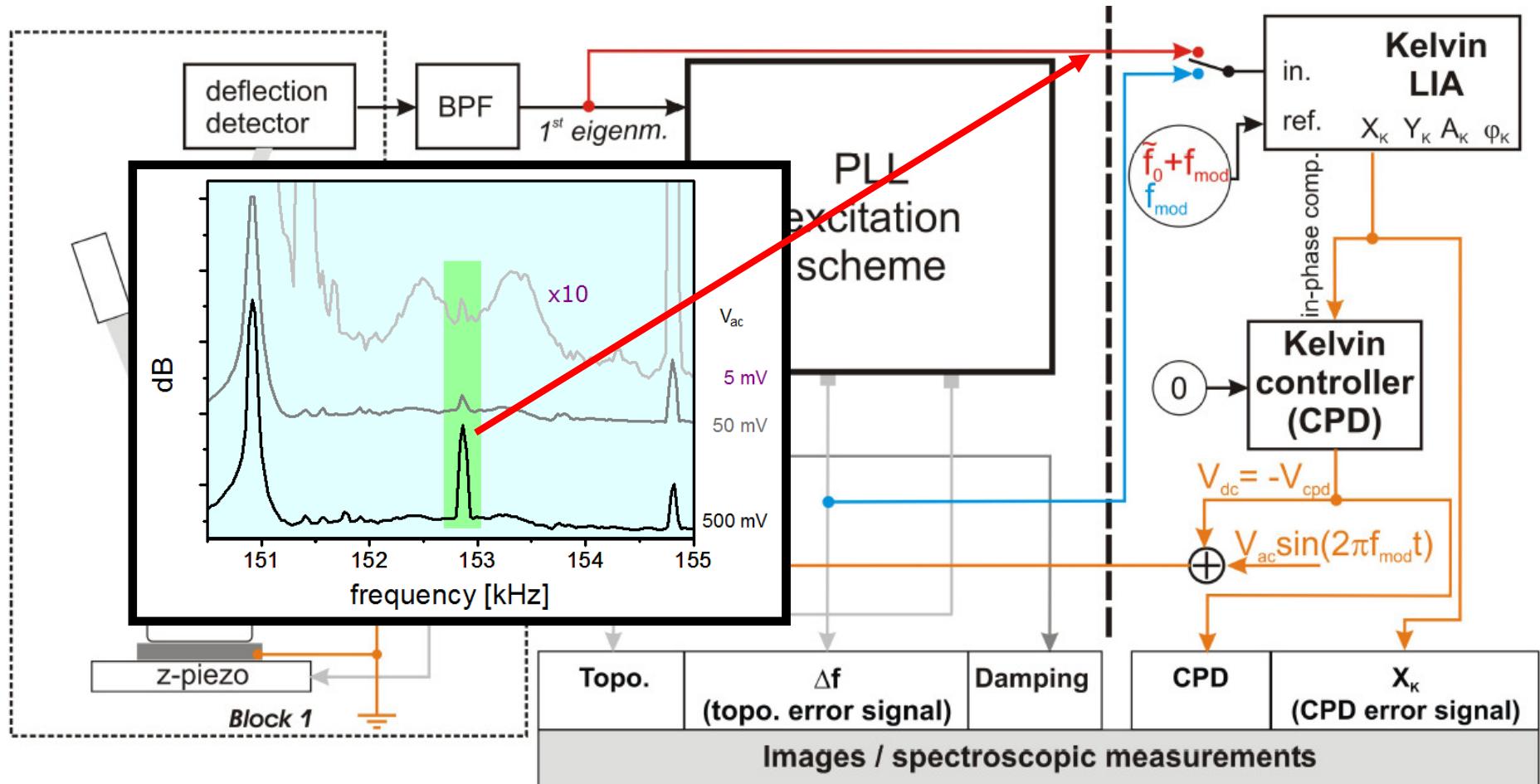


# Frequency-Modulation KPFM: temporal considerations

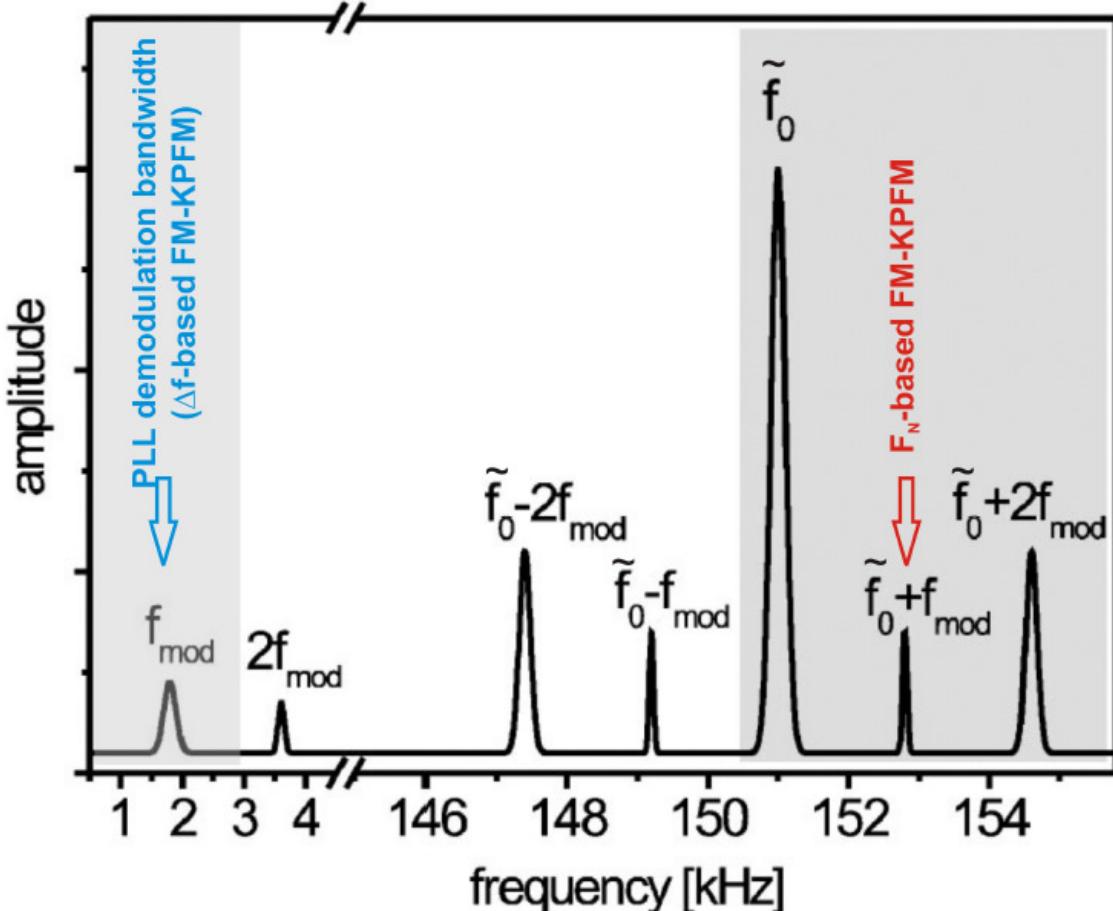


- $f_{mod}$  has to be within the demodulation bandwidth of the PLL → compromise:
  - extending the PLL bandwidth → adds noise to  $\Delta f$  detection
  - must remain large enough to not influence the z regulation (usually requires to slow down the scans)
  - order of magnitude: 1 kHz

# Frequency-Modulation KPFM: experimental setup



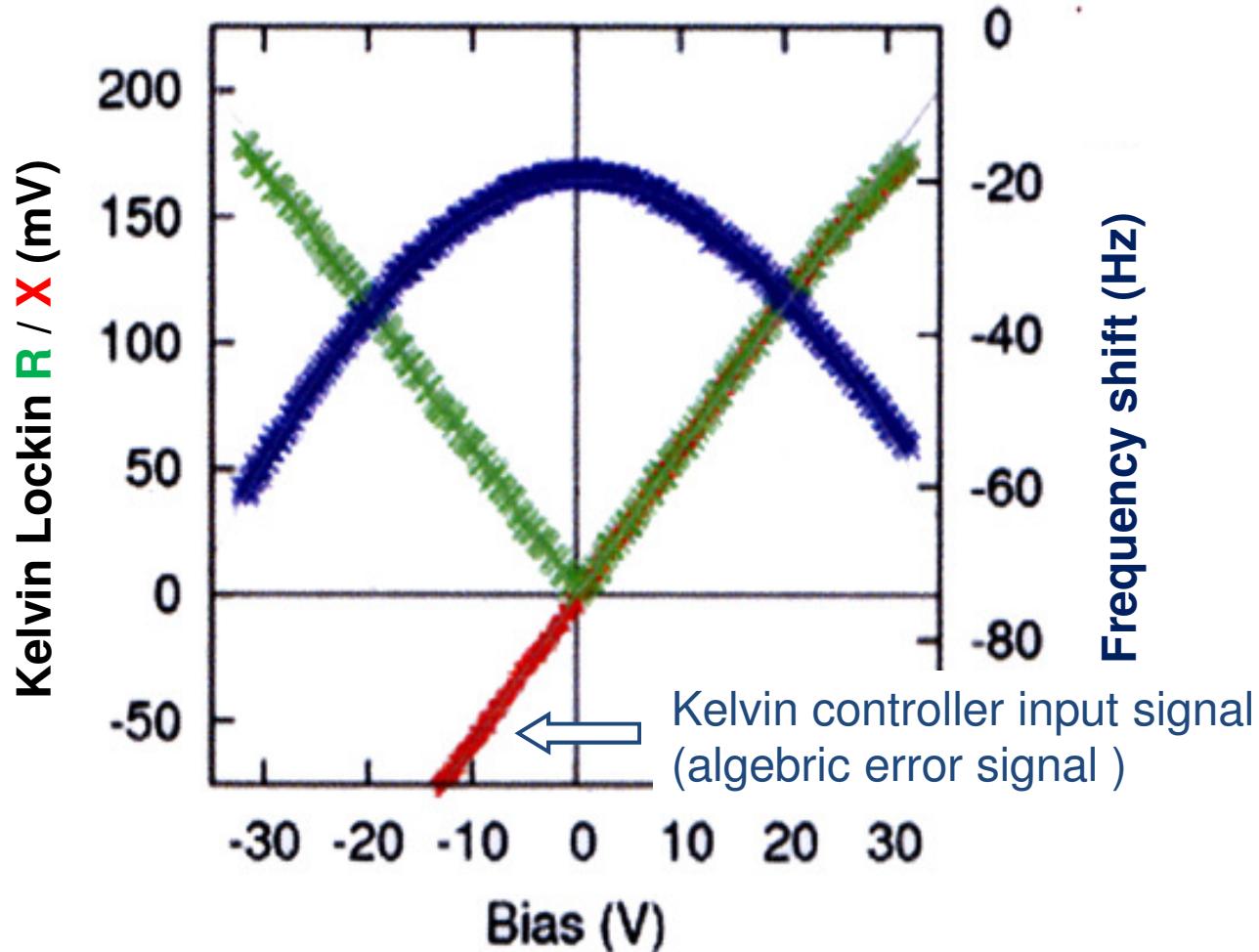
# Frequency-Modulation KPFM: temporal considerations



- ❑  $f_{mod}$  has to be within the demodulation bandwidth of the PLL → compromise:
  - extending the PLL bandwidth → adds noise to  $\Delta f$  detection
  - must remain large enough to not influence the z regulation (usually requires to slow down the scans)
  - order of magnitude: 1 kHz
  
- ❑ To avoid this, the oscillating component may be used ( $f_0 + f_{mod}$ ) as the Kelvin LIA input, but then the signal is to be amplified significantly for a proper detection

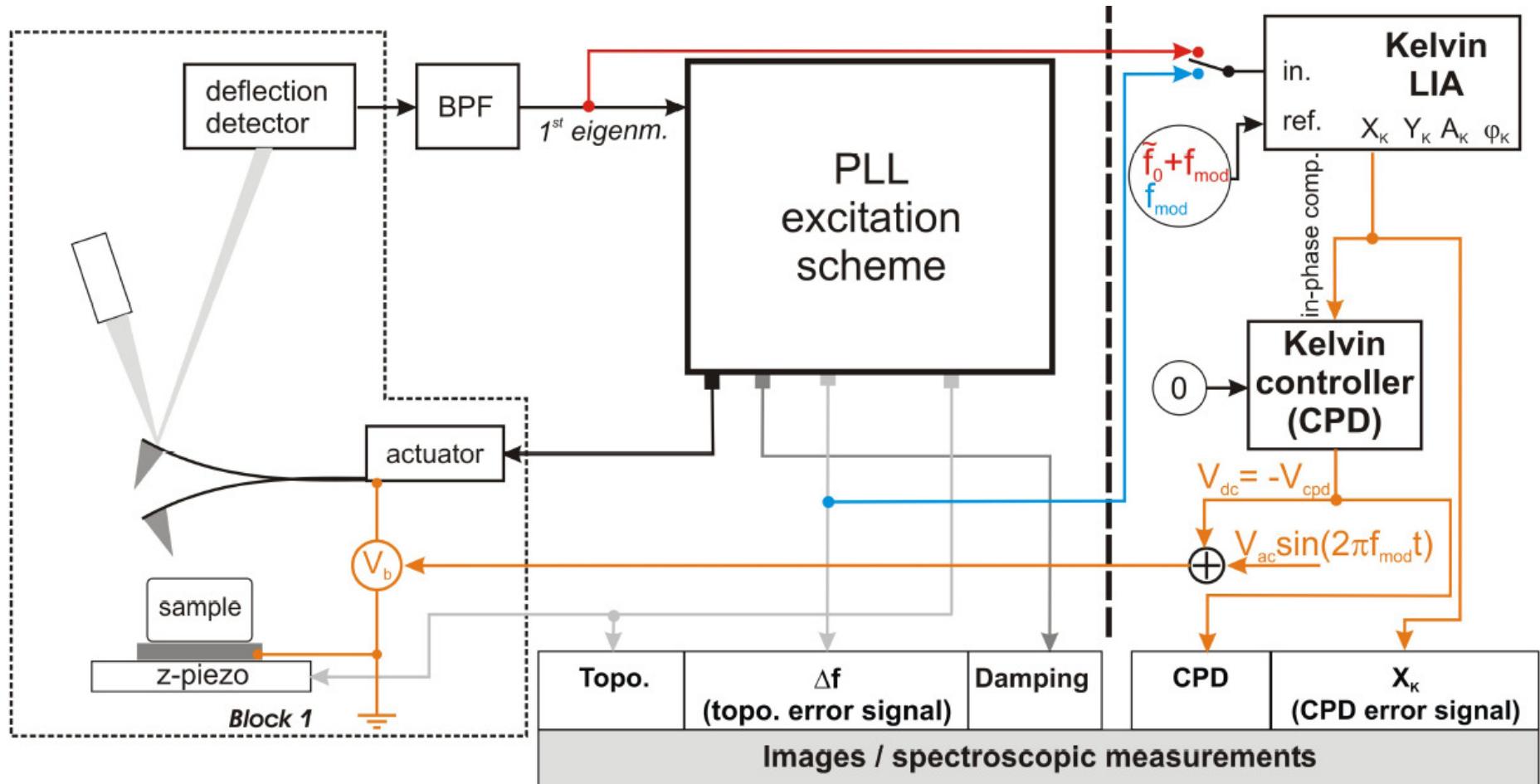
# Frequency-Modulation KPFM: experimental setup

- Data from Th. Glatzel (E.Meyer's group, Basel) in [1]:



<sup>1</sup>Kelvin Probe Force Microscopy, Measuring & Compensating Electrostatic forces, Springer Series in Surface Sciences (Th. Glatzel & S. Sadewasser Ed.)

# Frequency-Modulation KPFM: experimental setup



## Summary of that section...

- $\Delta f$  vs  $V_{bias}^{dc}$  curves give a dc potential value (maximum of the parabola) that relates to the sample's CPD, actually not only concealing the CPD of the bulk material, but information about local charges, dipoles,..., as well
- FM-KPFM is a method where  $\mathbf{F}^{el}$ , hence  $\Delta f$ , is modulated by the electrostatic force owing to the bias modulation ( $f_{mod}$ )
- The  $f_{mod}$  spectral component of  $\Delta f$  is detected as the X component of the LIA (algebraic signal required)
- The PI controller supplies the proper dc bias that cancels that component, that is the « CPD »

# III. Electrostatic models



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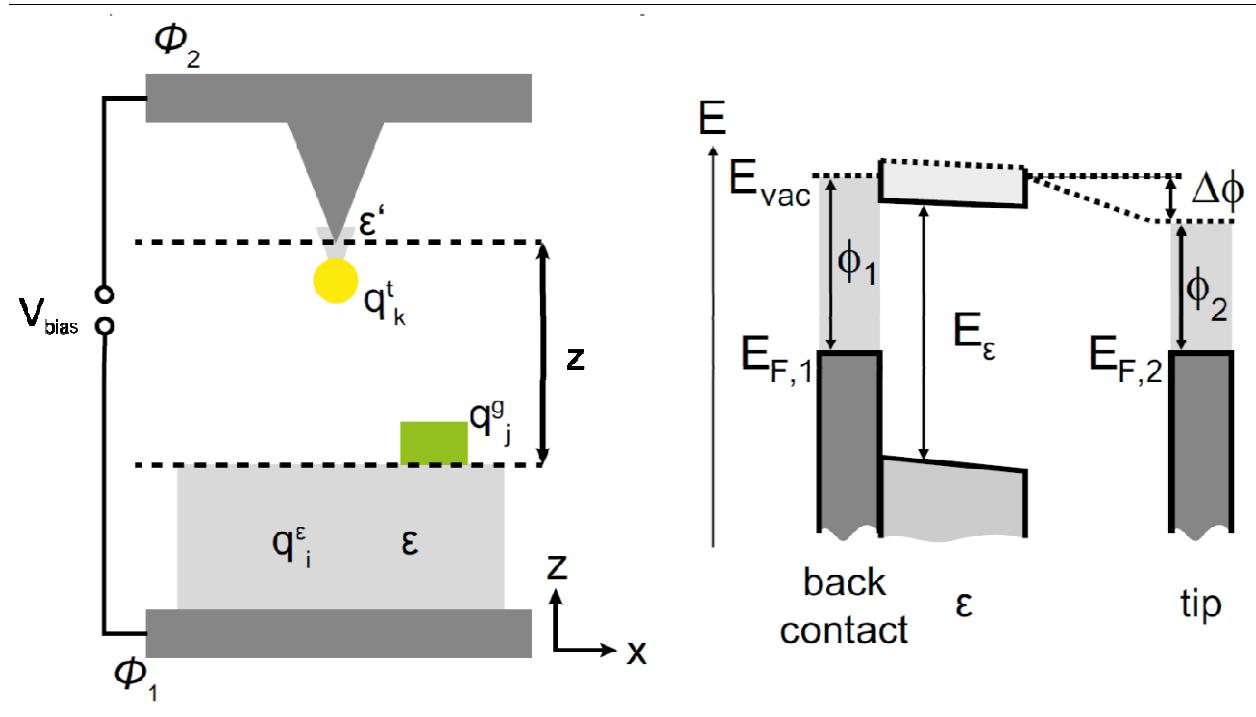


POLYTECH  
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# Generic approach to FeI

- Electrostatic energy of an ensemble of point charges inside a capacitor<sup>1</sup>:



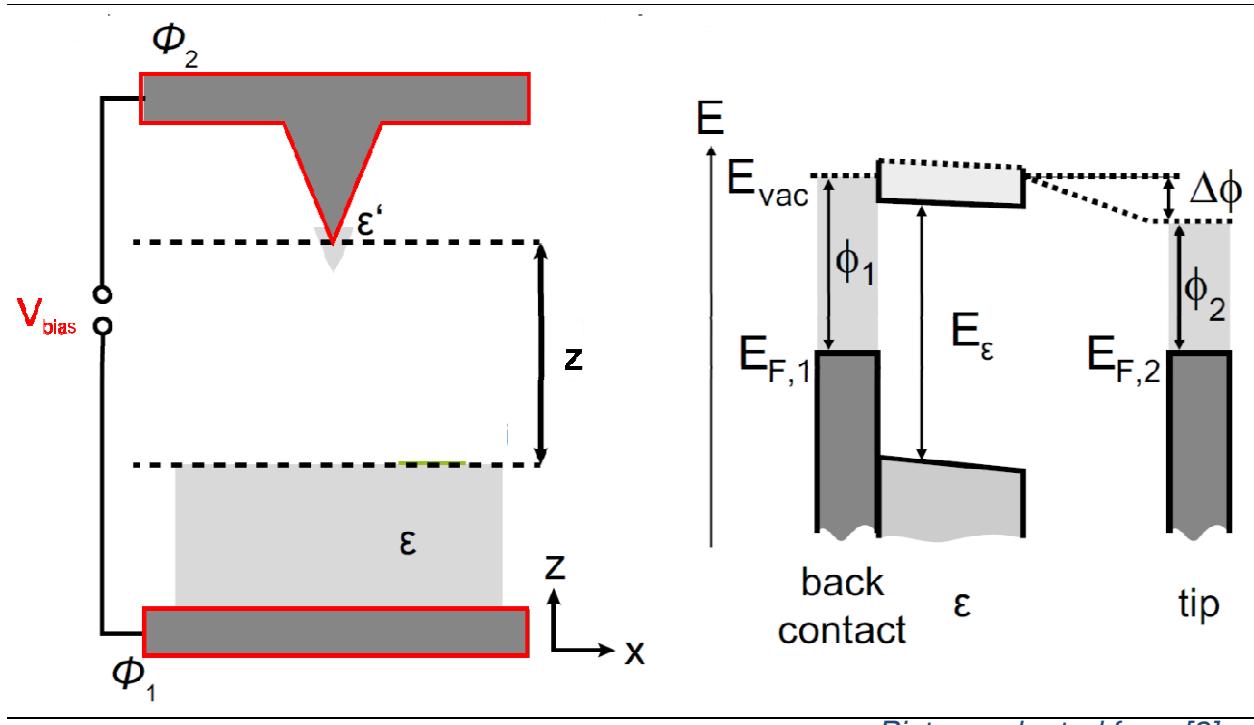
$$W^{\text{el}} = -\frac{1}{2}C^{(0)}V_{\text{bias}}^2 + \sum_i q_i \phi^{(0)}(\mathbf{r}_i) + \frac{1}{2} \sum_i q_i \phi_{\text{im}}(\mathbf{r}_i) + W_{\text{Coulomb}} \quad (\text{Eq. 13})$$

<sup>1</sup> L. Kantorovich et al., *J. Phys. Cond. Mat.* 12, 795 (2000); L. Kantorovich et al. *Surf. Sci.* 445, 283 (2000)

<sup>2</sup> J.L. Neff, P. Rahe, *Phys. Rev. B* 91, 085424 (2015)

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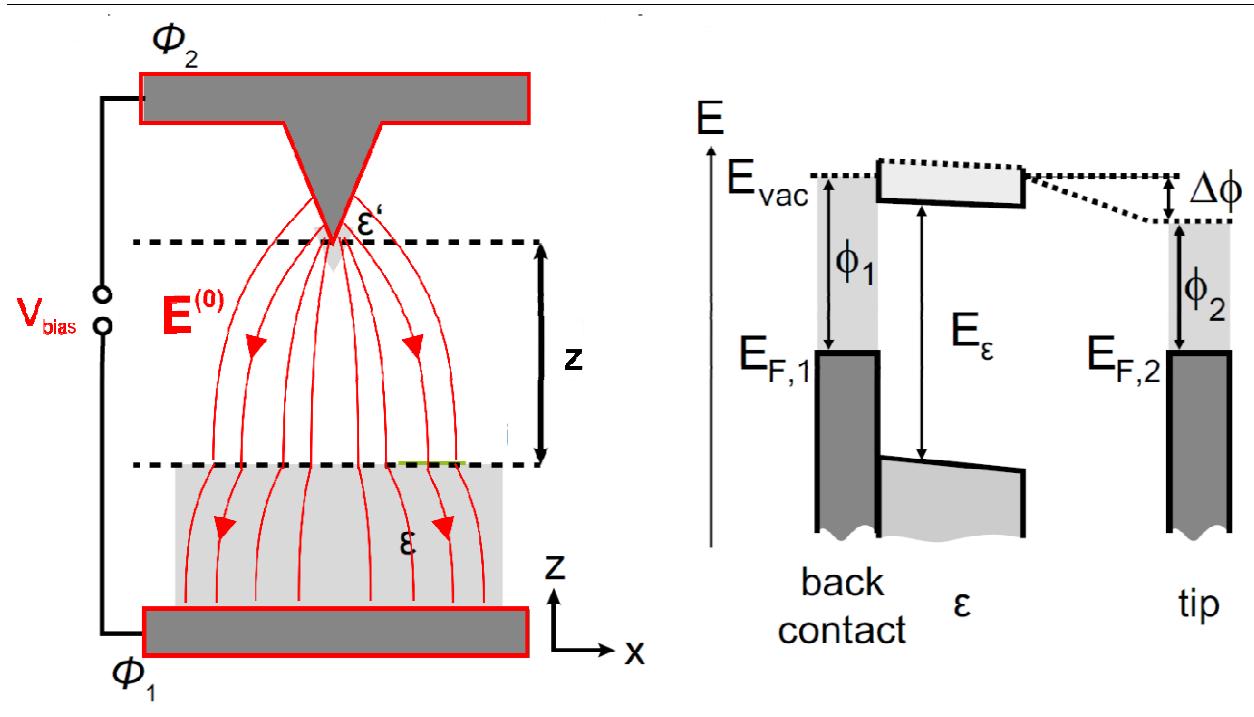
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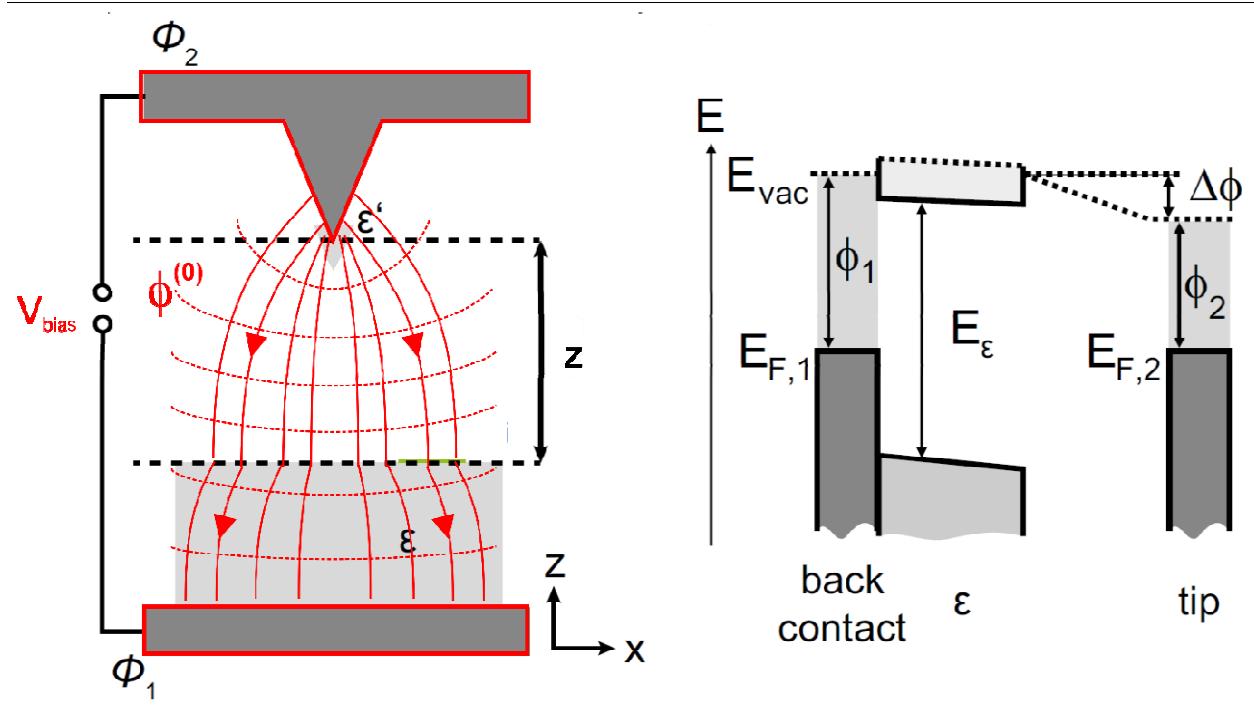
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Picture adapted from [2]

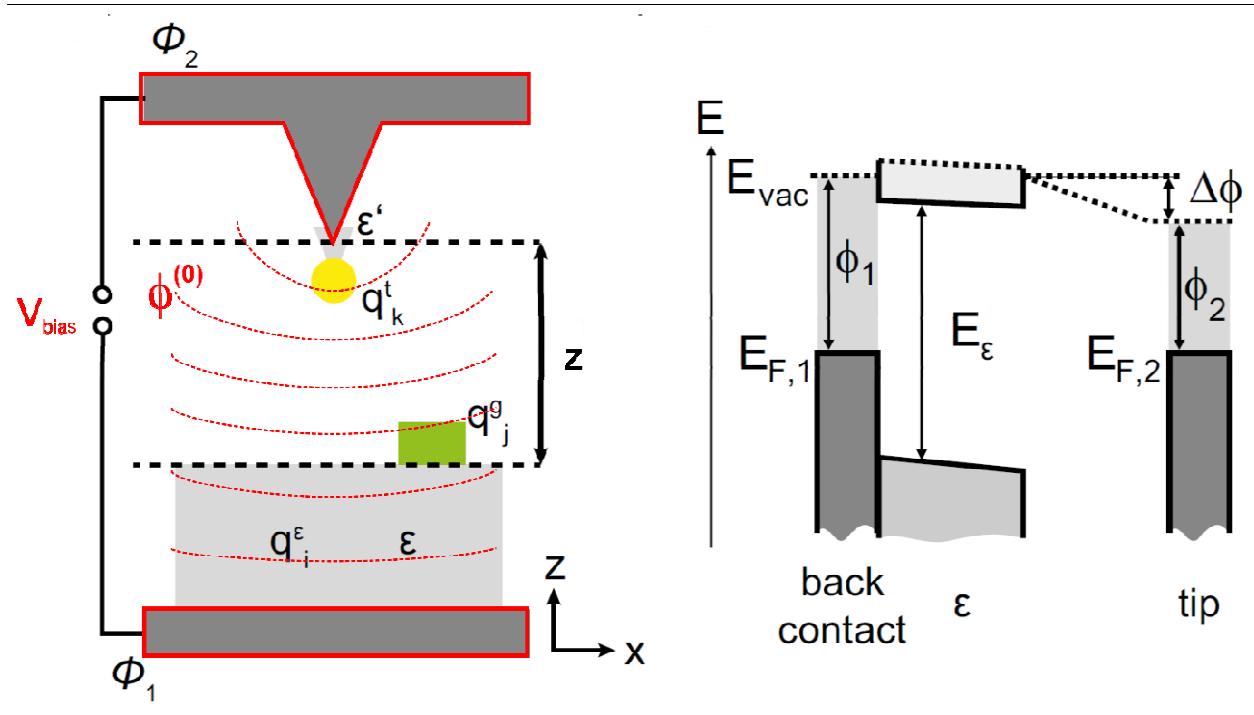
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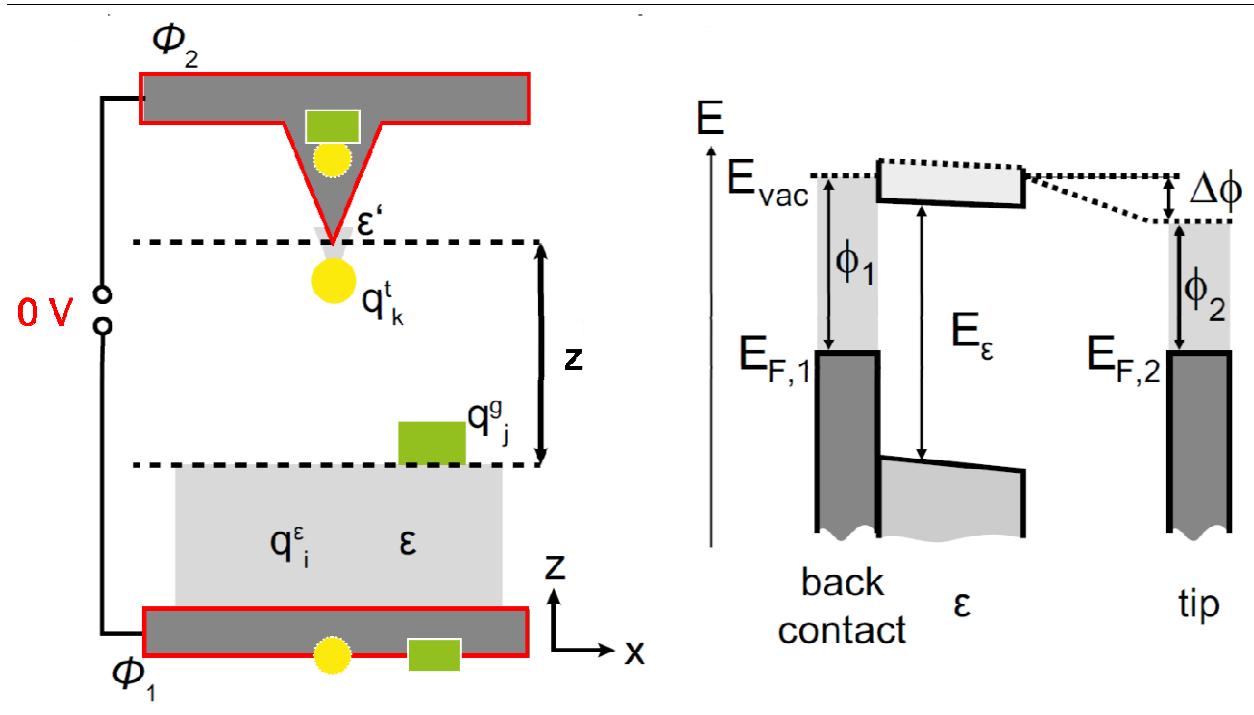
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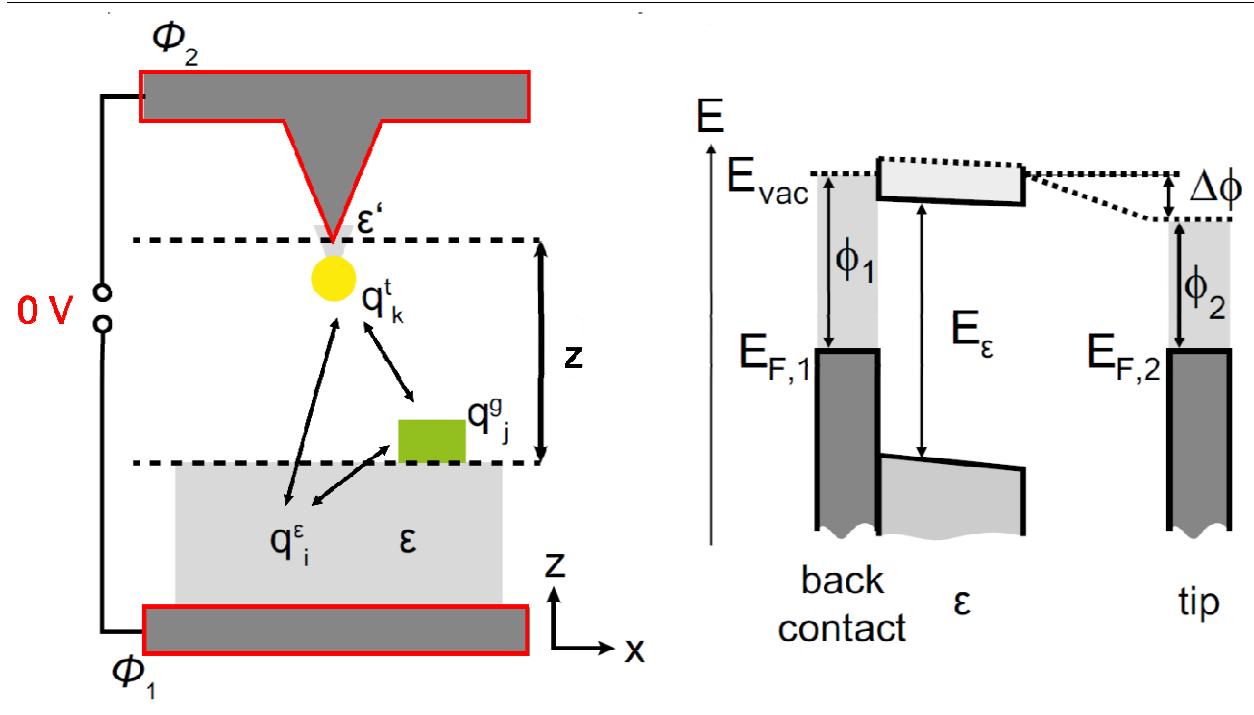
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# Generic approach to FeI

$$\vec{F}_{\text{tot}} = \vec{F}_{\text{LR}} + \vec{F}_{\text{SR}} = [\boxed{\vec{F}_{\text{LR}}^{\text{el}}} + \vec{F}_{\text{LR}}^{\text{vdW}}] + [\boxed{\vec{F}_{\text{SR}}^{\text{el}}} + \vec{F}_{\text{SR}}^{\text{vdW}}]$$

- $W^{\text{el}}$  requires to know the potential generated by the void capacitor upon biasing: **mesoscopic range (mm-nm)**
  - ✓ Usually: finite elements methods + Poisson equation or Green's formalism + boundary conditions
- Charges and dipoles yield *short-range electrostatic forces*: **microscopic range (nm-pm)**
  - ✓ Ab initio computational methods, or analytic methods

PHYSICAL REVIEW B 86, 075407 (2012)

## Multiscale approach for simulations of Kelvin probe force microscopy with atomic resolution

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PHYSICAL REVIEW B 91, 085424 (2015)

## Insights into Kelvin probe force microscopy data of insulator-supported molecules

Julia L. Neff

*Institut für Physikalische Chemie, Johannes Gutenberg Universität Mainz, Duesbergweg 10-14, 55099 Mainz, Germany*

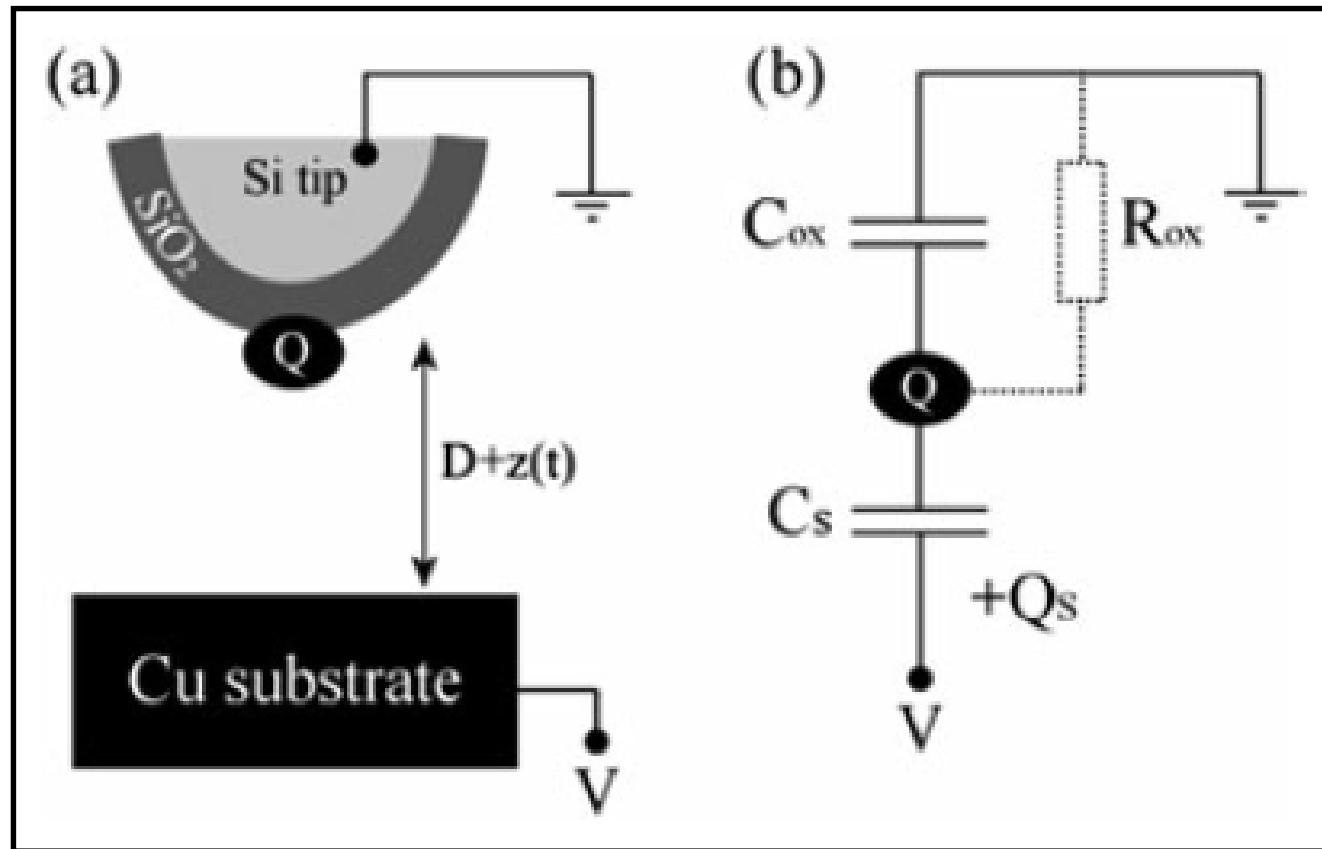
Philipp Rahe\*

*Department of Physics and Astronomy, The University of Utah, 115 South 1400 East, Salt Lake City, Utah 84112-0830, USA*

(Received 1 September 2014; revised manuscript received 28 January 2015; published 24 February 2015)

## Examples: 1- double capacitance model (mesoscopic model)

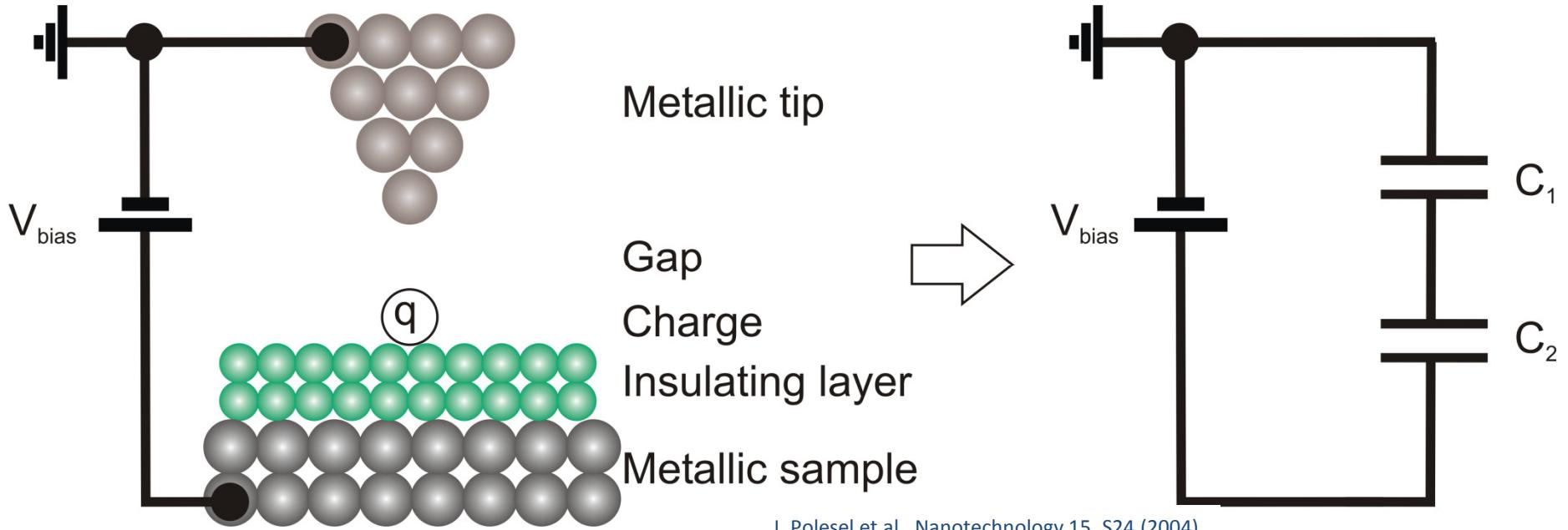
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J. Polesel et al., Nanotechnology 15, S24 (2004)

## Examples: 1- double capacitance model (mesoscopic model)

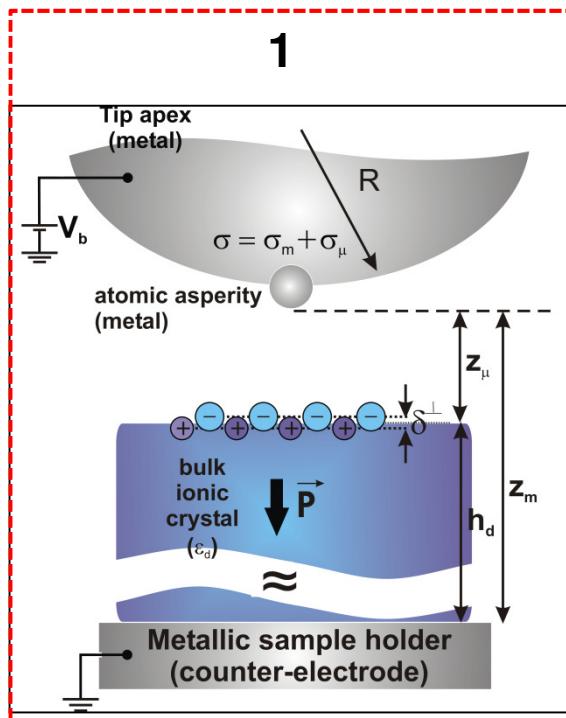
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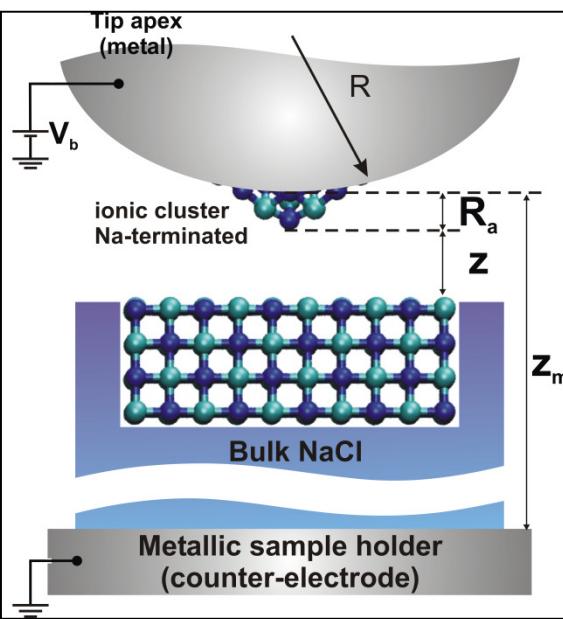
<sup>1</sup> *Nanoelectronics and Information Technology: Advanced Electronic Materials and Novel Devices*, edited by R. Waser (John Wiley & Sons, New York, 2003); R. Stomp et al., Phys. Rev. Lett. 94, 056802 (2005); J. Polesel et al., Nanotechnology 15, S24 (2004)

# Examples: 2- microscopic approach to $F_{el}$ : polarizability



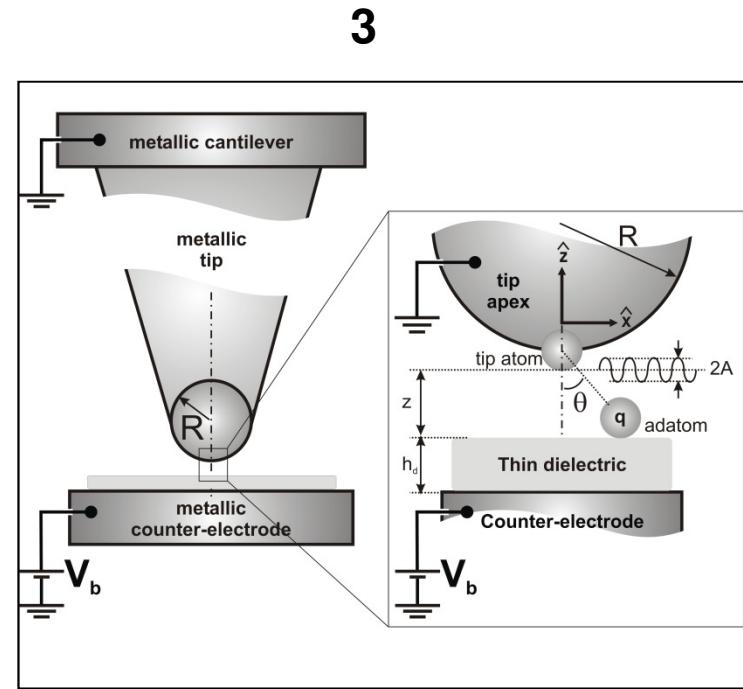
- Tip termination: metallic atomic asperity
- Sample: Bulk ionic crystal
- Analytical & Experimental approach

F.Bocquet et al., Phys. Rev. B **78**, 035410 (2008)  
 L.Nony et al., Nanotechnology **20**, 264014 (2009)



- Tip termination: ionic cluster (Na<sup>+</sup>-terminated)
- Sample: Bulk ionic crystal
- Fully numerical approach

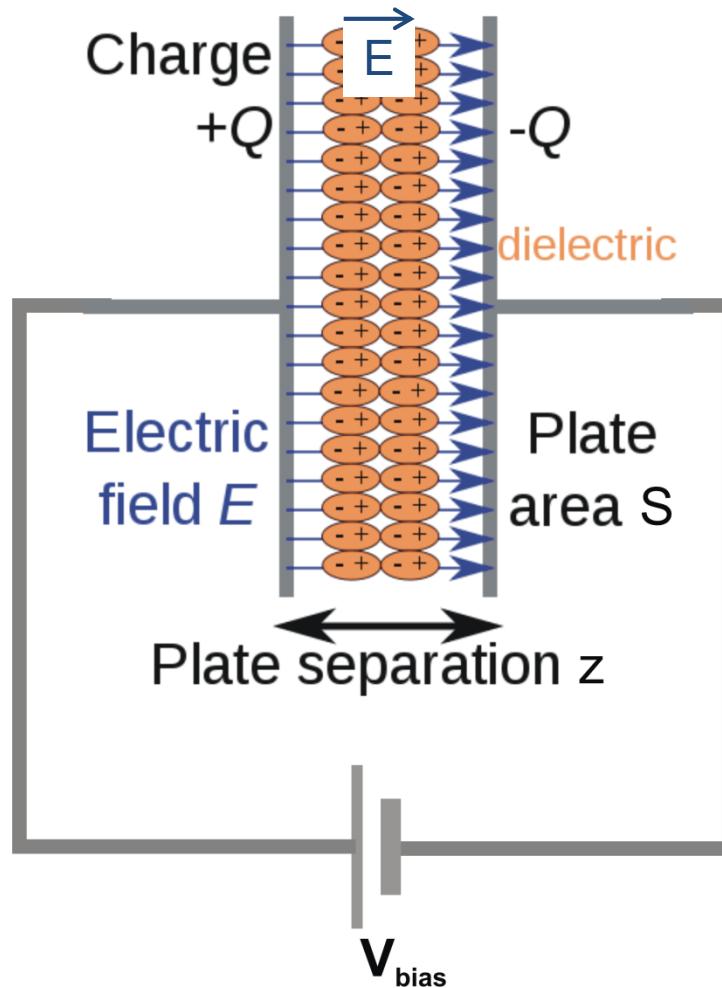
L.Nony et al., Phys. Rev. Lett. **103**, 036802 (2009)



- Tip termination: single metallic atom
- Sample: 2ML NaCl / Cu(111)
- Fully analytical approach

F.Bocquet et al., Phys. Rev. B **83**, 035411 (2011)  
 Based upon the work by L.Gross et al. Science **324**, 1428 (2009)

## Examples: 2- microscopic approach to $\mathbf{F}^{\text{el}}$ : polarizability



Dipole moment of each part of dielectric within the capacitance:

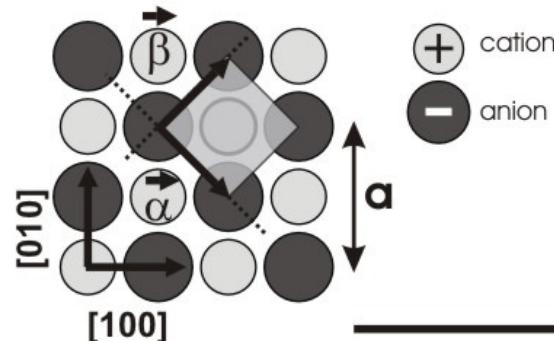
polarizability

$$\vec{p} = \alpha \epsilon_0 \vec{E}$$

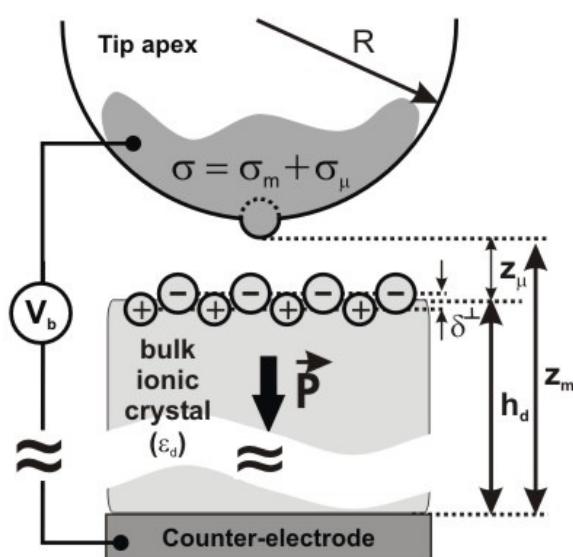
# Examples: 2- microscopic approach to $F^{\text{el}}$ : polarizability

Interaction force :  $F(z) = F_{lr}(z) + F_{es}(z) + F_{sr}(z)$  with  $F_{\text{es}} = \int_{\text{tip}} \frac{\sigma^2}{2\epsilon_0} \hat{n} \cdot \hat{u}_z dS$

Building the analytic approach to  $F_{\text{es}}$ :



- Crystal surface has a perfect fcc structure, carrying **neither local charge nor dipole**
- The **Madelung potential expands at the surface<sup>2</sup>**, although decaying exponentially fast

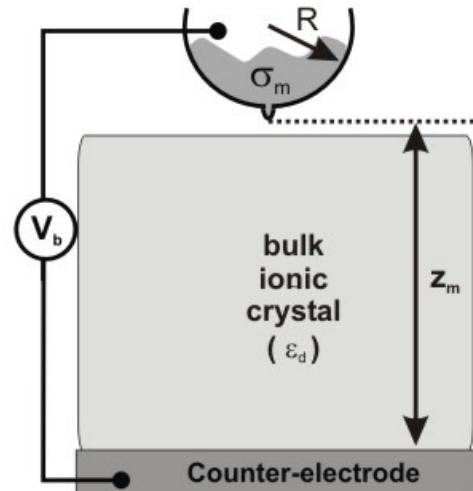
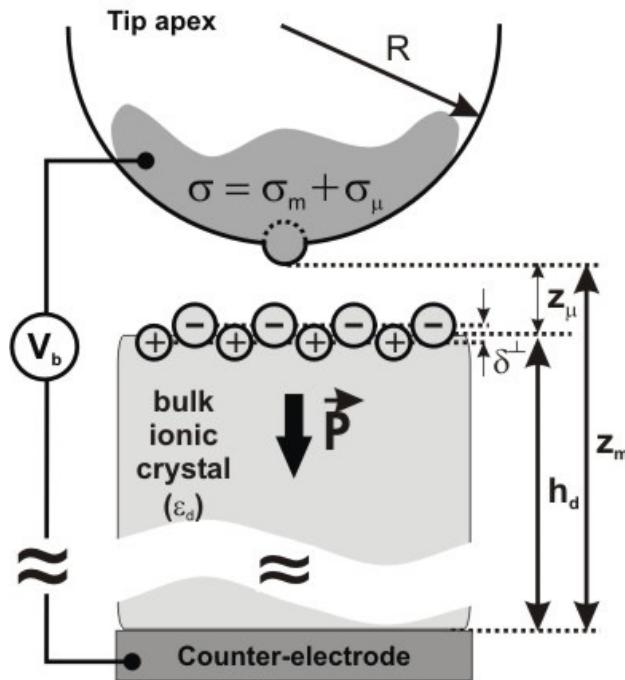


- Tip apex:** microscopic structure (nano-asperity, area 1, radius  $R_a$ ) + mesoscopic half-sphere (area 2, radius  $R$ ): **METALLIC**
- Sample:** topmost infinite layer of alternate point charges + bulk treated as a continuous medium
- Surface charge density that develops on the tip has 2 origins:
  - ☞ **capacitive contribution (mesoscopic):**  $\sigma_m$ , connected with  $V_b$
  - ☞ **Madelung surface potential-mediated contribution (microsc.):**  $\sigma_\mu$
- Description of the ionic polarization of the sample , self-consistency**
- Classical approach

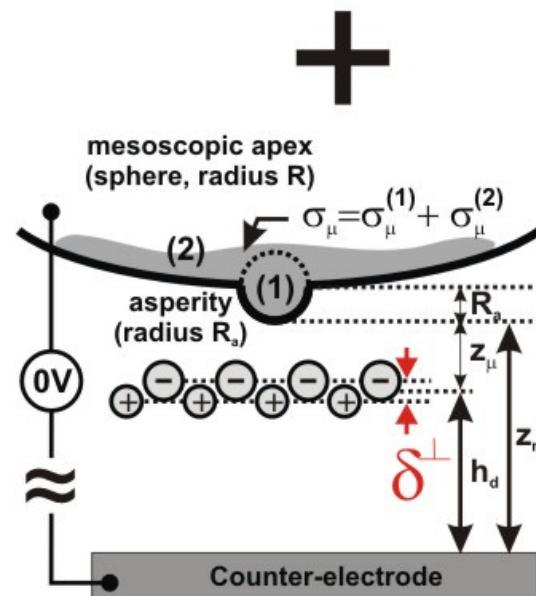
<sup>1</sup>F. Bocquet *et al.*, Phys. Rev. B **78**, 035410 (2008); <sup>2</sup>R.Watson *et al.*, Phys. Rev. B **24**, 1791 (1981)

# Examples: 2- microscopic approach to $F^{el}$ : polarizability

Superposition principle :



Mesoscopic problem ( $\sigma_m$ )



Microscopic problem ( $\sigma_\mu$ )

# Examples: 2- microscopic approach to $F^{\text{el}}$ : polarizability

Madelung surface potential<sup>1</sup>:

$$V_s(x, y, z_\mu) = -\frac{q}{\pi \epsilon_0 a'} \cosh[\tilde{\delta}^\perp(V_b)] \tilde{\chi}(x, y) e^{-(2\pi/a')z_\mu}$$

Polarization, i.e. Bias dependence

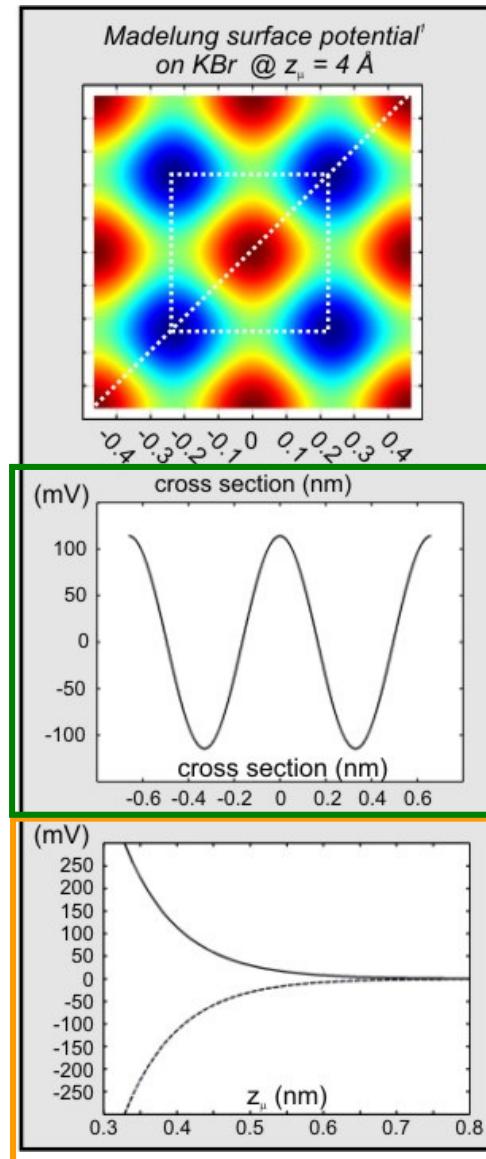
Lateral periodicity (in plane)

$$\tilde{\chi}(x, y) = \cos\left[\frac{2\pi}{a'}(x - x_0)\right] + \cos\left[\frac{2\pi}{a'}(y - y_0)\right]$$

Distance dependence

"...when considering an infinite planar slab of point charges, the Madelung surface potential reaches its asymptotic value in a very short distance normal to the slab. Consequently, the ions within the crystal at a distance only one lattice constant from the surface have Madelung potentials, which are indistinguishable from those of the bulk."

<sup>1</sup> R.Watson et al., Phys. Rev. B **24**, 1791 (1981)



## Examples: 2- microscopic approach to $\mathbf{F}^{\text{el}}$ : polarizability

$$F_{es} = \int_{\text{tip}} \frac{(\sigma_m + \sigma_\mu)^2}{2\epsilon_0} \hat{n} \cdot \hat{u}_z dS = F_m + \boxed{F_{m\mu}} + \boxed{F_\mu}$$

- ☞  $\mathbf{F}_m$  : negligible (counter-electrode too far)
- ☞  $\mathbf{F}_{m\mu}^{(2)}$  : capacitive coupling on the mesoscopic part of the tip decays fast; negligible compared to  $\mathbf{F}_{m\mu}^{(1)}$ ; tip enhancement effect
- ☞  $\mathbf{F}_\mu^{(1)}$  : negligible compared to  $\mathbf{F}_\mu^{(2)}$  (not obvious, geometry dependent)

$$F_{es} = \boxed{F_{m\mu}^{(1)}} + \boxed{F_\mu^{(2)}}$$

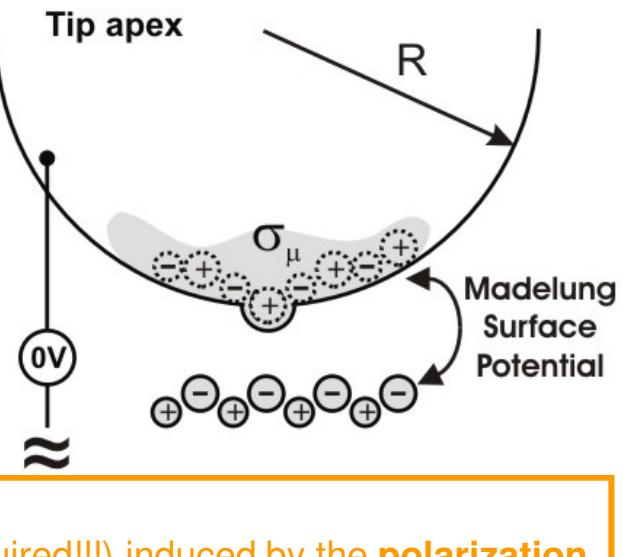
- short-range
- Lateral periodicity of the MSP
- Proportional to  $V_b$

- short-range
- $V_b^2$  dependence (required!!!) induced by the **polarization**
- No lateral periodicity

$$F_{es}(V_b) = \boxed{B \times V_b \exp \left\{ -\frac{2\pi}{a'} z_\mu \right\} \times [\cos(\tilde{x}_0) + \cos(\tilde{y}_0)]} + \boxed{(AV_b^2 + C) \times \exp \left\{ -\frac{4\pi}{a'} z_\mu \right\}}$$

with  $V_b = V_{dc} + V_{ac} \sin(2\pi f_K t)$

**short-range electrostatic force**

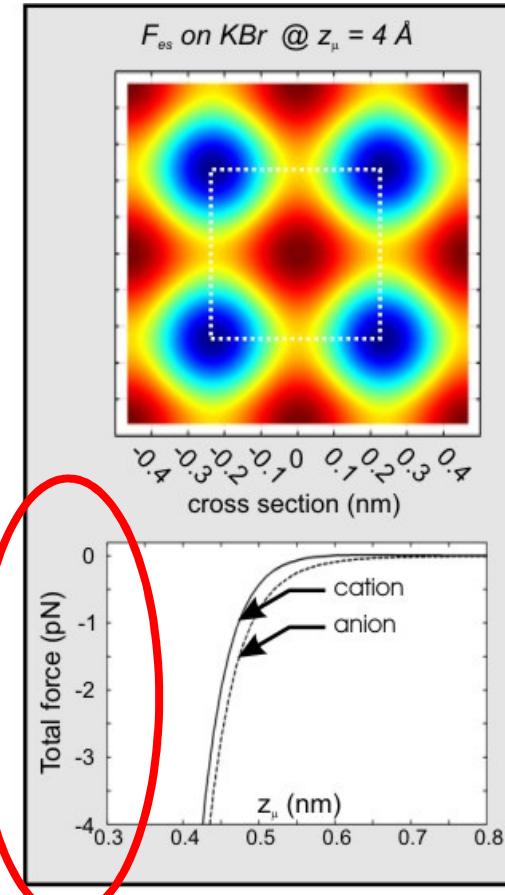


## Examples: 2- microscopic approach to $\mathbf{F}^{\text{el}}$ : polarizability

$$F_{es} = \int_{\text{tip}} \frac{(\sigma_m + \sigma_\mu)^2}{2\epsilon_0} \hat{n} \cdot \hat{u}_z dS = F_m + F_{m\mu} + F_\mu$$

- ☞  $\mathbf{F}_m$  : negligible (counter-electrode too far)
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$$F_{es}(V_b) = B \times V_b \exp \left\{ -\frac{2\pi}{a'} z_\mu \right\} \times [\cos(\tilde{x}_0) + \cos(\tilde{y}_0)] + (AV_b^2 + C) \times \exp \left\{ -\frac{4\pi}{a'} z_\mu \right\}$$

with  $V_b = V_{dc} + V_{ac} \sin(2\pi f_K t)$

**short-range electrostatic force** (Eq. 15)

## Summary of the section...

- The quantitative interpretation of the KPFM signal requires sophisticated multiscale approaches: mesoscopic range (CPD), microscopic range (charges, dipoles, polarization effects...)
- Due to charges, dipoles, polarization effects,..., the electrostatic force is a function of the bias with the form:

$$F^{\text{el}} = AV_{\text{bias}}^2 + BV_{\text{bias}} + C$$

- Hence, the  $f_{\text{mod}}$ -modulated component has the form:

$$F^{\text{el}, f_{\text{mod}}} = [B + 2A(V_{\text{dc}} - V_{\text{CPD}})] V_{\text{ac}} \sin(2\pi f_{\text{mod}} t)$$

- Therefore:

$$V_{\text{dc}} = V_{\text{CPD}} - \frac{B}{2A}$$

- ✓ The measured « CPD » conceals the physics of the interface (parameters A & B): charges, dipoles, polarization effects...
- ✓ B and A are **tip geometry- and distance-dependent**...
- ✓ Extracting quantitative parameters (number of charges...) requires the void capacitor to be perfectly characterized

# Summary of the section...

- The quantitative interpretation of the KPFM signal requires sophisticated multiscale approaches: mesoscopic range (CPD), microscopic range (charges, dipoles, polarization effects...)
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- Therefore:

$$V_{\text{dc}} = V_{\text{CPD}} - \frac{B}{2A}$$

$$V_{\text{DC}}^{(\text{c})} = V_{\text{cpd}} - \frac{C_1 a_1 e^{-\alpha z_{\min}}}{2C_2 b_1 e^{-2\alpha z_{\min}} + 4\pi C'_2 A_0 / z_M^3}$$

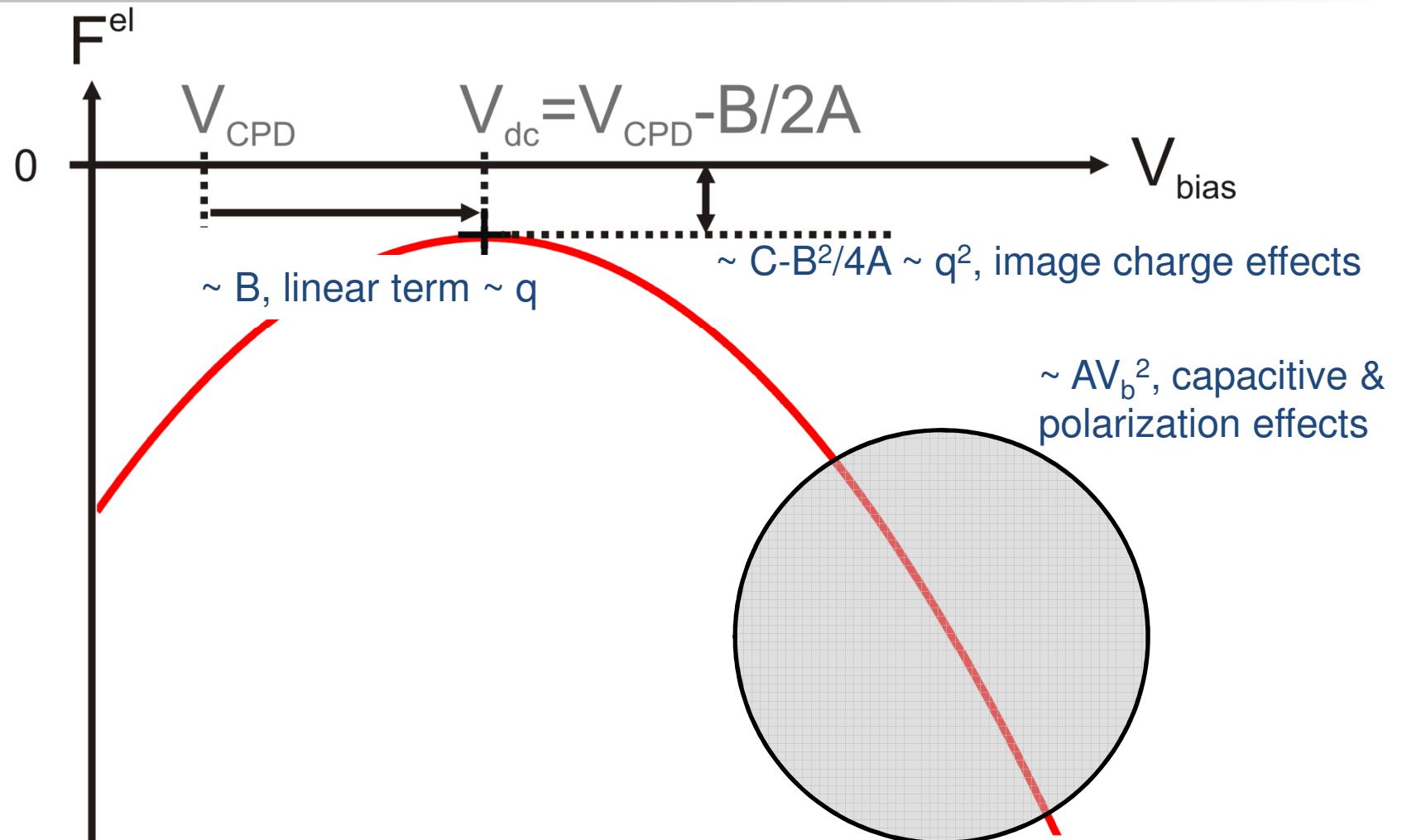
L.Nony et al., Nanotechnology 20, 264014 (2009)

$\Delta V_{\text{FM-KPFM}}$

$$= \frac{\Delta\phi}{e} + \frac{\sum_i q_i \int_{-A_0}^{A_0} \frac{\partial \tilde{\Phi}^{(0)}(\vec{r}_i)}{\partial d} \Big|_{d+A_0-\tau} \frac{\tau}{\sqrt{A_0^2 - \tau^2}} d\tau}{\int_{-A_0}^{A_0} \frac{\partial C^{(0)}}{\partial d} \Big|_{d+A_0-\tau} \frac{\tau}{\sqrt{A_0^2 - \tau^2}} d\tau}$$

J.Neff et al., PRB 91, 085434 (2015)

## Summary of the section...



## IV. Examples of applications

- Long-range regime
- Short-range regime



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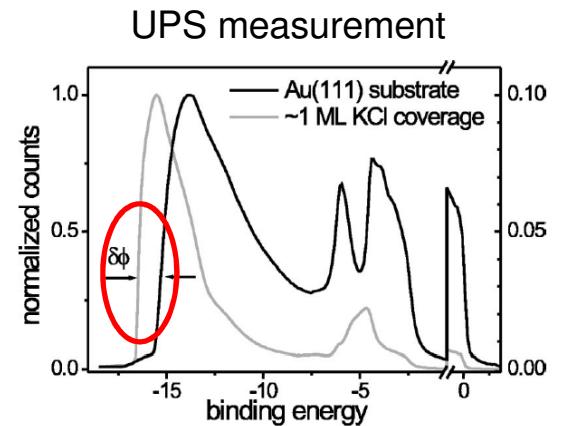
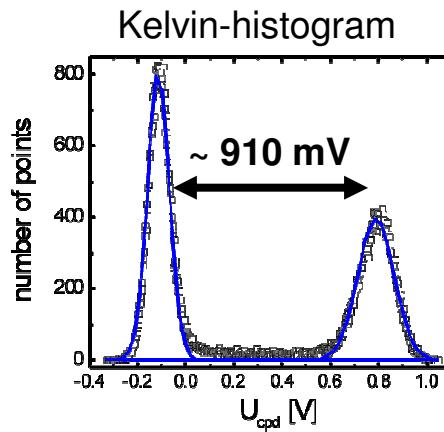
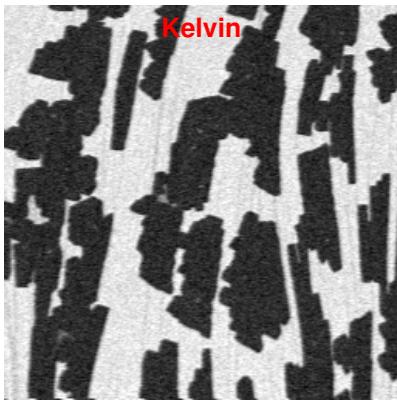
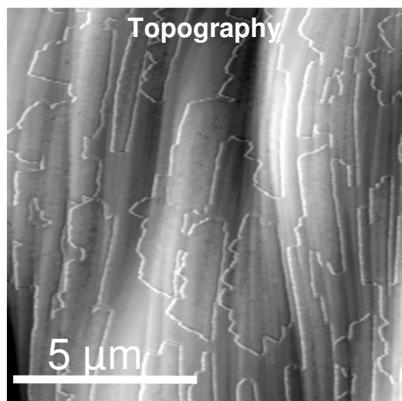
# Huge amount of published results about KPFM...

- B.D. Terris et al., Phys. Rev. Lett. **63**, 2669 (1989)
- H. Jacobs et al. J. Appl. Phys. **84**, 1168 (1998)
- J. Colchero et al. Phys. Rev. B **64**, 245403 (2001)
- A. Gil et al. Nanotechnology **14**, 332 (2003)
- Y. Azuma et al., Phys. Rev. Lett. **96**, 016108 (2006)
- K. Sajewicz et al. Jap. J. Appl. Phys. **49**, 025201 (2010).
- **IBM Zurich lab.:** L. Gross et al. Science **324** :1428–1431 (2009); F. Mohn et al. Nature Nanotechnology **7**(4), 227–231 (2012); B. Schuler et al. Nano Letters **14**, 3342-3346 (2014); F. Albrecht et al. Phys. Rev. B **92**, 235443 (2015) ...
- **C. Barth:** C. Barth et al., New J. Phys. **12**, 093024 (2010); B. Hoff et al., J. Phys. Chem. C **118**, 14569 (2014); E. Palacios-Lidon et al., ACS Catalysis **4**, 1838 (2014); B. Hoff et al. Nanoscale **8**, 411-419 (2016)...
- **E. Meyer group**, Uni. Basel, Switzerland: T. Glatzel et al., Appl. Surf. Sci. **210**, 84 (2003); S. Kawai et al. Nanotechnology **21**, 245704 (2010); R. Pawlak et al. Nano Lett. **13**, 5803-5807 (2013); A. Henning et al., Beilstein Journal of Nanotechnology, **4**, 418-428 (2013); B. Eren et al., Appl. Phys. Lett. **108**, 041602 (2016)...
- **S. Gauthier**, CEMES, France: A. Hinaut et al., Beilstein journal of Nanotechnology 3, 221-229 (2012)...
- **B. Grévin**, CEA France: Y. Luo et al. Adv. Mater. **19**, 2267-2273 (2007); E. Spadafora et al., Nano Lett. **10**, 3337 (2010); E. Spadafora et al. Appl. Phys. Lett. **99**, 233102 (2011); F. Fuchs et al., Phys.Rev.B **88**, 205423 (2013); F. Fuchs et al. ACS Nano **10**, 739–746 (2016)...
- **T. Mélin**, IEMN, France: T. Mélin et al., Phys. Rev. Lett. **92**, 166101 (2004); S. Barbet et al., J. Appl. Phys. **115**, 144313 (2014); H. Diesinger et al., Beilstein Journal of Nanotechnology **5**, 1-18 (2014); E. Palleau et al., Nanotechnology **21**, 225706 (2010); H. Diesinger et al., Ultramicroscopy **110**, 162-169 (2010)...
- **S. Sadewasser**, INL Portugal: S. Sadewasser et al., Phys. Rev. Lett. **103**, 266103 (2009); R. Baier et al., Phys. Rev. B **85**, 165436 (2012); F. Mesa, et al. J. Nanotechnol. **3**, 277-284 (2012)...
- **P. Grütter**, Mc Gill, Canada: R. Stomp et al., Phys. Rev. Lett. **94**, 056802 (2005); S.A. Burke et al., Nanotechnology **20**, 264012 (2009); Y. Miyahara et al. Phys. Rev. Appl. **4**, 054011 (2015)...
- **P. Jelineck group**, Praha, Czech Rep.: F. Albrecht et al. Phys. Rev. Lett. **115**, 076101 (2015); M. Ondráček et al. Nanotechnology **27**, 274005 (2016); P. Hapala et al., Nat. Commun. **7**, 11560 (2016)...
- **Sorry for the others...**

# KPFM on metallic surfaces including adsorbates:

## □ Thin insulating inorganic films :

KCl on Au(111)<sup>1</sup> (FM-KPFM):



- KCl islands decrease the CPD: interface dipole decreased (c.t. to the sample)
- Quantitative measurement of the CPD in the LR regime when the adsorbates are larger than the tip radius

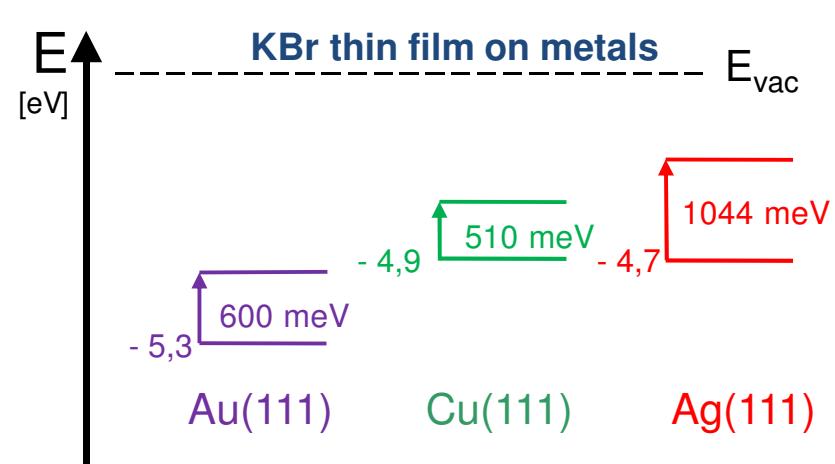
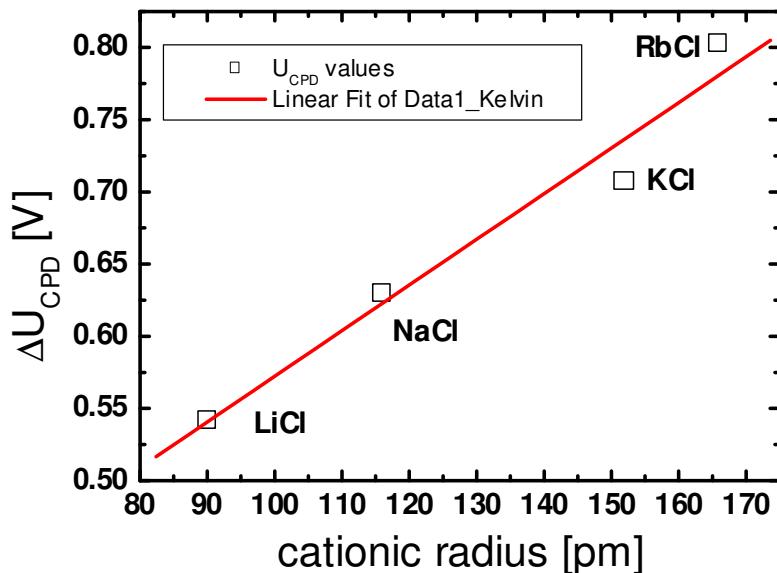
<sup>1</sup>U. Zerweck *et al.*, Phys. Rev. B **71**, 125424 (2005);



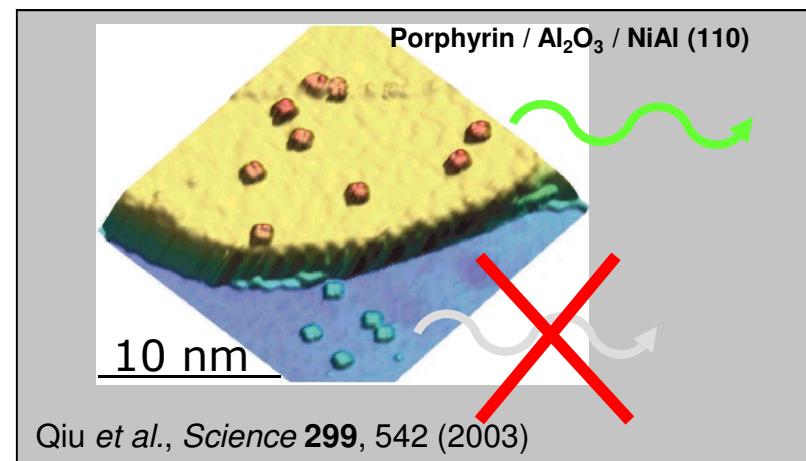
# KPFM on metallic surfaces including adsorbates:

## □ Thin insulating inorganic films :

Ionic thin films on Au(111)<sup>1</sup> (FM-KPFM):



- Interface dipole varies with the nature of the metal
- Adsorption properties must change



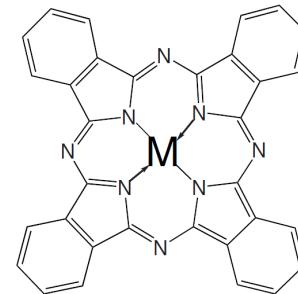
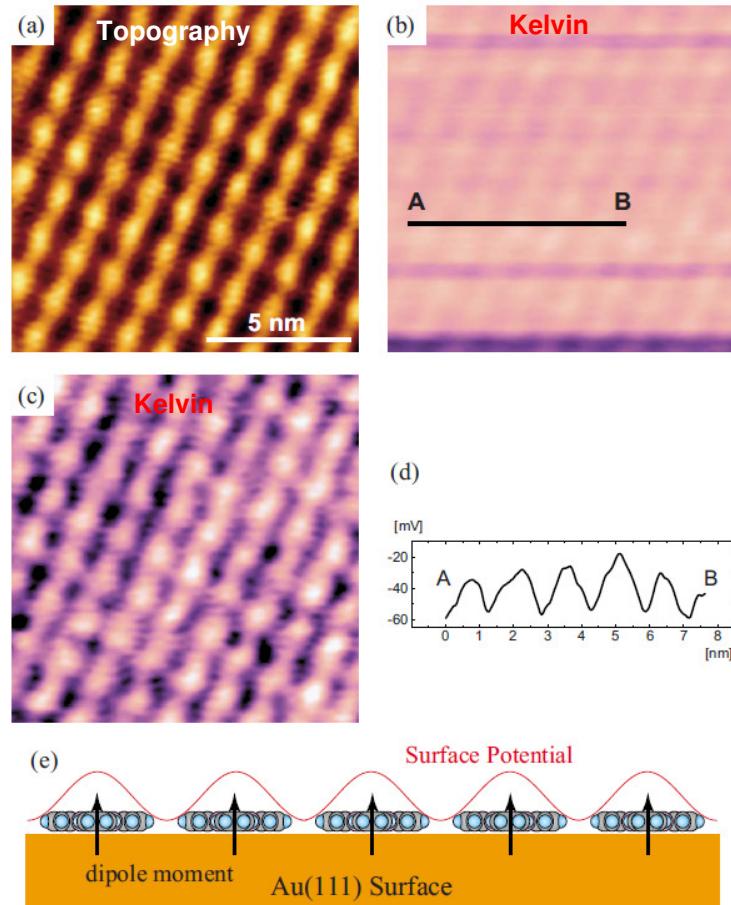
<sup>1</sup>Ch. Loppacher *et al.*, Nanotechnology 15, S9 (2004)



# KPFM on metallic surfaces including adsorbates:

## □ Molecular organic films :

CuPc on Au(111)<sup>1</sup> (FM-KPFM):



M=Cu, Co

- Molecular resolution in KPFM
- +30mV positive shift, increase of the interface dipole, c.t. to the layer
- Results interpreted in terms of electrostatic MS interaction

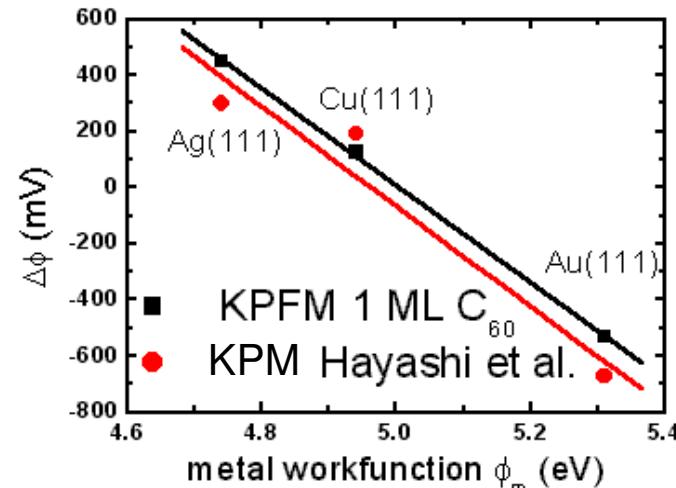
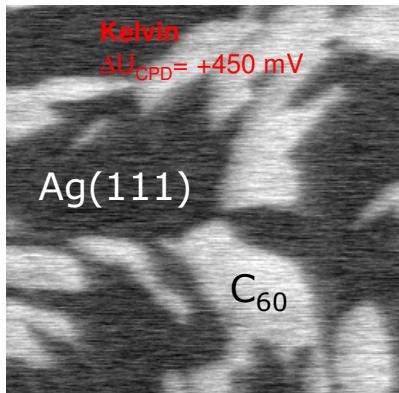
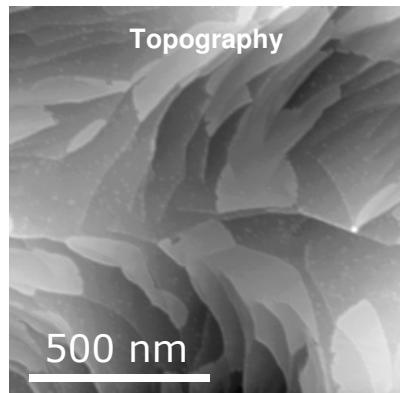
<sup>1</sup>T. Ichii *et al.*, JAP 107 024315 (2010);



# KPFM on metallic surfaces including adsorbates:

## ❑ Molecular organic films :

**C<sub>60</sub> on Ag(111)<sup>1</sup> (FM-KPFM):**



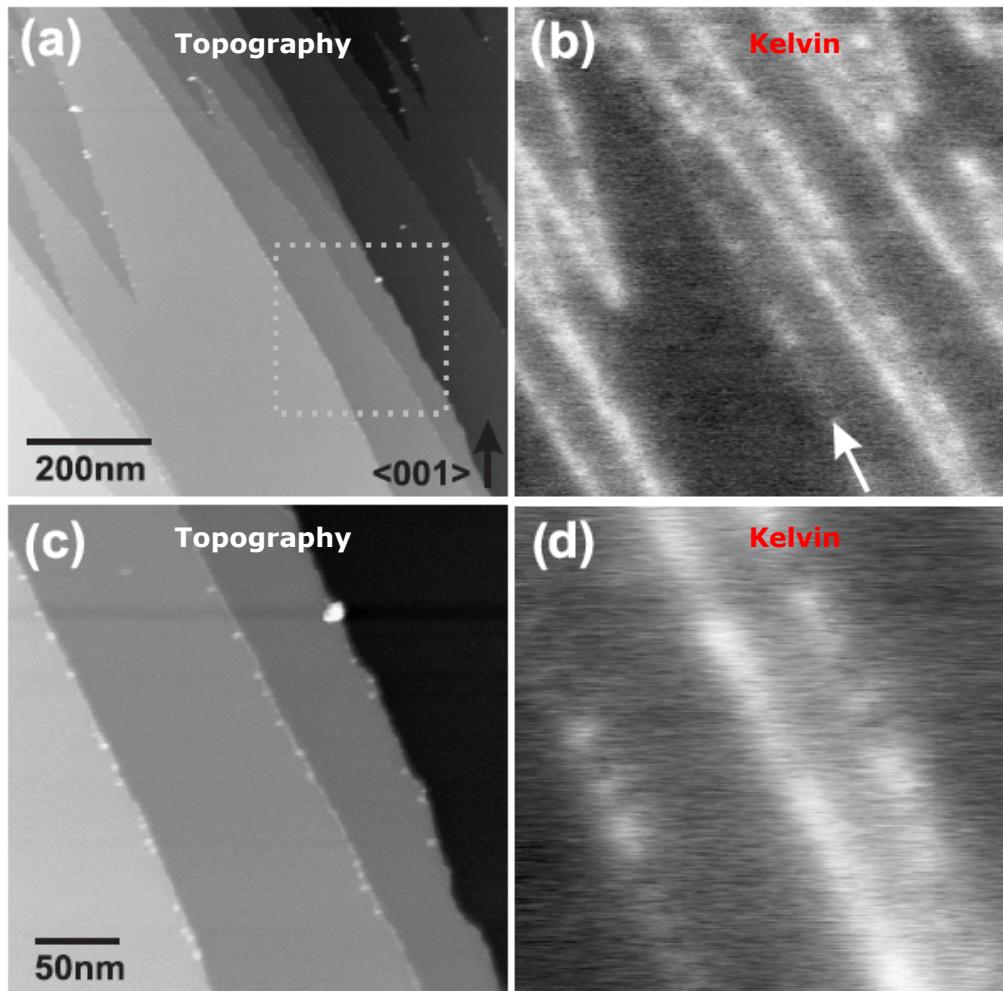
- ❑ C<sub>60</sub> layers increase the CPD: interface dipole increase, c.t. to the molecules
- ❑ Behavior depends on the nature of the metal
- ❑ Results are compliant with macroscopic KPM

<sup>1</sup>U. Zerweck *et al.*, Nanotechnology **18** 084006 (07); Hayashi *et al.*, JAP **92**, 3784 (02)



# KPFM on bulk insulators

- Mixed ionic crystals<sup>1</sup>: NaCl(001)+1% KCl (FM-KPFM)



- Significant positive CPD shift at the step edges (+300 mV)
- Local (-) charges are heterogeneously trapped along the step edges : not intrinsic
- Similar behavior on other alkali halides (KCl)

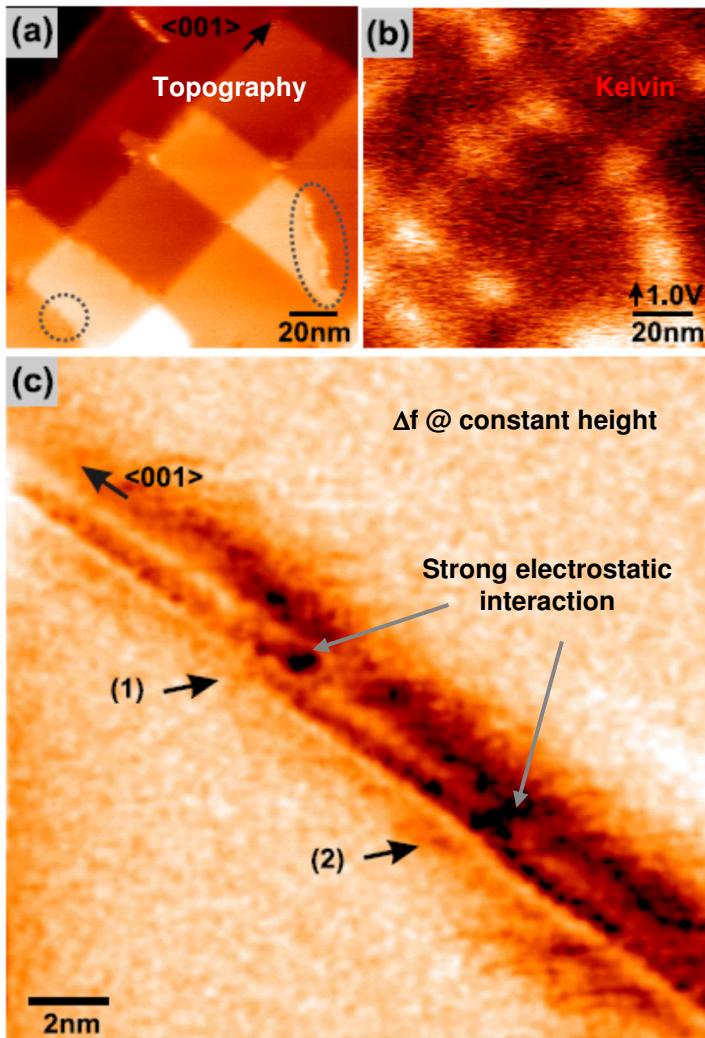
Origin of these charges?

<sup>1</sup>C. Barth *et al.*, *Nanotechnology* **17**, S155 (2006)



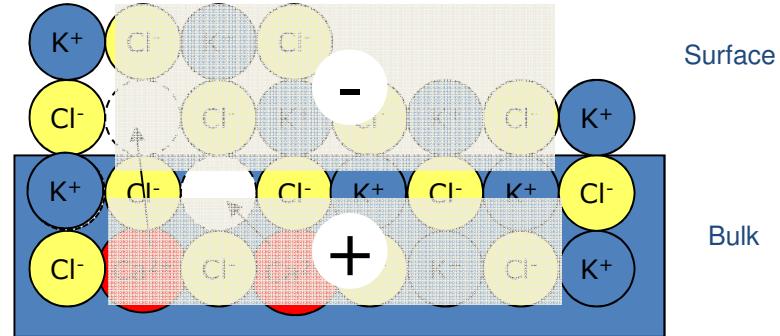
# KPFM on bulk insulators

## □ KCl(001)<sup>1</sup>: (FM-KPFM)



### “Double layer surface“ effect<sup>2</sup>

- Ionic crystals are extrinsic : Ca<sup>2+</sup> impurities nearby steps below the surface
- Global charge of the crystal is neutral → V<sup>-</sup> centers (cationic vacancies)
- Net negative charge nearby (below) step edges and kink sites

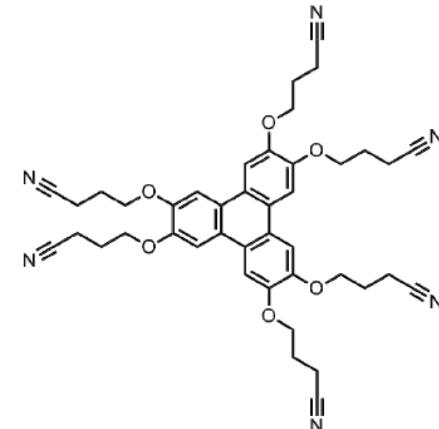
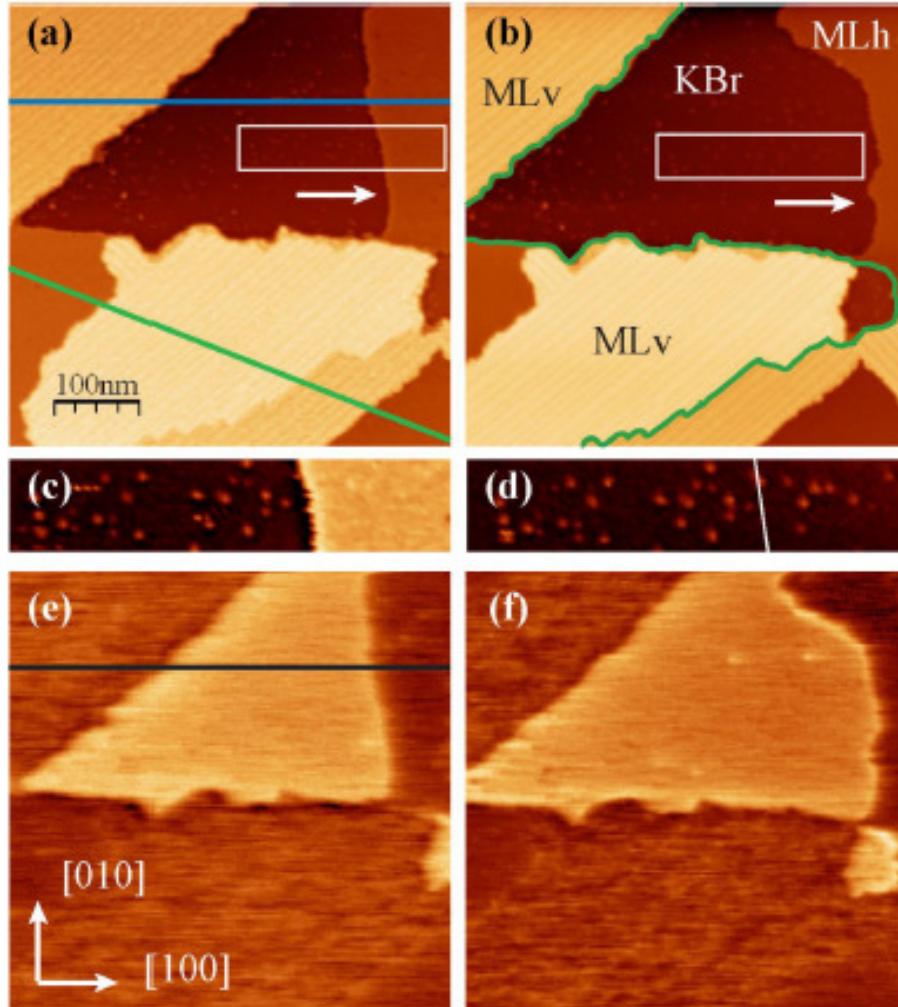


<sup>1</sup>C. Barth *et al.*, *Phys. Rev. Lett.* 98, 136804 (2007); <sup>2</sup>J. Frenkel, *Kinetic Theory of Liquids*, (Clarendon Press, Oxford, 1946).



# KPFM on bulk insulators including molecular films

## □ Triphenylene derivative on KBr(001)<sup>1</sup>: (FM-KPFM)



- Two kinds of adsorption: flat (h) and vertical (v)
- Both domains exhibit lower CPDs than KBr: surface dipole increase
- h-domains consist of molecules interacting electrostatically with the substrate via polar CN groups

<sup>1</sup>A. Hinaut *et al.*, *J. Beilstein Nanotech.* **3**, 221 (2012)

## IV. Examples of applications

- Long-range regime
- Short-range regime



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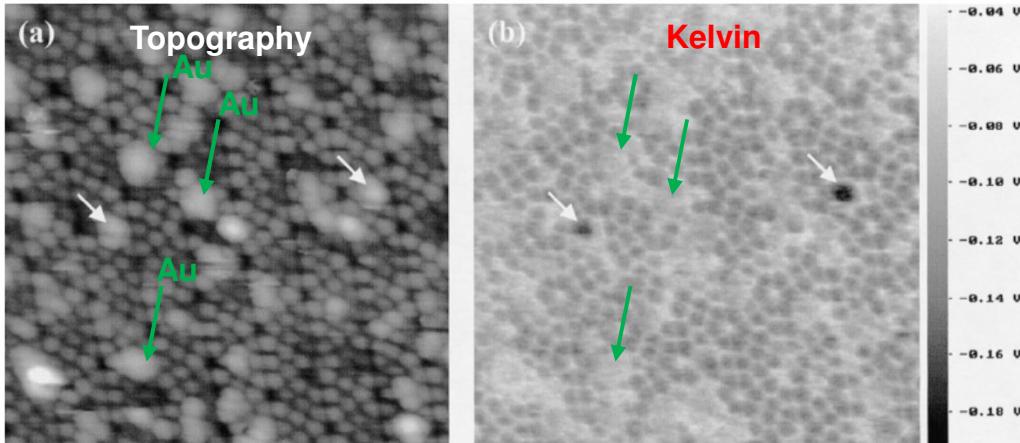
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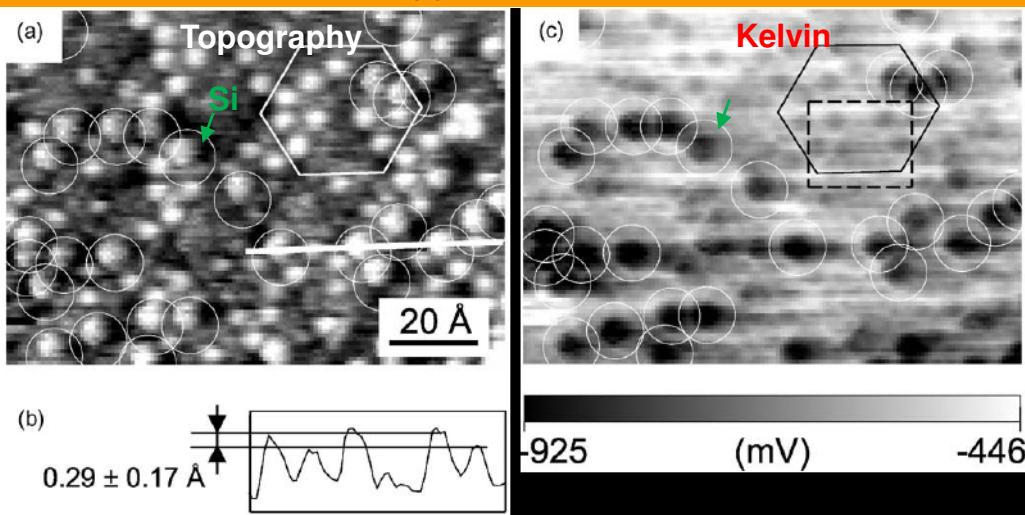
# High-resolution KPFM: semiconductor surfaces

➤ S. Kitamura *et al.*, Appl. Surf. Sci. **157**, 222 (2000) : Au/Si(111) 7x7



"The potential difference of atomic structures...does not seem to reflect the work function as we initially expected. It is therefore considered that the atomic potential difference reflects the local electron density on the surface."

➤ K. Okamoto *et al.*, Appl. Surf. Sci. **210**, 128 (2003) : Si(111)5 $\sqrt{3}$ x5 $\sqrt{3}$ -Sb



First attempt to identify species of individual atoms by KPFM

Potential of adatoms (surface potential) :  $V_{Si} \sim V_{Sb} - 0.2V$  : "This value disagrees with the theoretical work functions of Si and Sb in bulk state...Our result indicates that KPFM on atomic scale does not measure the energy of the HOMO level."



# High-resolution KPFM: intramolecular resolution

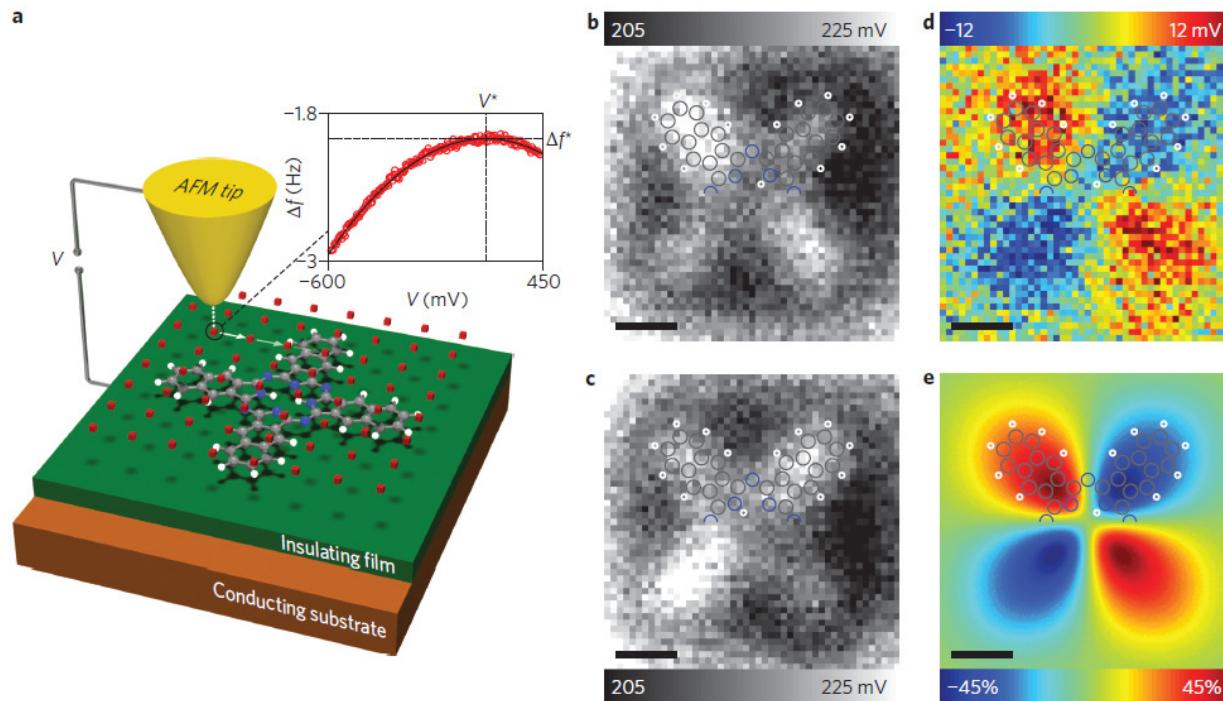
nature  
nanotechnology

LETTERS

PUBLISHED ONLINE: 26 FEBRUARY 2012 | DOI: 10.1038/NNANO.2012.20

## Imaging the charge distribution within a single molecule

Fabian Mohn\*, Leo Gross, Nikolaj Moll and Gerhard Meyer



Im2np

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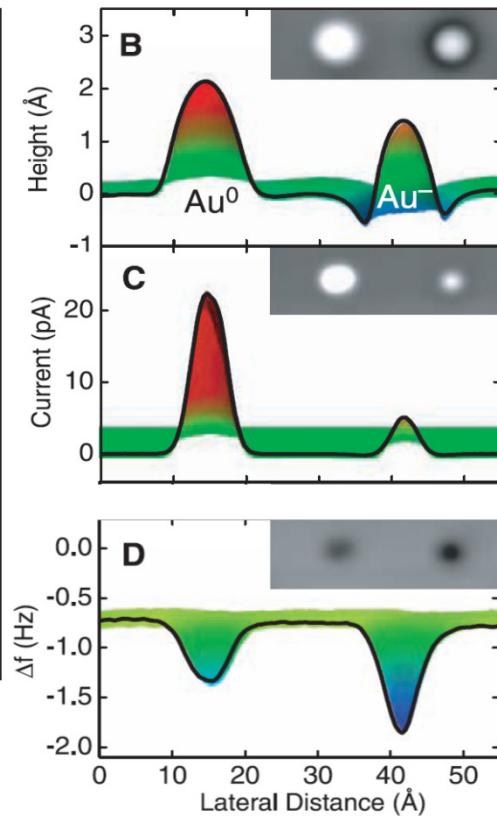
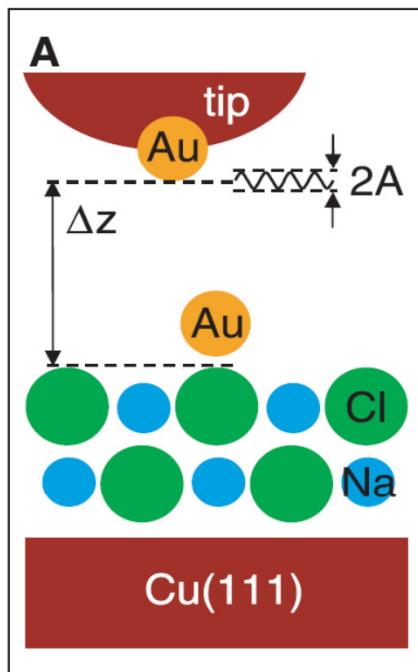
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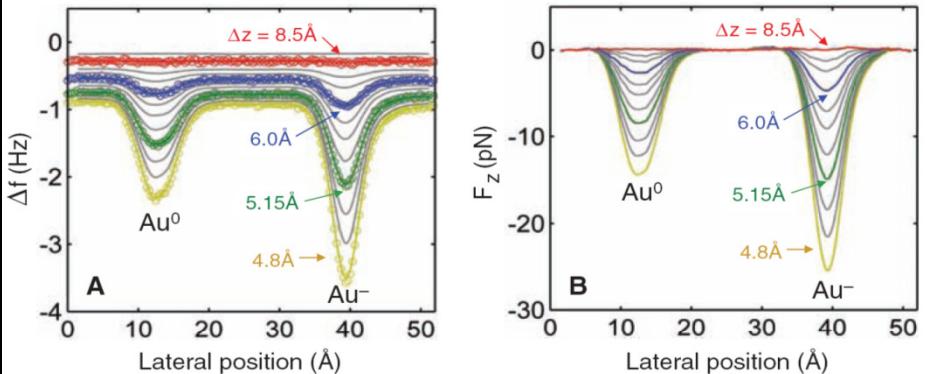
# High-resolution KPFM: charge state of individual atoms

## Measuring the Charge State of an Adatom with Noncontact Atomic Force Microscopy

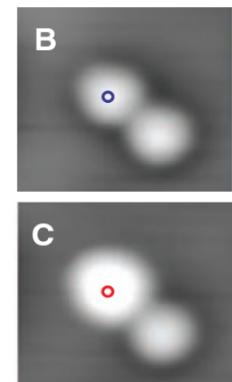
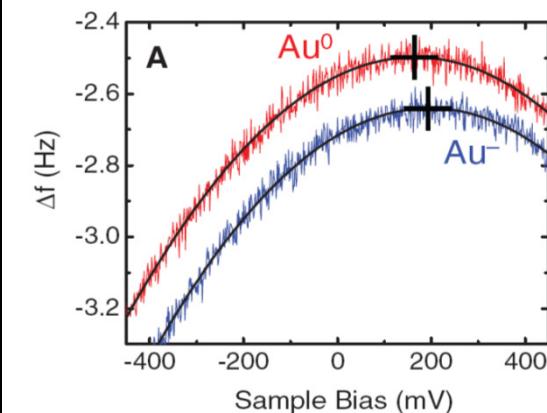
Leo Gross,<sup>1\*</sup> Fabian Mohn,<sup>1</sup> Peter Liljeroth,<sup>1,2</sup> Jascha Repp,<sup>1,3</sup> Franz J. Giessibl,<sup>3</sup> Gerhard Meyer<sup>1</sup>  
12 JUNE 2009 VOL 324 SCIENCE



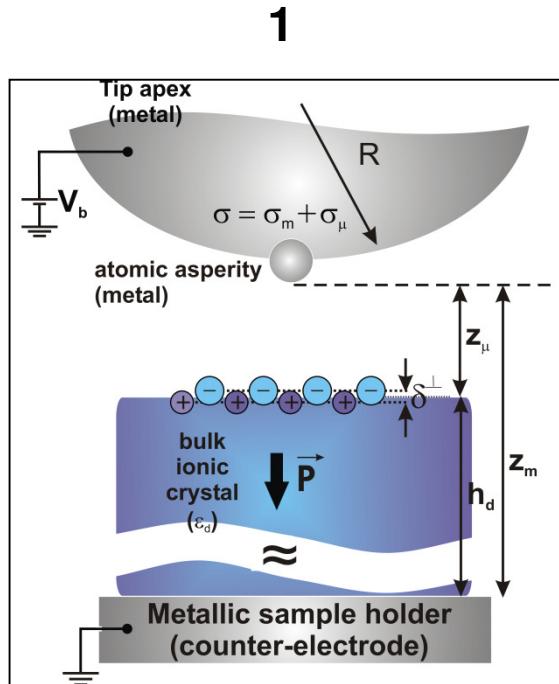
Topographic sensitivity to the charge state on the atomic scale



Spectroscopic sensitivity to the charge state on the atomic scale

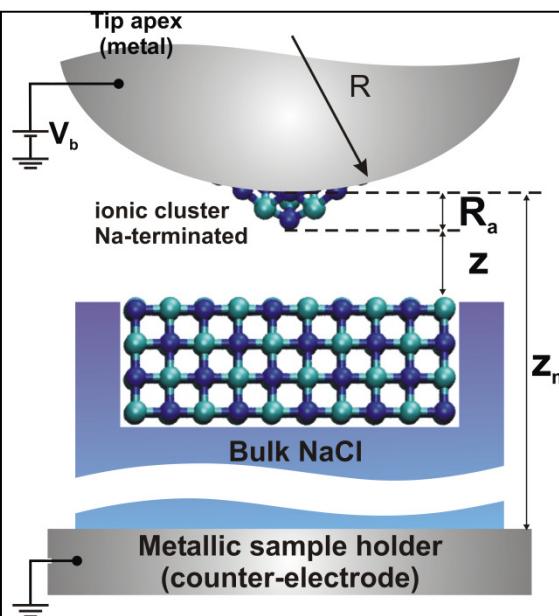


# High-resolution KPFM: modelling



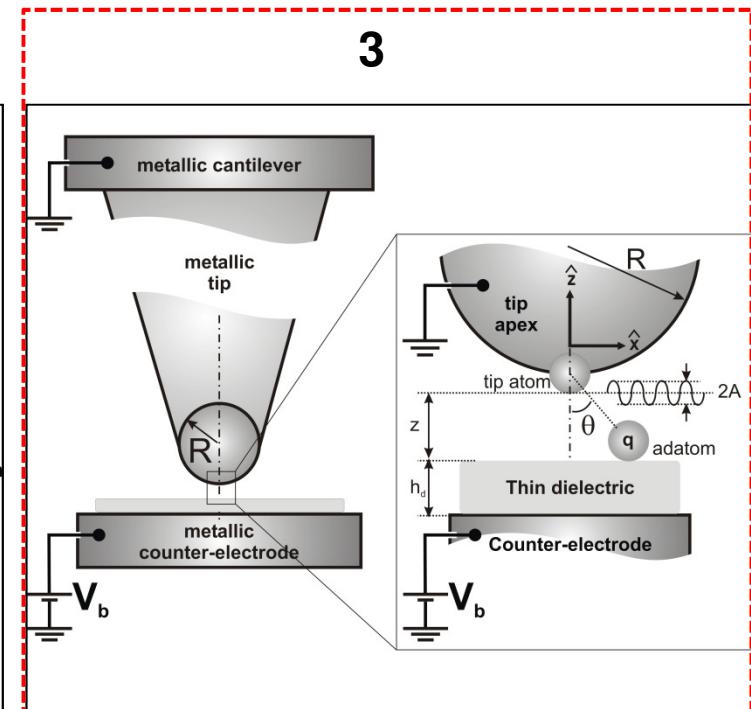
- Tip termination: metallic atomic asperity
- Sample: Bulk ionic crystal
- Analytical & Experimental approach

F.Bocquet et al., Phys. Rev. B **78**, 035410 (2008)  
 L.Nony et al., Nanotechnology **20**, 264014 (2009)



- Tip termination: ionic cluster ( $\text{Na}^+$ -terminated)
- Sample: Bulk ionic crystal
- Fully numerical approach

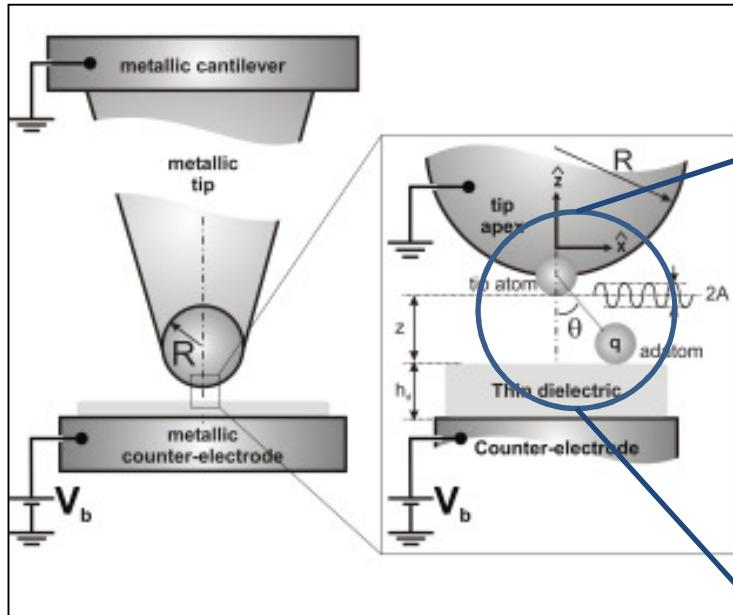
L.Nony et al., Phys. Rev. Lett. **103**, 036802 (2009)



- Tip termination: single metallic atom
- Sample: 2ML NaCl / Cu(111)
- Fully analytical approach

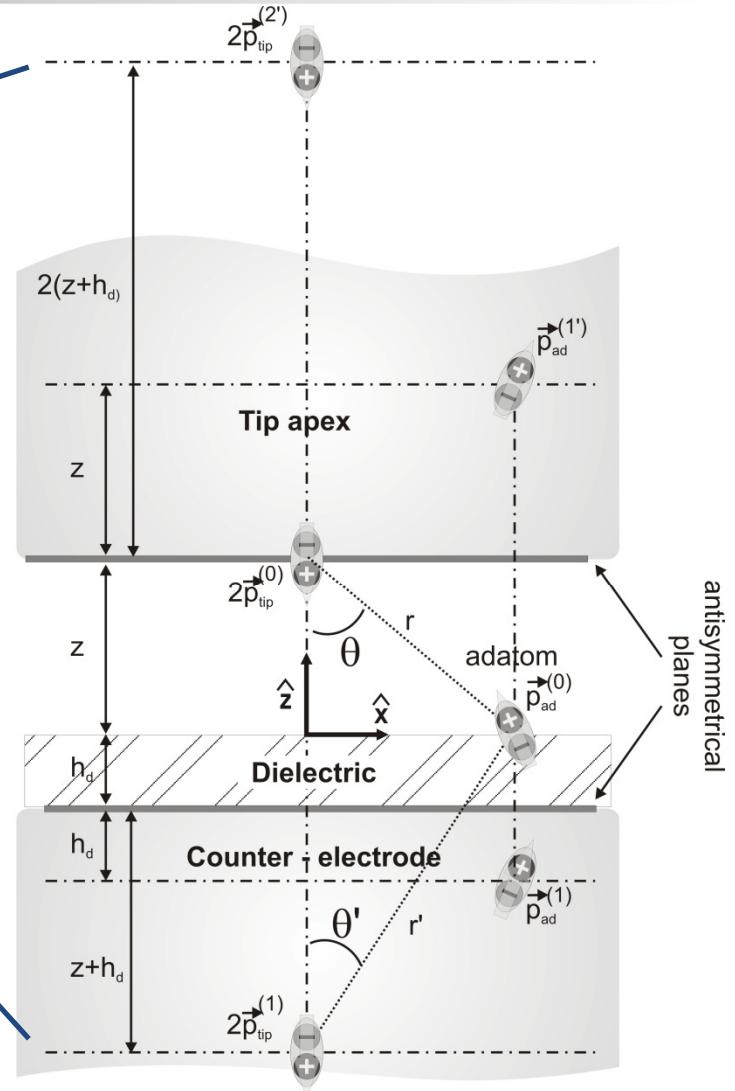
F.Bocquet et al., Phys. Rev. B **83**, 035411 (2011)  
 Based upon the work by L.Gross et al. Science **324**, 1428 (2009)

# Charge state of a single atom



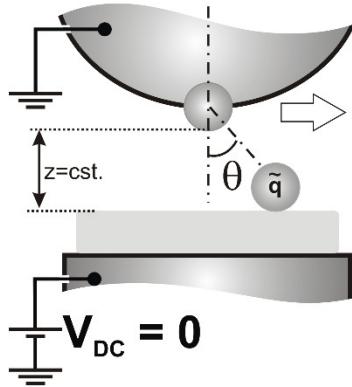
$$F_{SR}^{el} = -\frac{\partial}{\partial z} \left[ -\frac{1}{2} \vec{p}_{tip} \cdot \vec{E}_{tip}^{ext} - \frac{1}{2} \vec{p}_{ad} \cdot \vec{E}_{ad}^{ext} \right]$$

Electrostatic energy of polarization-induced dipoles

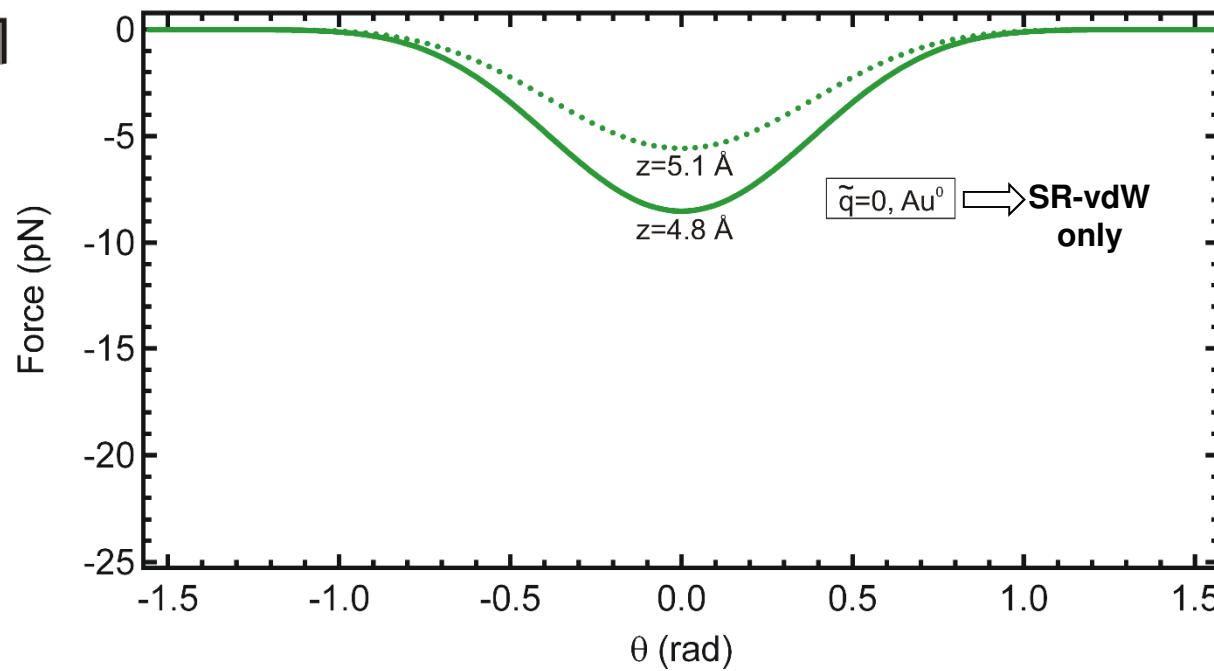




# Charge state of a single atom

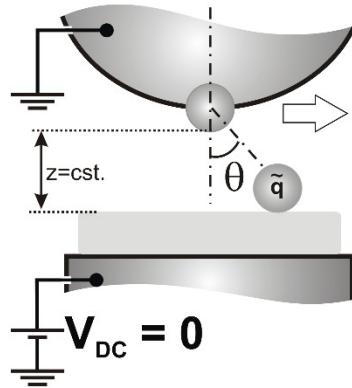


Polarizability for Gold:  $\alpha=6.78\text{\AA}^3$

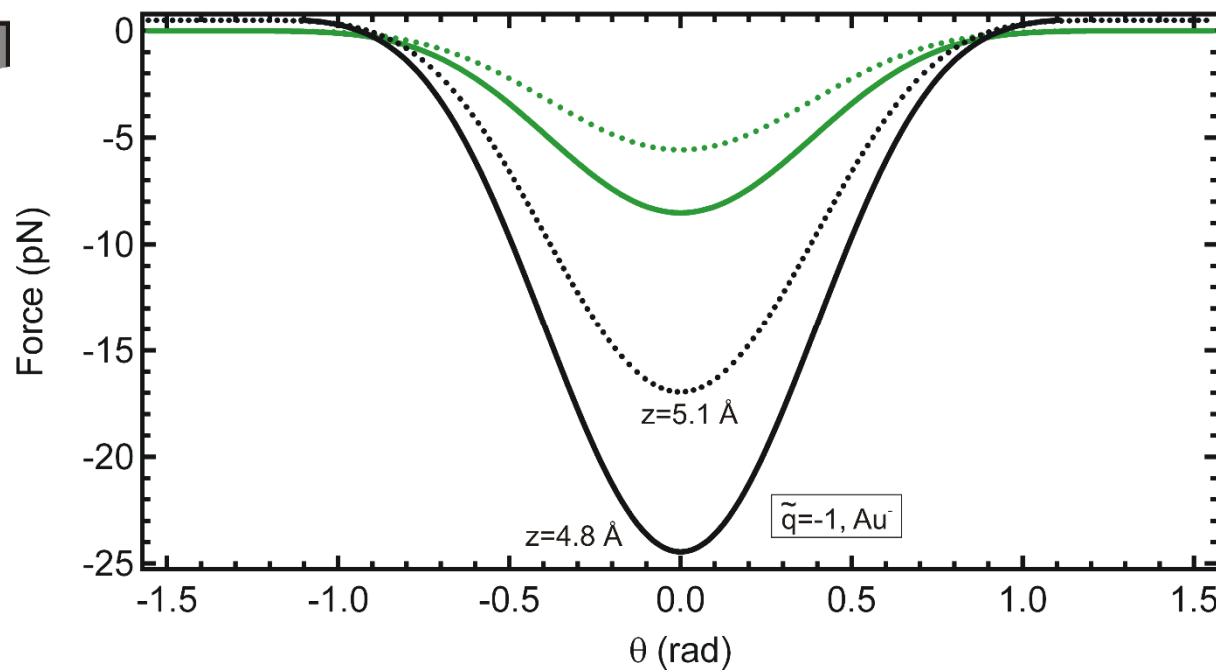




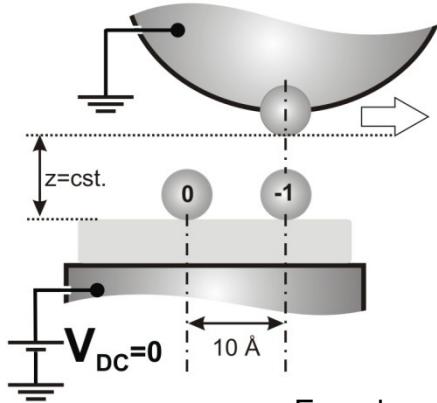
# Charge state of a single atom



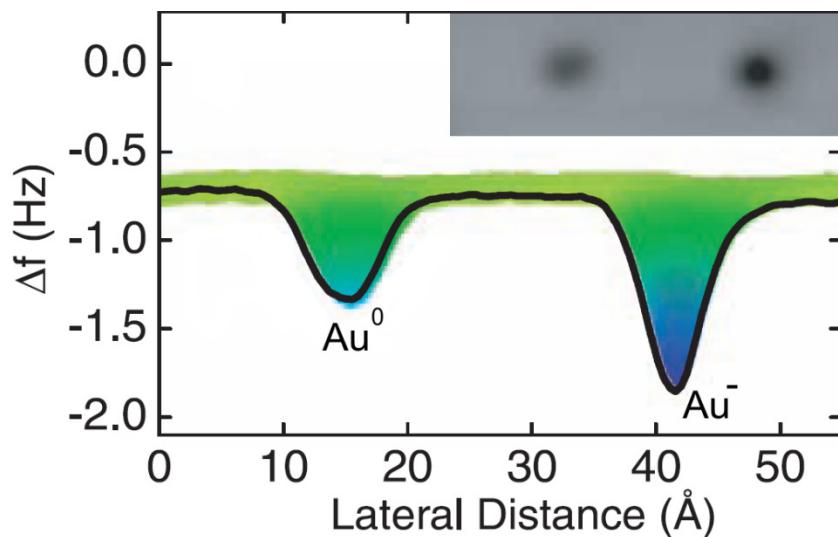
Polarizability for Gold:  $\alpha=6.78\text{\AA}^3$



# Charge state of a single atom

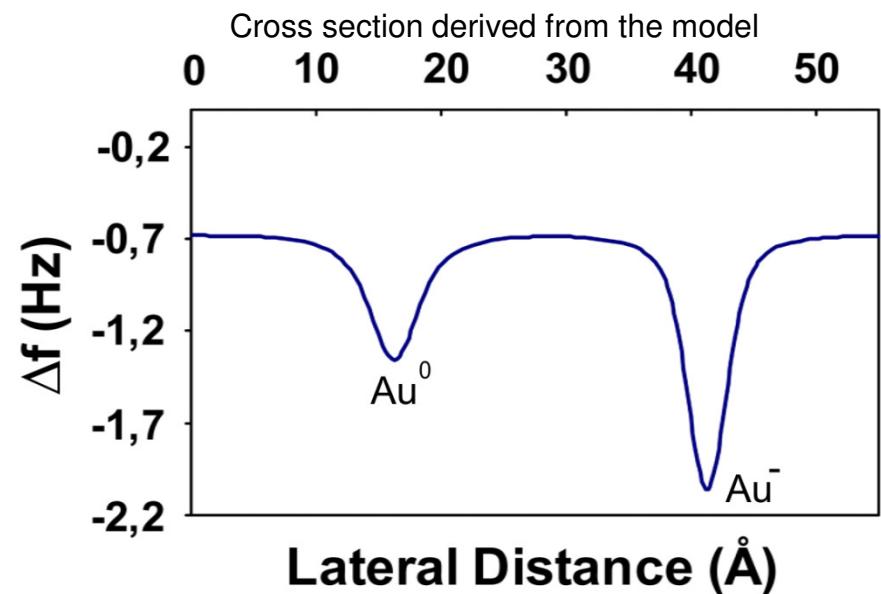


Experimental data by L.Gross et al.

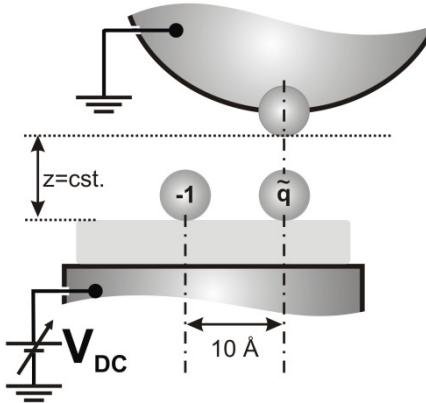


$$\text{Force} \rightarrow \Delta f = -\frac{f_0}{2k} \frac{\partial F}{\partial z}$$

$\Delta f$  derived from the total force (LR+SR components,  $z = 5.1 \text{ \AA}$ ,  $R = 50 \text{ \AA}$ )

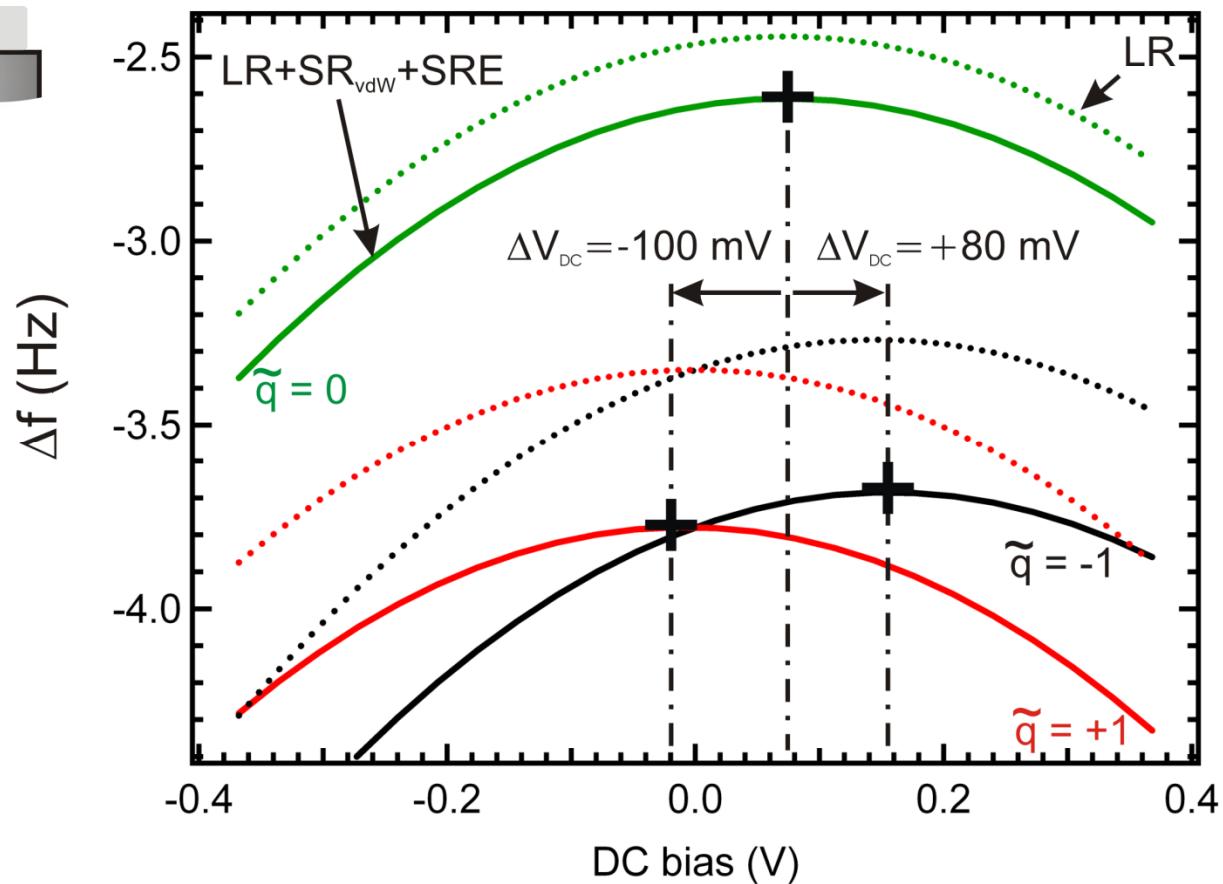


# Charge state of a single atom



$$\text{Force} \rightarrow \Delta f = -\frac{f_0}{2k} \frac{\partial F}{\partial z}$$

$\Delta f$  derived from the total force (LR+SR components,  $z = 5.8 \text{ \AA}$ ,  $R = 50 \text{ \AA}$ )



# Conclusion



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## Take home message

- ❑ Compensating electrostatic forces is required for high-resolution nc-AFM imaging → necessity for using KPFM
- ❑ Technic adds further complexity to the experimental setup but... 
- ❑ The sign of the charges or the dipole orientation of the species trapped within the capacitance which shift the CPD w.r.t.  $CPD_{ref}$  (background) is easy to determine
- ❑ In the long-range regime and with surface adsorbates whose size is larger than the tip apex, KPFM yields a consistent CPD map of the sample (consistent with UPS measurements)
- ❑ BUT getting quantitative numbers out of the experimental data is difficult (requires models) as the CPD is tip and distance dependent
- ❑ KPFM in the short-range regime is sensitive to short-range electrostatic forces which can qualitatively be understood from electronic & ionic polarizability

## Additional key references used for this talk

- *Kelvin Probe Force Microscopy, Measuring & Compensating Electrostatic forces*, Springer Series in Surface Sciences (Th. Glatzel & S. Sadewasser Ed.)
- W. Melitz et al., *Kelvin Probe Force Microscopy and its application*, Surf. Sci. Rep. **66**, 1-27 (2011).



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